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U.S. DEPARTMENT OF
ENERGY

Charged-particle detection

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Exotic Beam Summer School (EBSS) 2013
Friday August 2nd, 2013

- **General comments**
 - Radiation interactions
 - Detector principles of operation
 - Ionization chambers
- **Silicon detectors**
 - Band structure in crystals
 - The p-n junction
 - Impurities and doping
 - Silicon detectors
- **Science with exotic beams**
 - Decay spectroscopy with silicon
 - Transfer-reaction studies

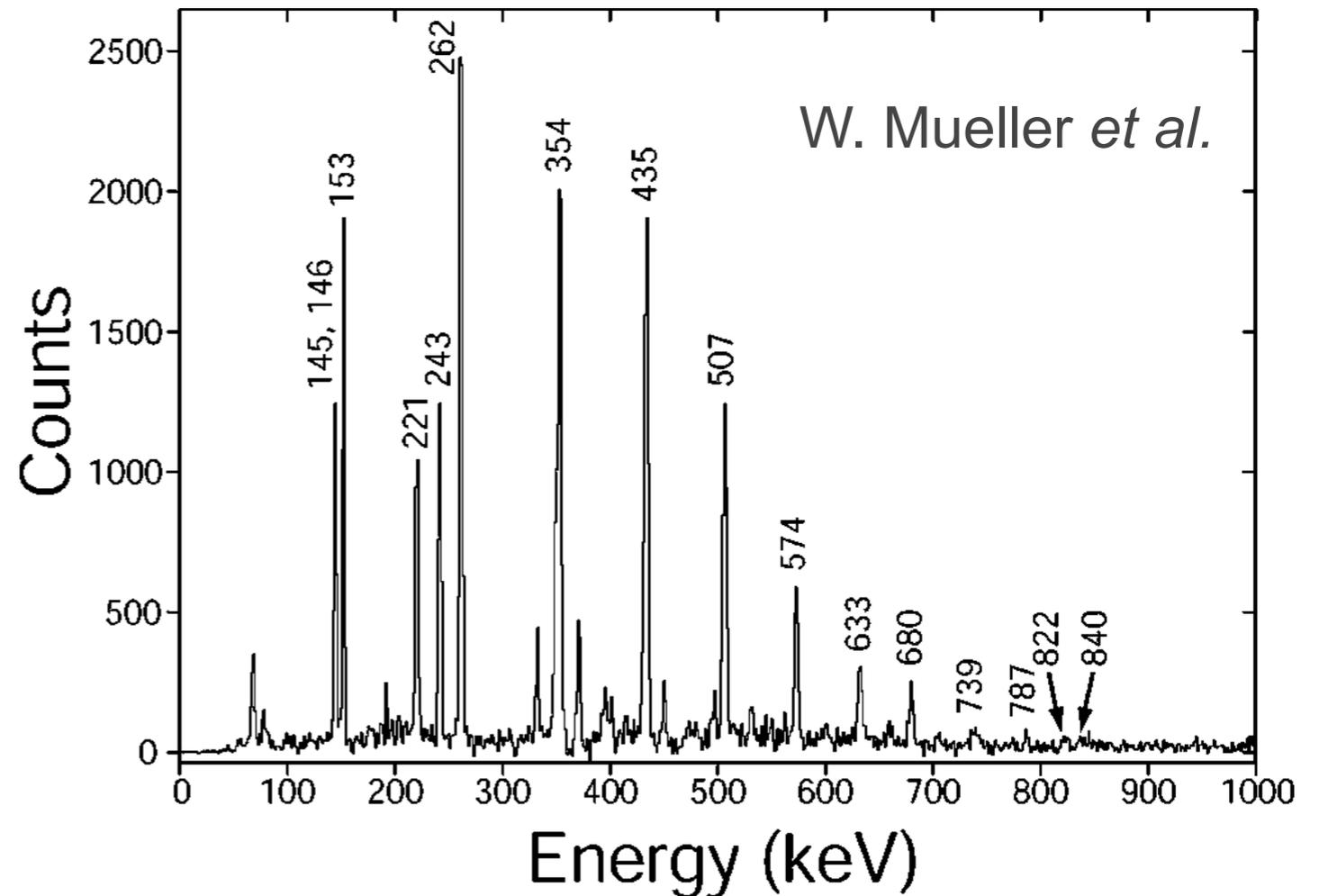
What do we mean by particle detection?

- Counting
- Spectroscopy
 - Gamma-ray spectroscopy
 - Charged-particle spectroscopy
 - Decay spectroscopy
- Particle Identification
 - Nuclei: Z, A
 - Neutron, gamma??



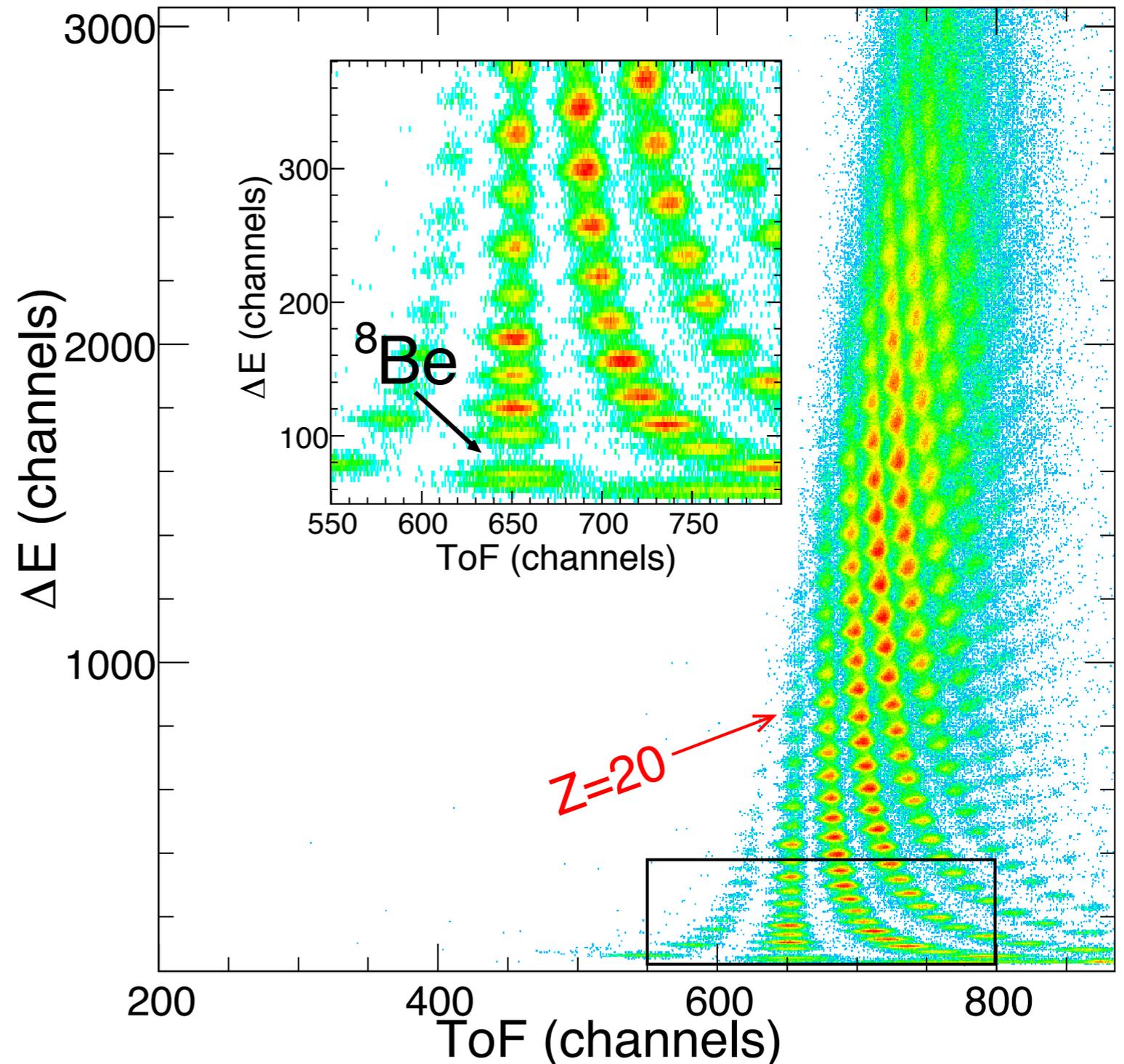
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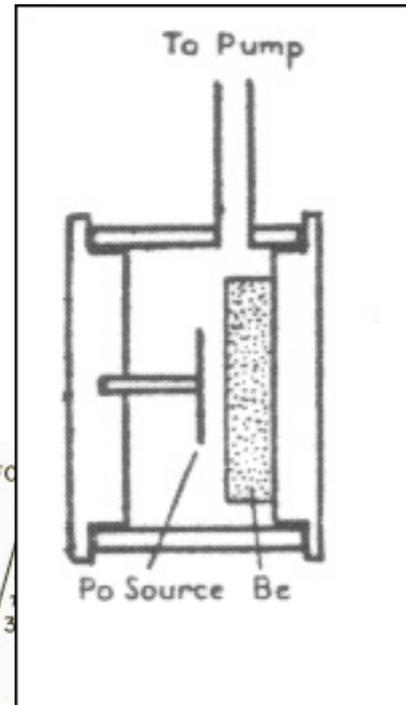
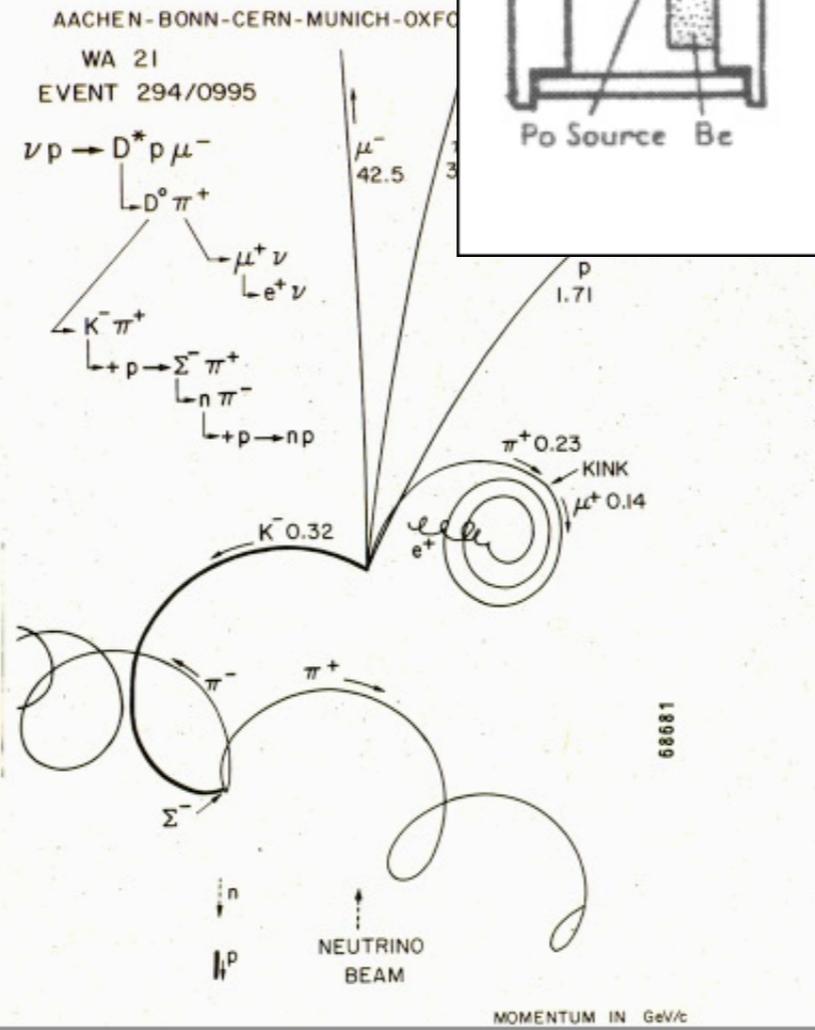
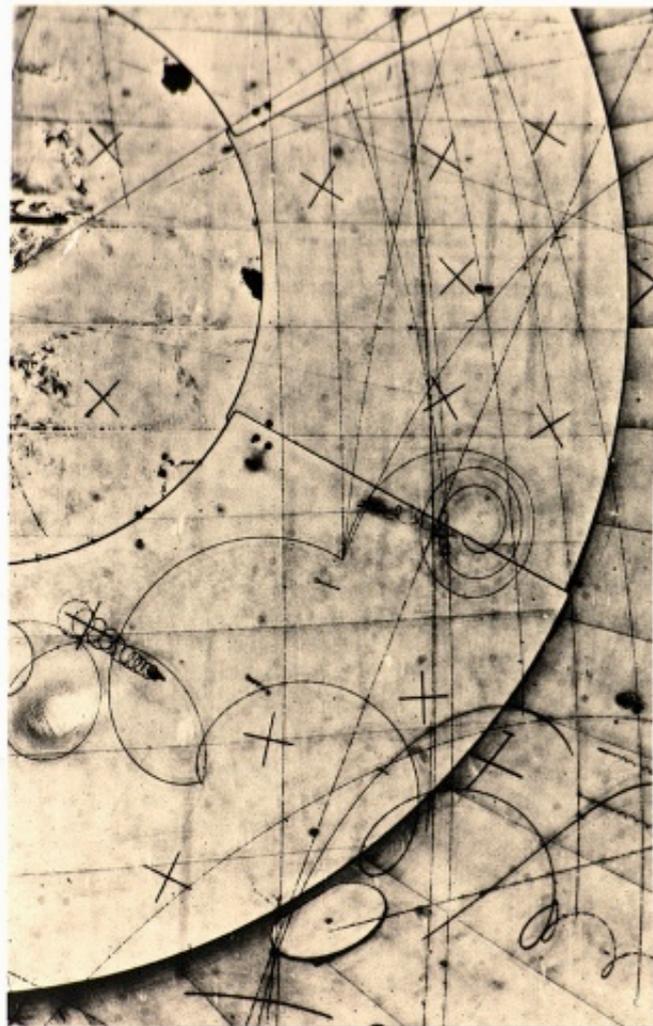
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General role and uses of particle detectors

- Nuclear and particle physics.
- Astronomy
- Medicine
- Industry



Discover of the neutron
by Chadwick (1932)

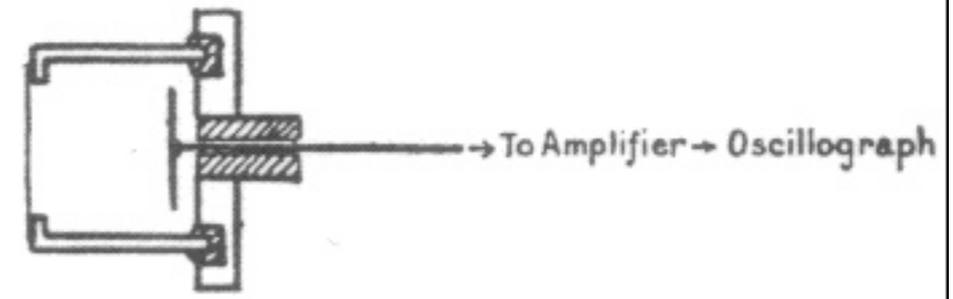
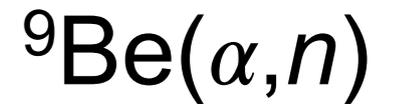
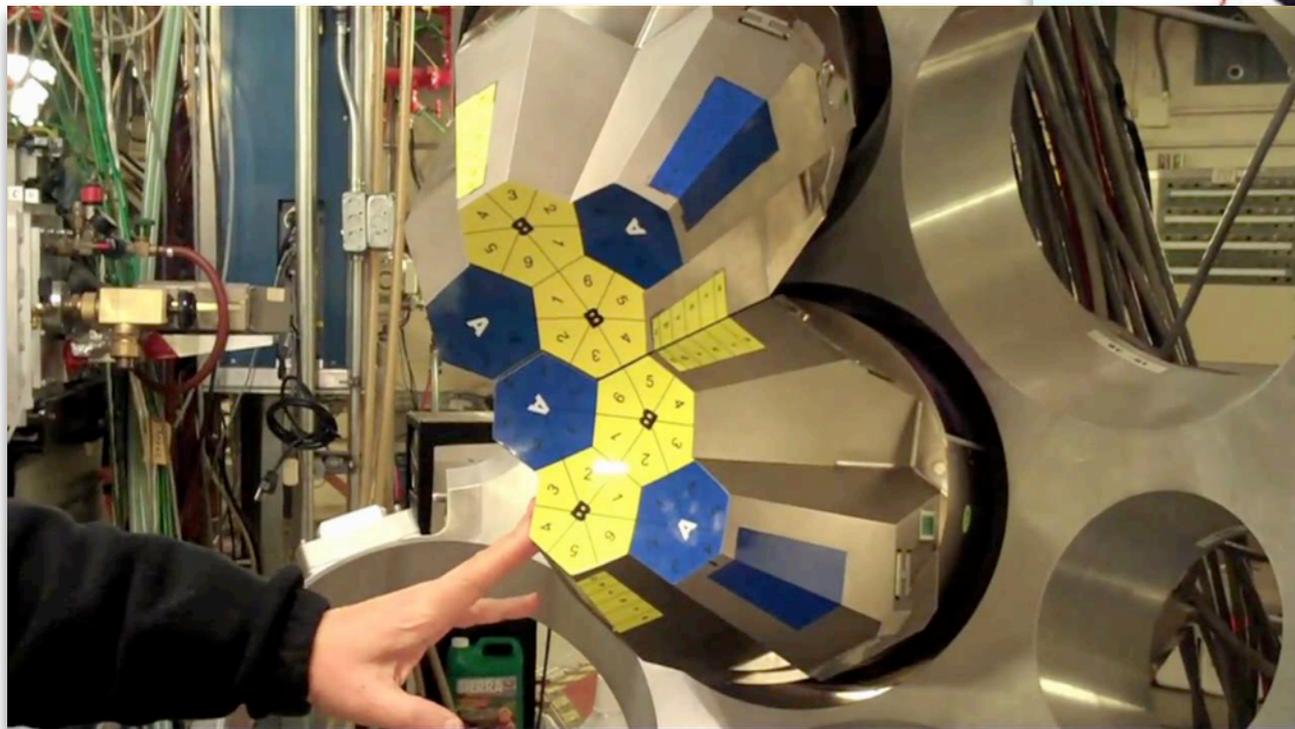
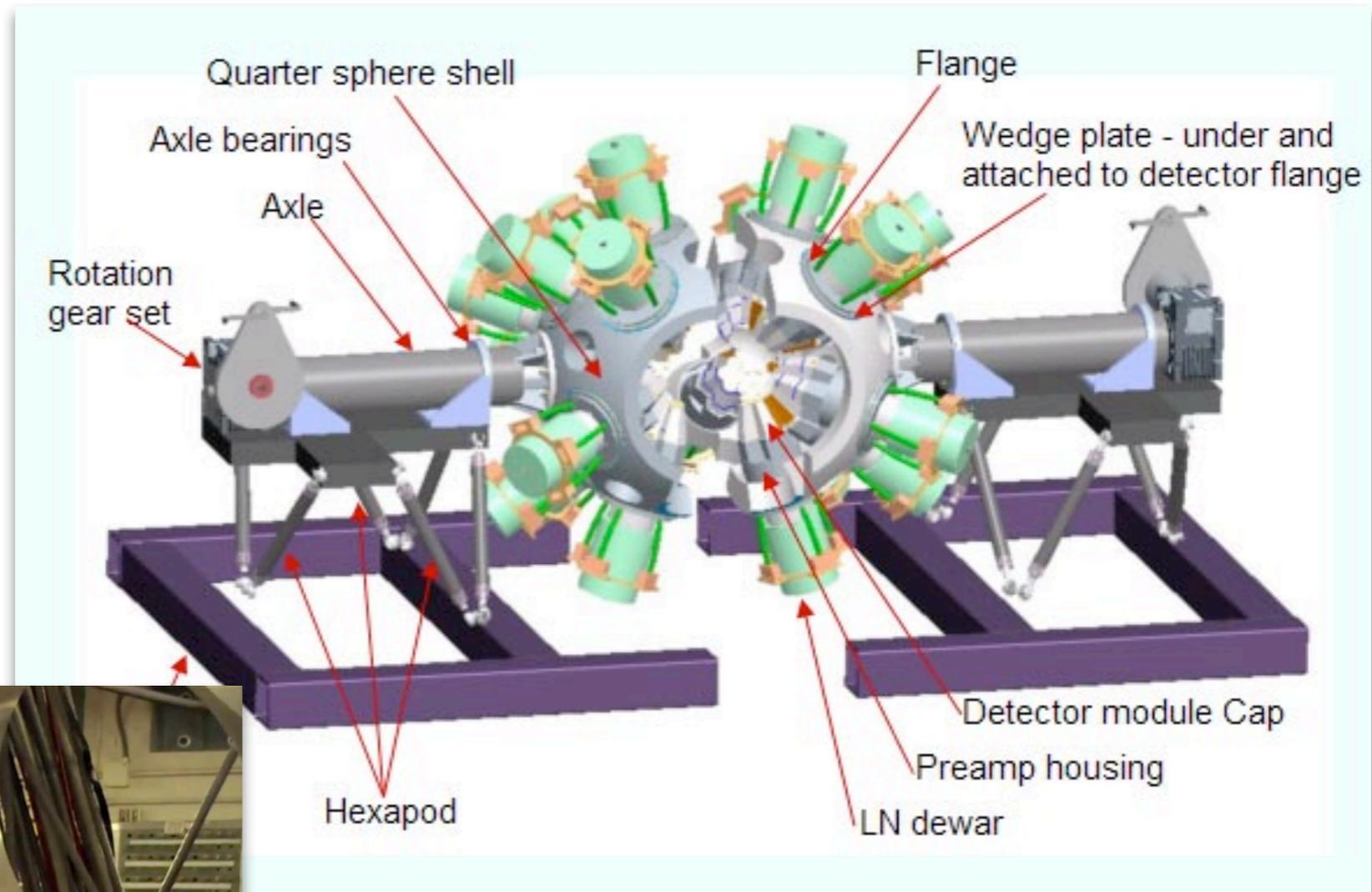


FIG. 1.

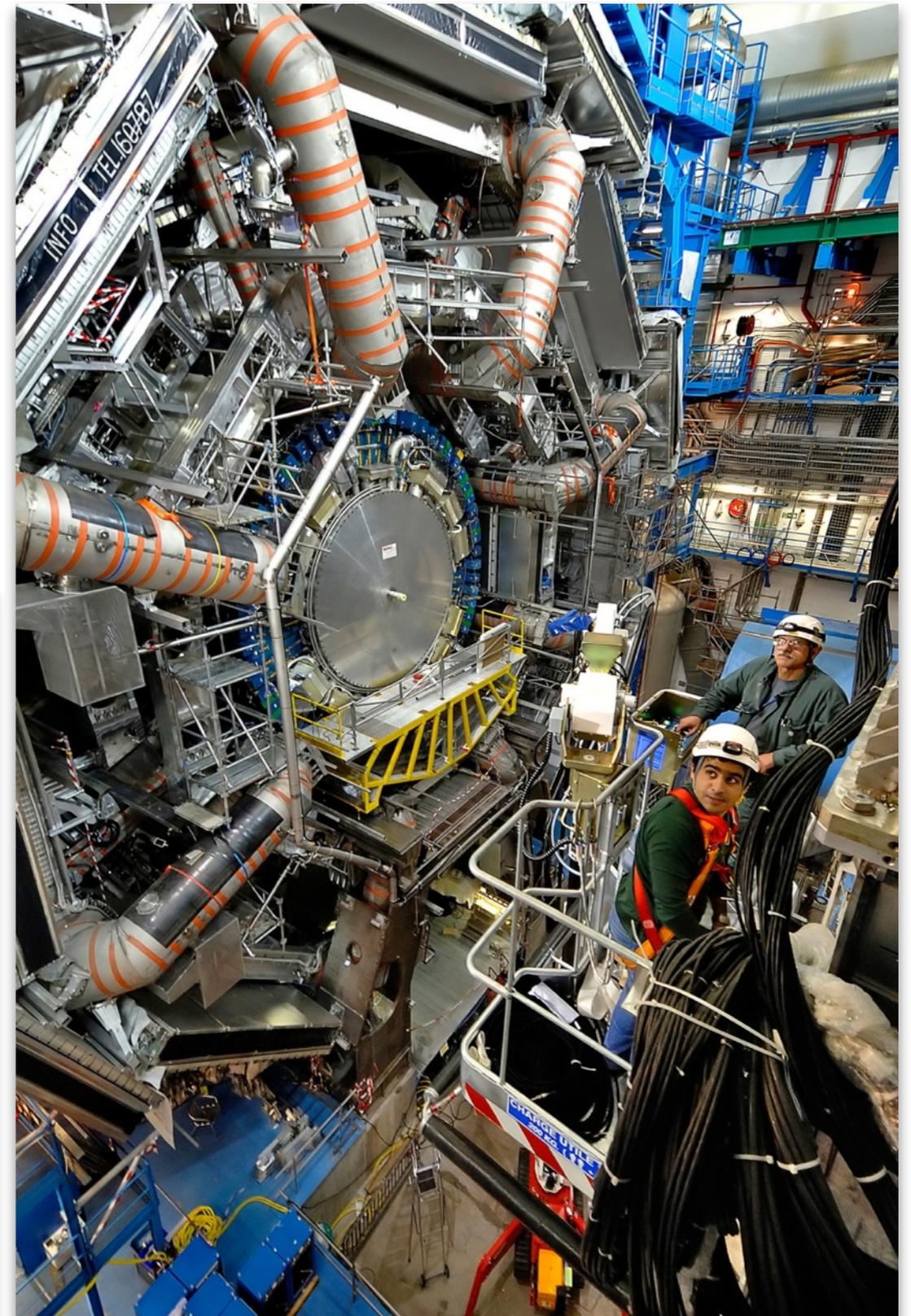
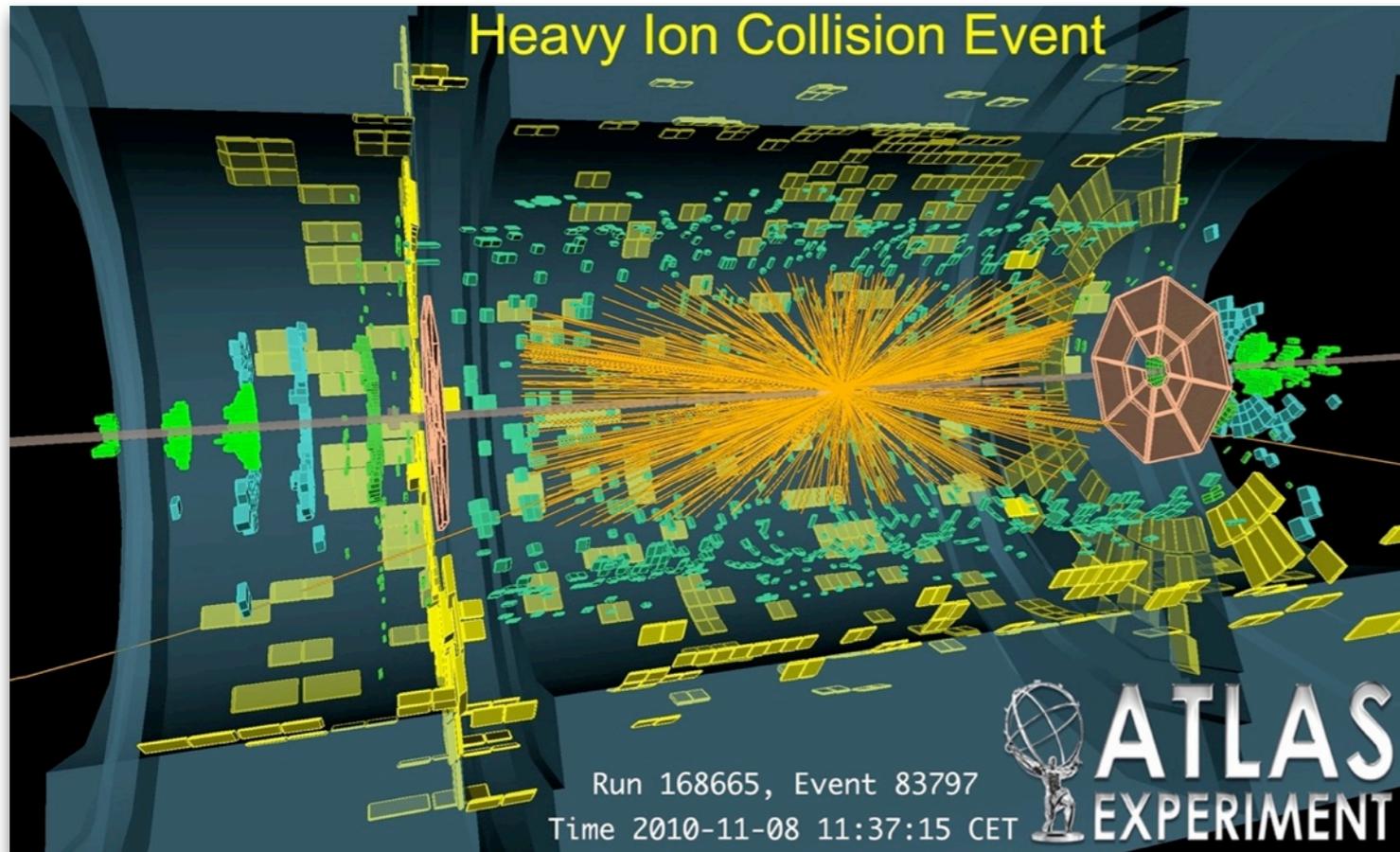
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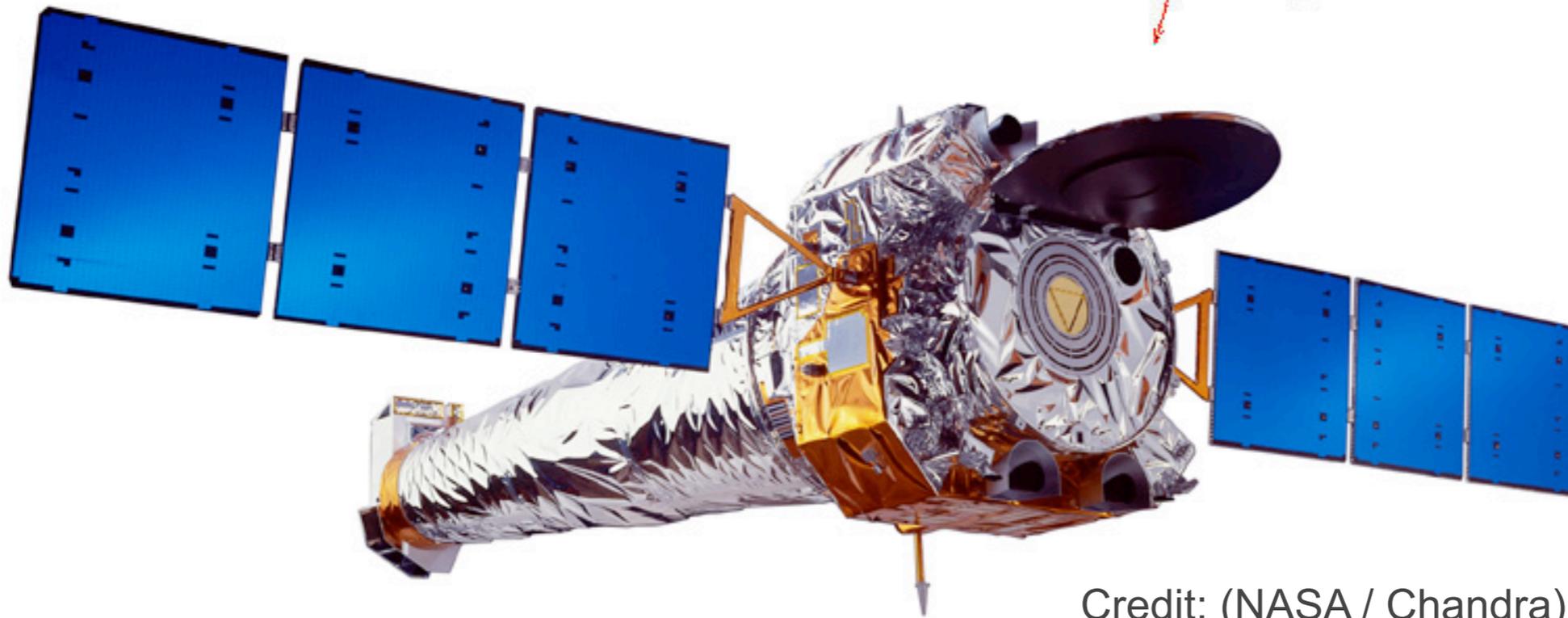
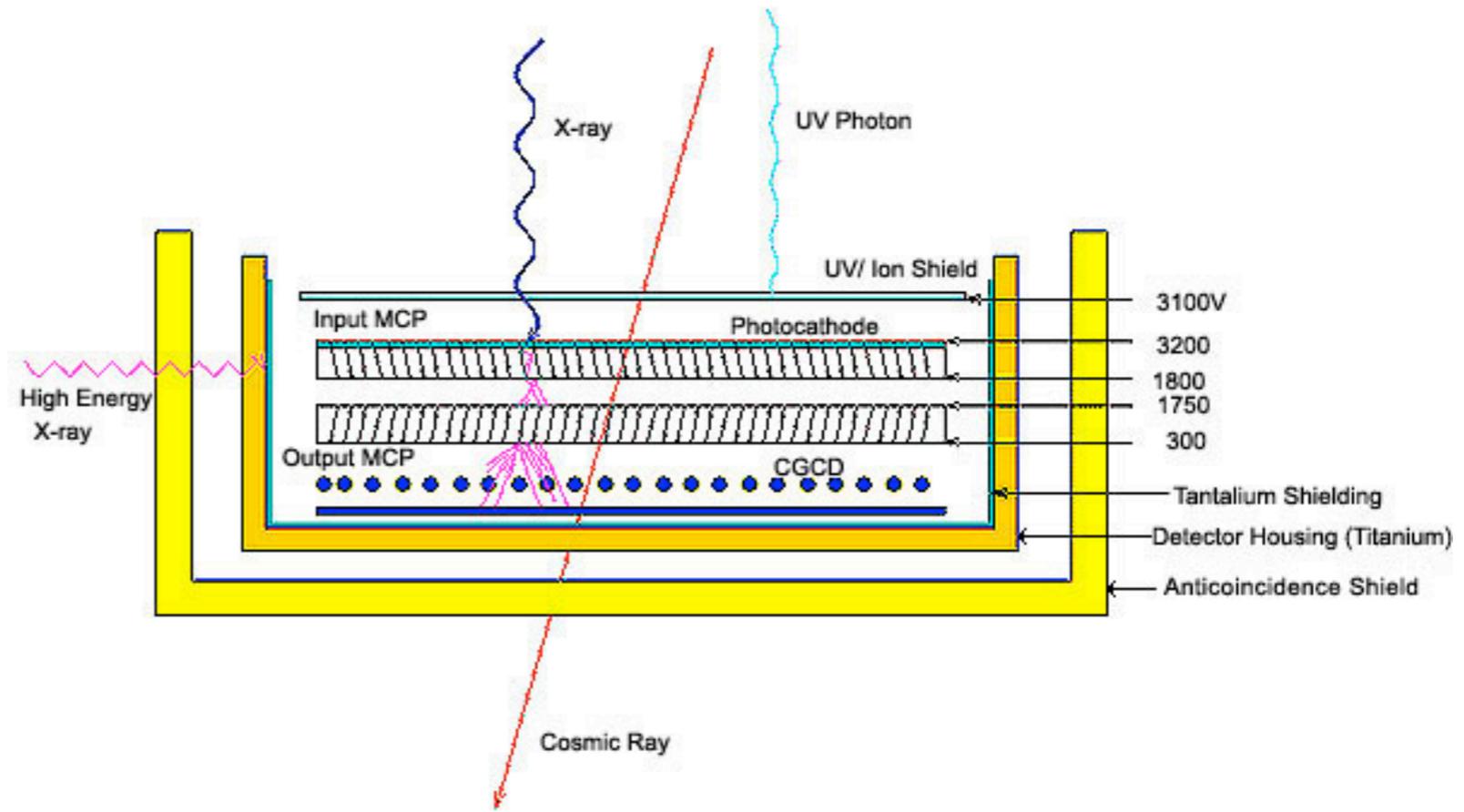
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General role and uses of particle detectors

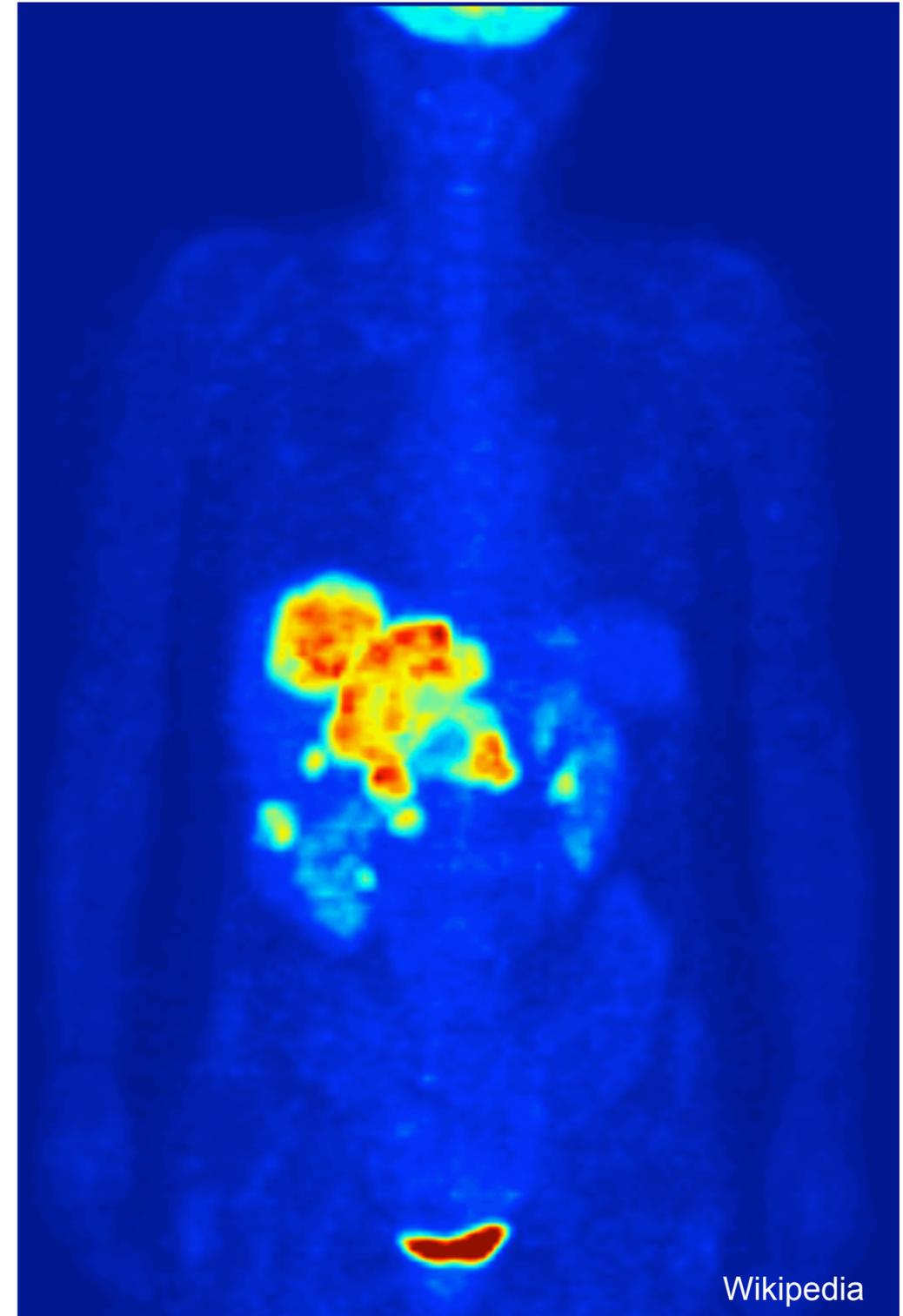
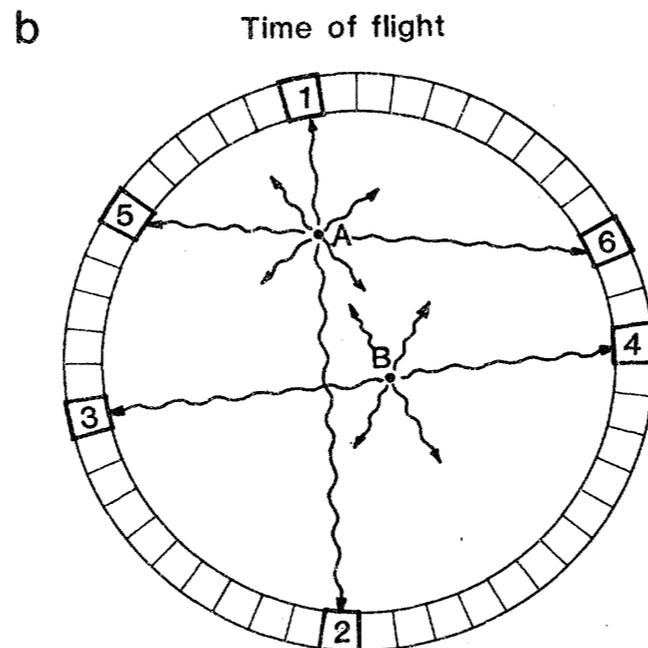
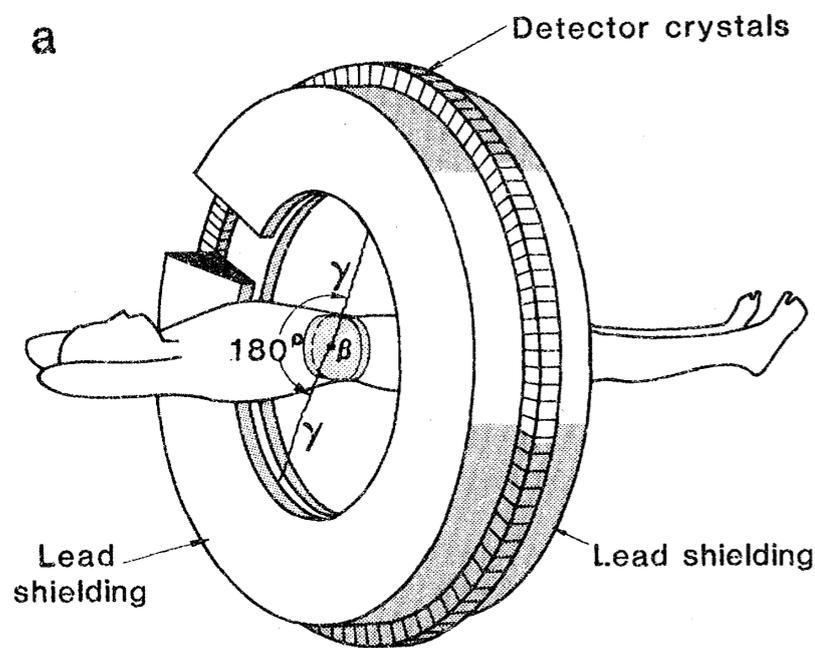
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- Medicine
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Credit: (NASA / Chandra)

General role and uses of particle detectors

- Nuclear and particle physics.
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Interaction of radiation with matter

We detect particles through their direct and indirect interactions within a detector volume.

Charged Particles

Neutral Particles

Heavy charged particles (p, α, ions)	Neutrons
Fast electrons / positrons	X-rays and γ-rays



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Charged particles undergo continuous interaction through the coulomb force.

Many orbital electron interactions,

- Excitation
- Ionization

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Conversion of particle energy primarily through localized interactions

Energy loss of heavy charged particles

$$-\frac{dE}{dx} = \frac{4\pi e^4 z^2}{m_0 v^2} N Z \left[\ln \frac{2m_0 v^2}{I} - \ln \left(1 - \frac{v^2}{c^2} \right) - \frac{v^2}{c^2} \right]$$

- **Bethe formula (1930 Hans Bethe):**

z = incident-particle charge

v = incident-particle velocity

N = absorber number density

Z = absorber atomic number

m_0 = electron mass

e = electron charge

I = Mean excitation potential (Carbon: 73.8 eV, Silicon: 174.5 eV, Lead: 818.8 eV)

▶ Proportional to z^2

▶ Proportional to NZ

Energy loss of heavy charged particles

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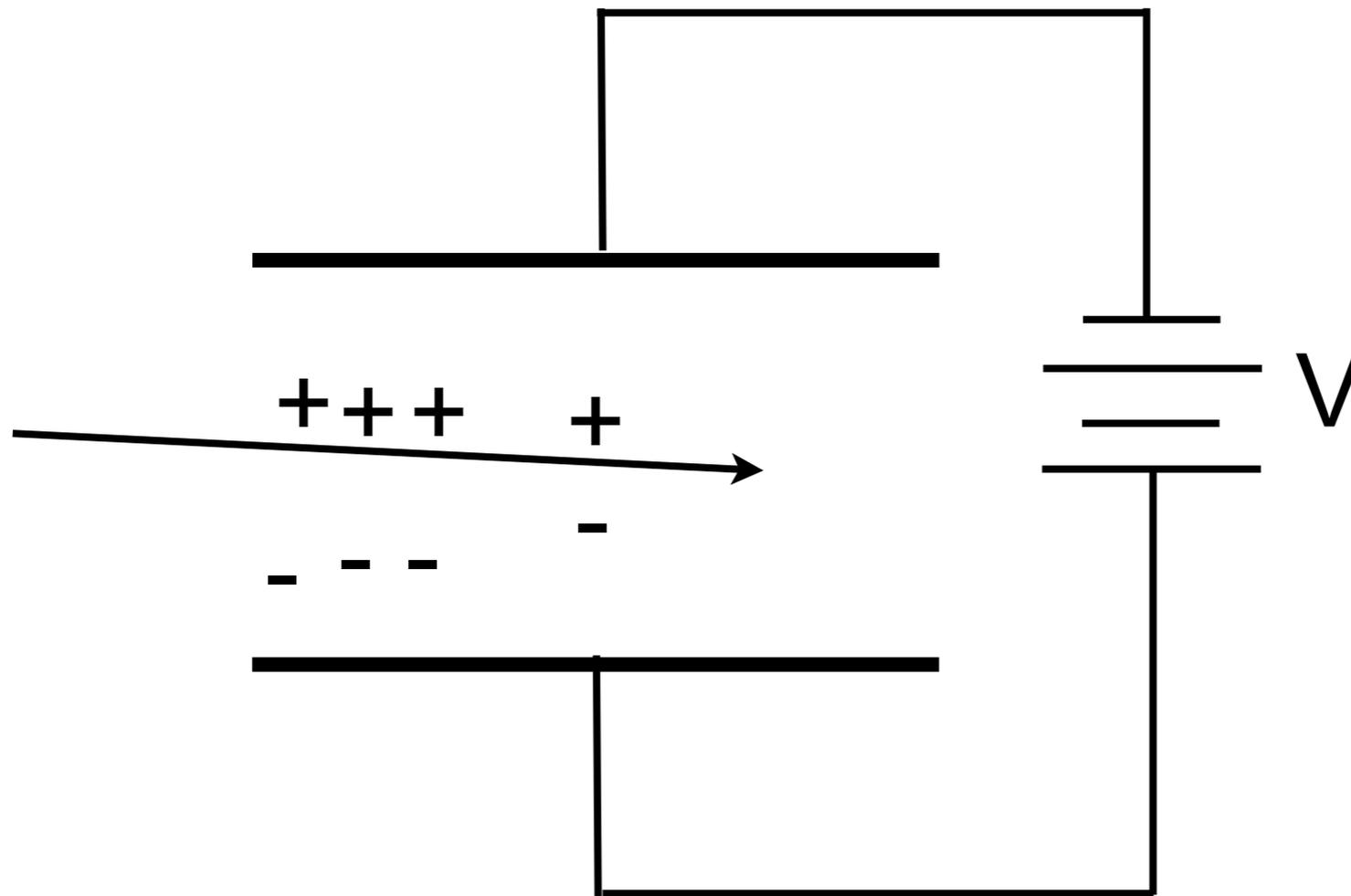
▶ Proportional to z^2

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$$\frac{dE}{dx} \propto \frac{m_z z^2}{E} \ln \left(C \frac{E}{m_z} \right)$$

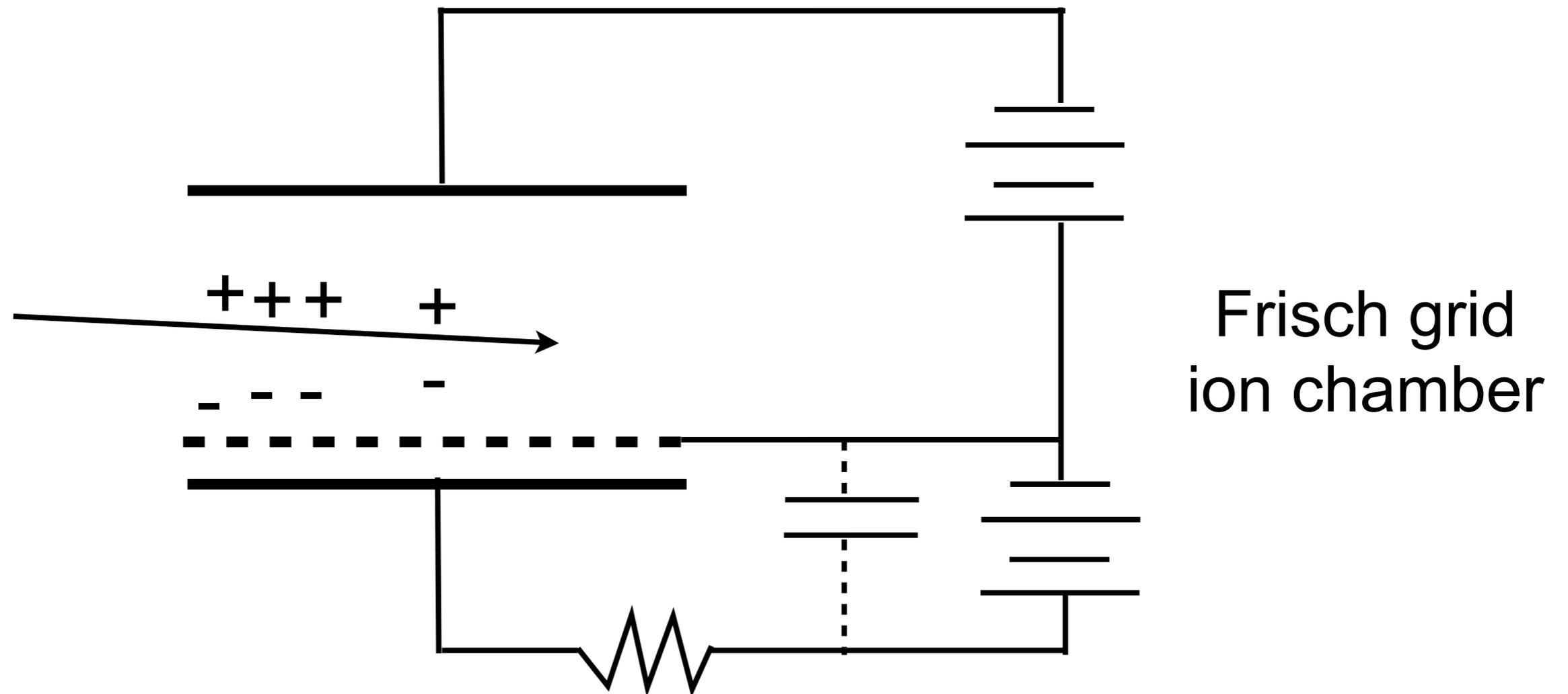
Gaseous ionization chambers

- Ionization and excitation of detector gas.
- Energy to produce an electron-ion pair is $\sim 30\text{eV}$.
- Collection times for electrons and ions differ greatly, of order μs for electrons compared to ms for ions.
- Relatively simple detectors and can have large dimensions.



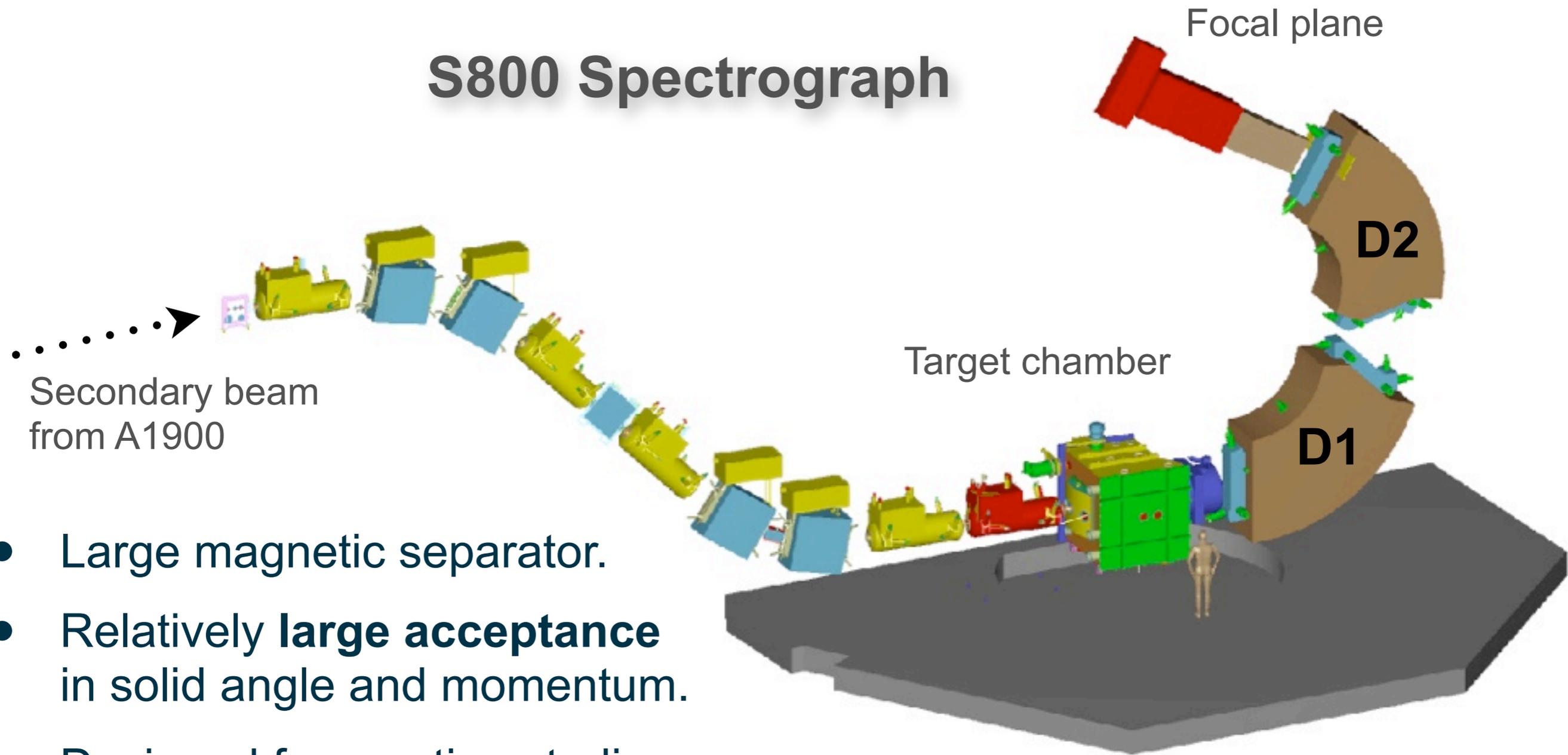
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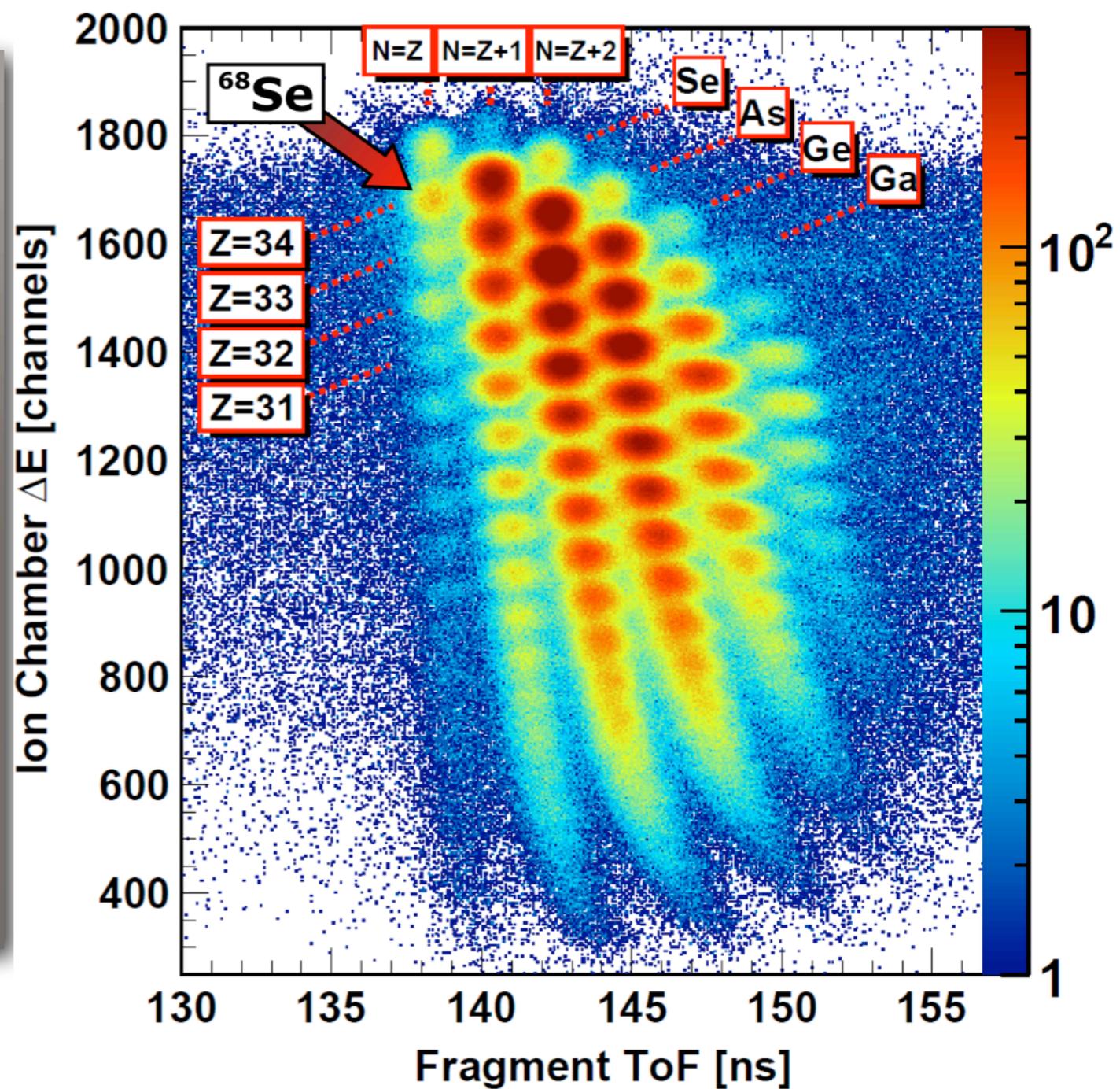
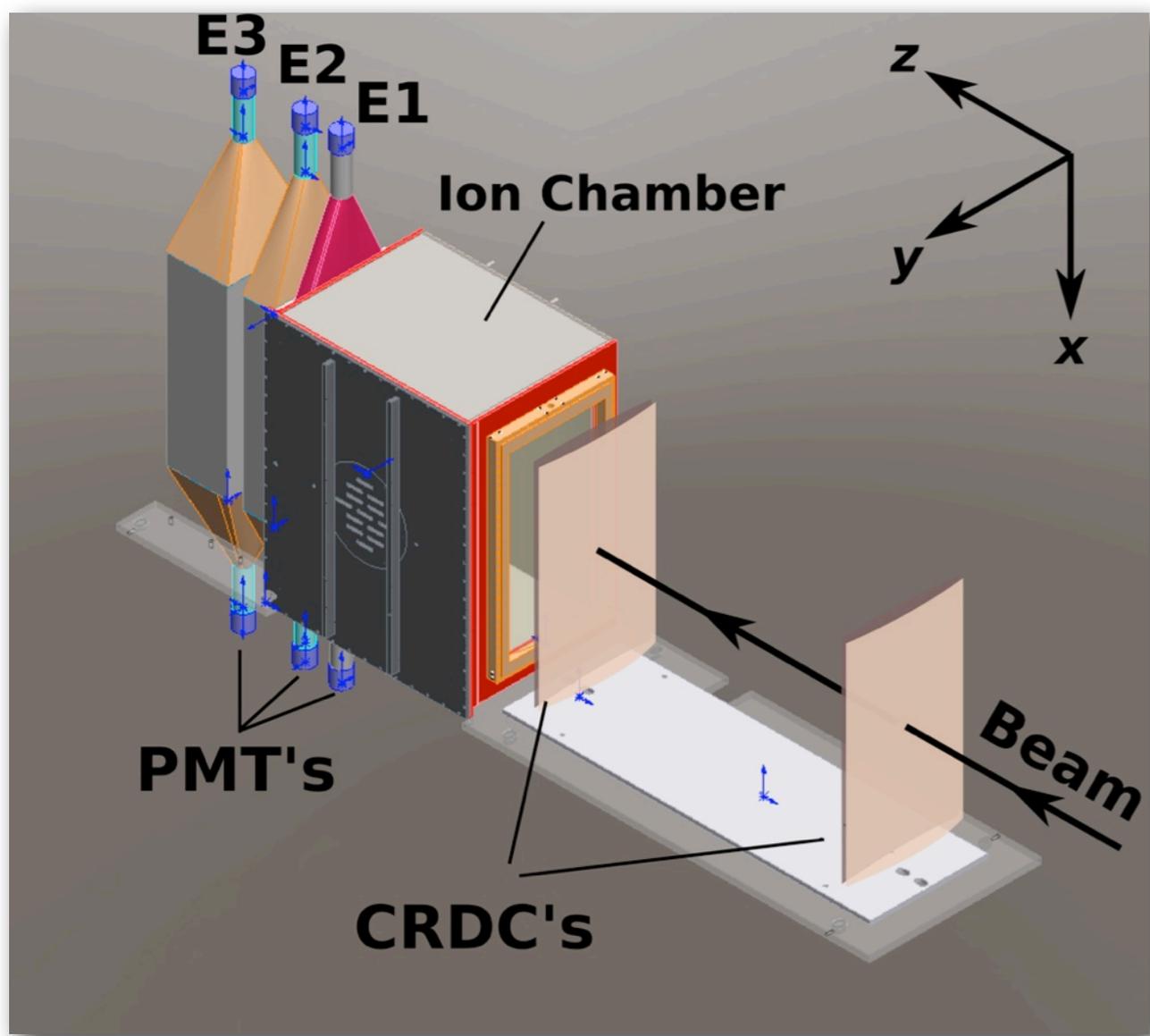
Gaseous chambers in the NSCL S800

S800 Spectrograph



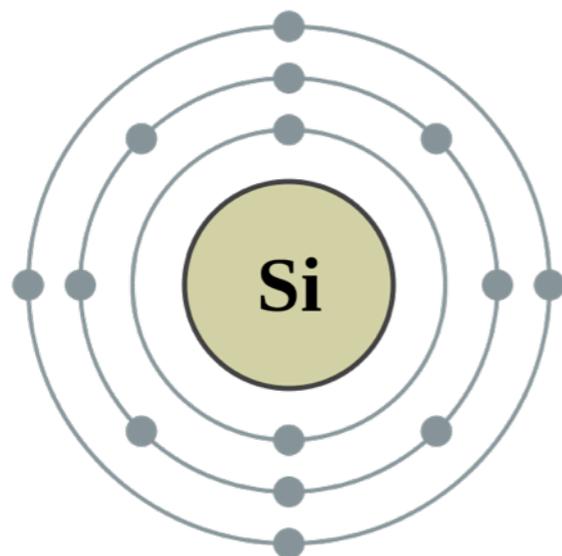
- Large magnetic separator.
- Relatively **large acceptance** in solid angle and momentum.
- Designed for reaction studies with exotic beams produced through projectile fragmentation at NSCL.

Gaseous chambers in the NSCL S800



Silicon Detectors

Silicon



					8A 2 He $1s^2$ helium 4.003
3A 5 B [He] $2s^2 2p^1$ boron 10.81	4A 6 C [He] $2s^2 2p^2$ carbon 12.01	5A 7 N [He] $2s^2 2p^3$ nitrogen 14.01	6A 8 O [He] $2s^2 2p^4$ oxygen 16.00	7A 9 F [He] $2s^2 2p^5$ fluorine 19.00	10 Ne [He] $2s^2 2p^6$ neon 20.18
13 Al [Ne] $3s^2 3p^1$ aluminum 26.98	14 Si [Ne] $3s^2 3p^2$ silicon 28.09	15 P [Ne] $3s^2 3p^3$ phosphorus 30.97	16 S [Ne] $3s^2 3p^4$ sulfur 32.06	17 Cl [Ne] $3s^2 3p^5$ chlorine 35.45	18 Ar [Ne] $3s^2 3p^6$ argon 39.95
31 Ga [Ar] $4s^2 3d^{10} 4p^1$ gallium 69.72	32 Ge [Ar] $4s^2 3d^{10} 4p^2$ germanium 72.64	33 As [Ar] $4s^2 3d^{10} 4p^3$ arsenic 74.92	34 Se [Ar] $4s^2 3d^{10} 4p^4$ selenium 78.96	35 Br [Ar] $4s^2 3d^{10} 4p^5$ bromine 79.90	36 Kr [Ar] $4s^2 3d^{10} 4p^6$ krypton 83.79

(From LANL Chem. Div.)

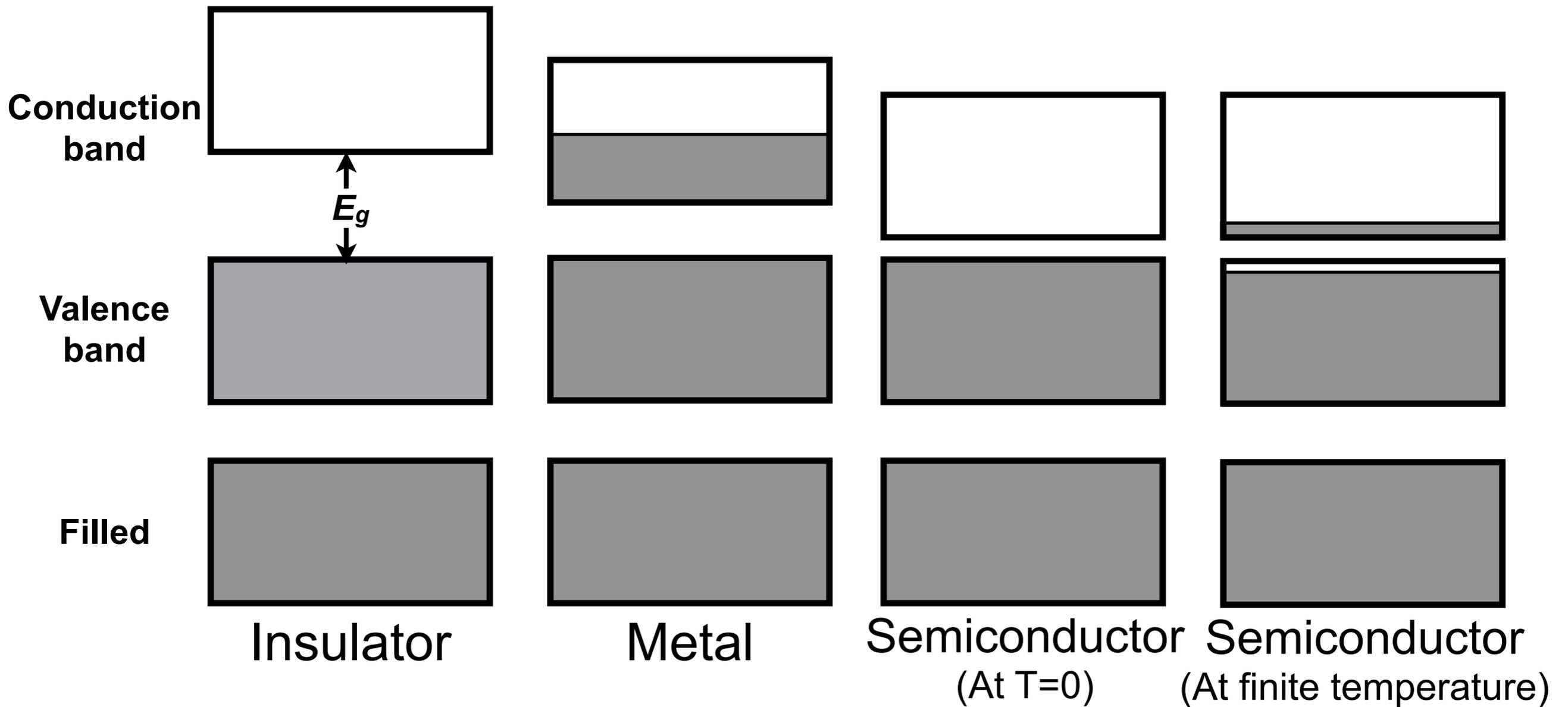
4 valence electrons that participate in covalent bonding.



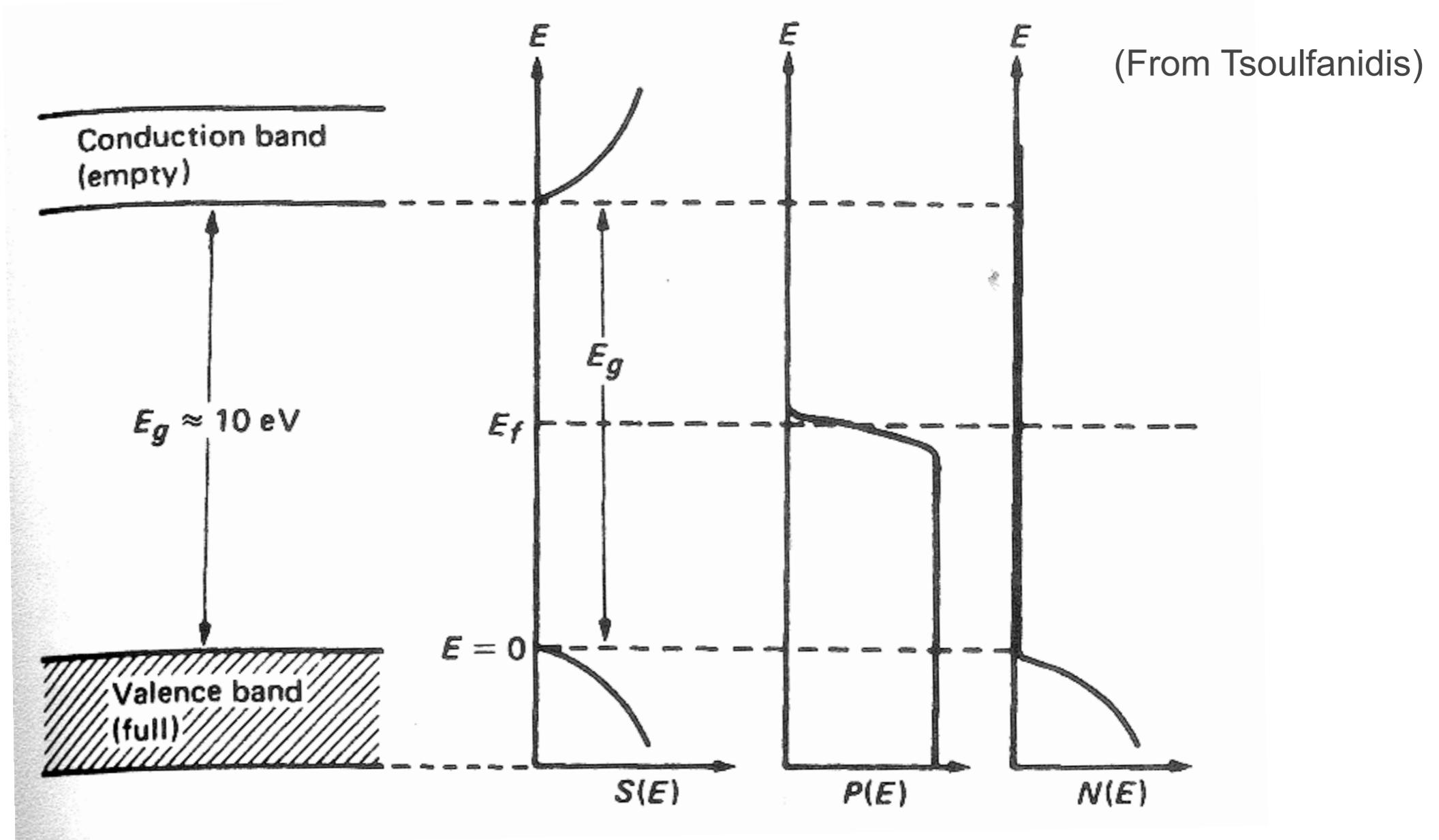
The Avogadro Project

Electronic band structure

- Atoms have discrete energy levels.
- Electrons in crystals are arranged in energy bands.
- Forbidden regions, where no wavelike electron orbitals exist, are known as *bandgaps*.



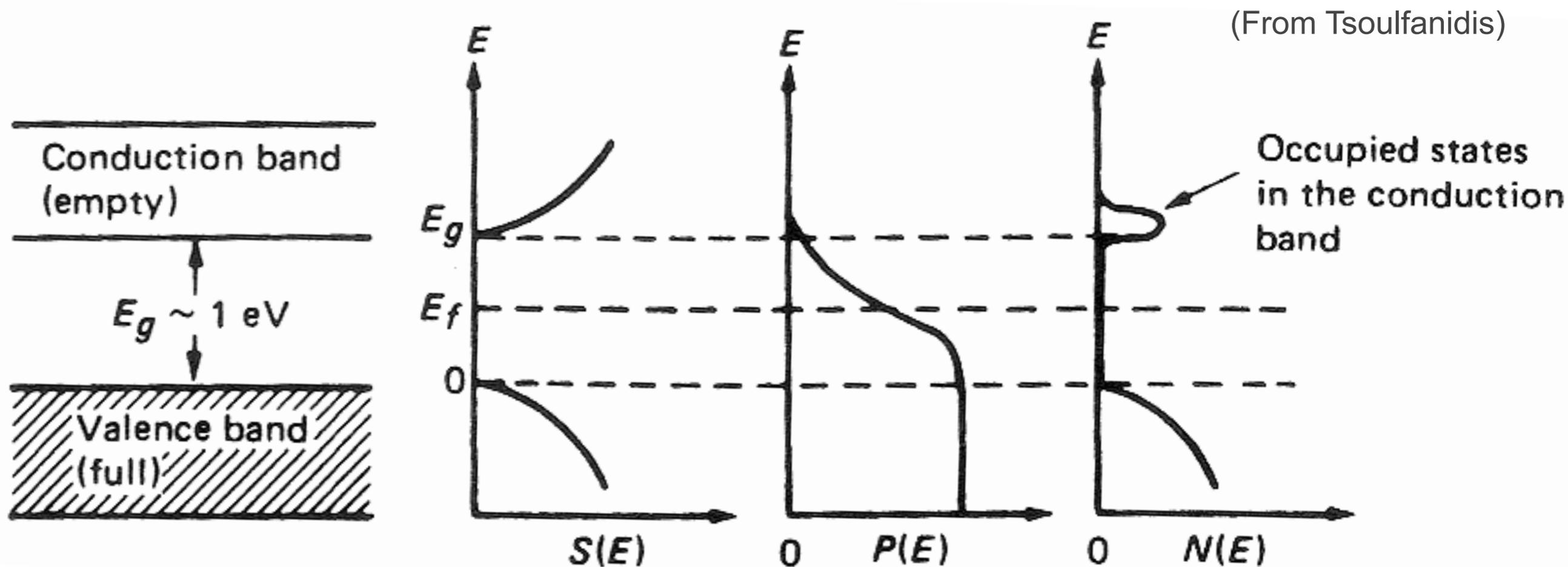
Insulator band structure



- The probability that a state of energy E is occupied is given by the Fermi distribution function.
- In an *insulator* the band gap is relatively large.
- Even at large finite temperature the number of electrons in the conduction band is **zero**.

$$P(E) = \frac{1}{1 + e^{(E - E_f)/kT}}$$

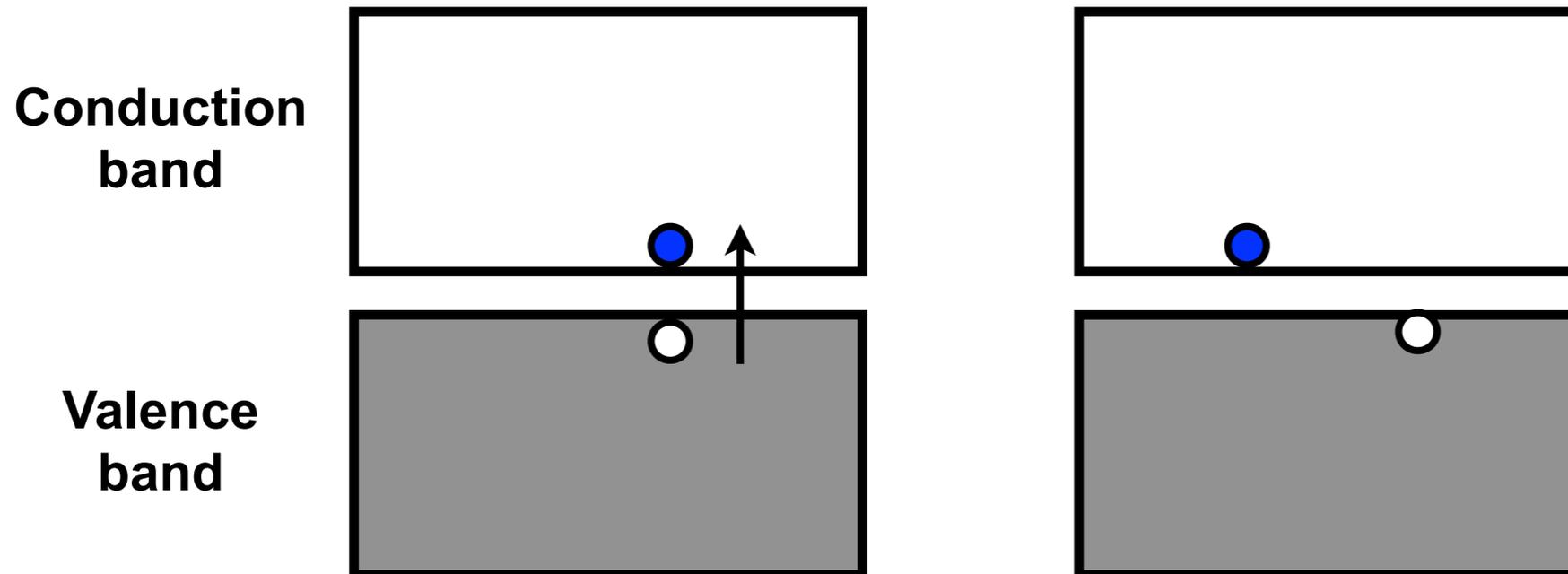
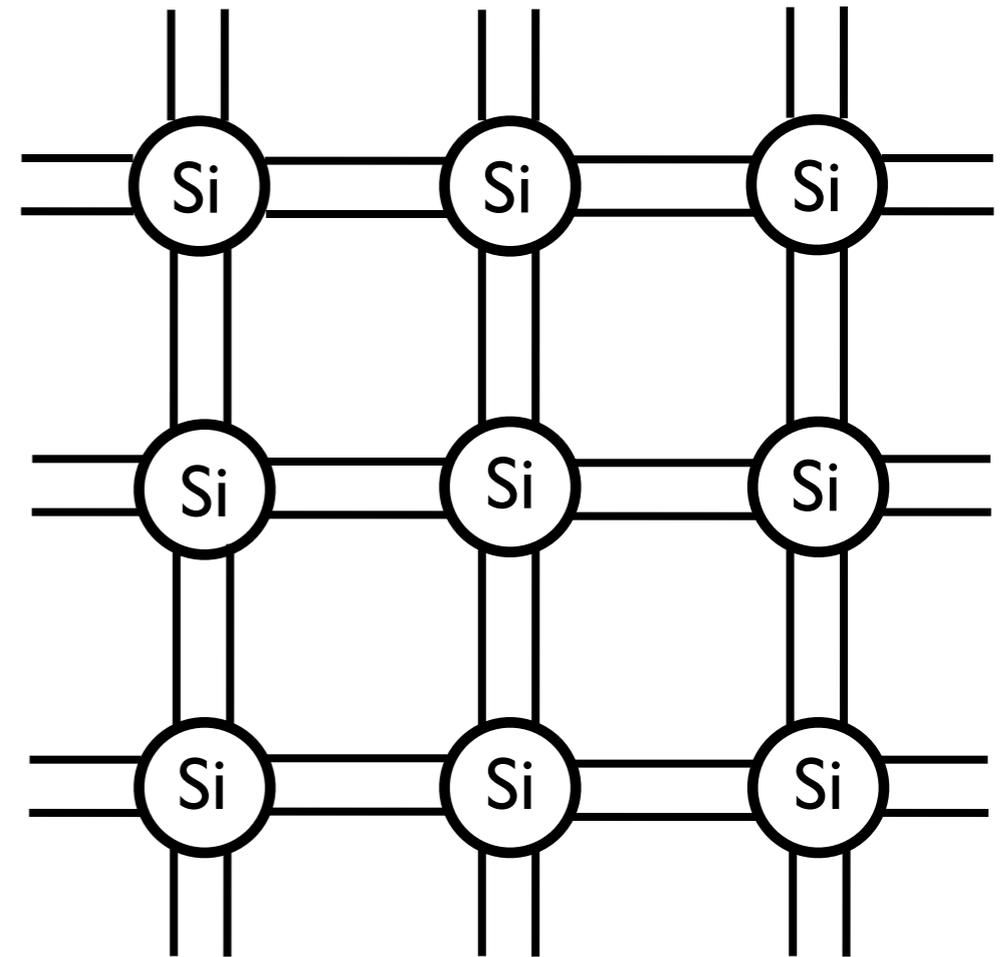
Semiconductor band structure



- In an **semiconductor** the band gap is relatively small.
- At finite temperature the number of electrons in the conduction band is **finite** but small compared to a metal. If an electric field is applied a current will flow.
- At $T=0$, states can be filled up to the Fermi energy and the number of electrons in the conduction band is zero. At $T=0$ the semiconductor is an **insulator**.

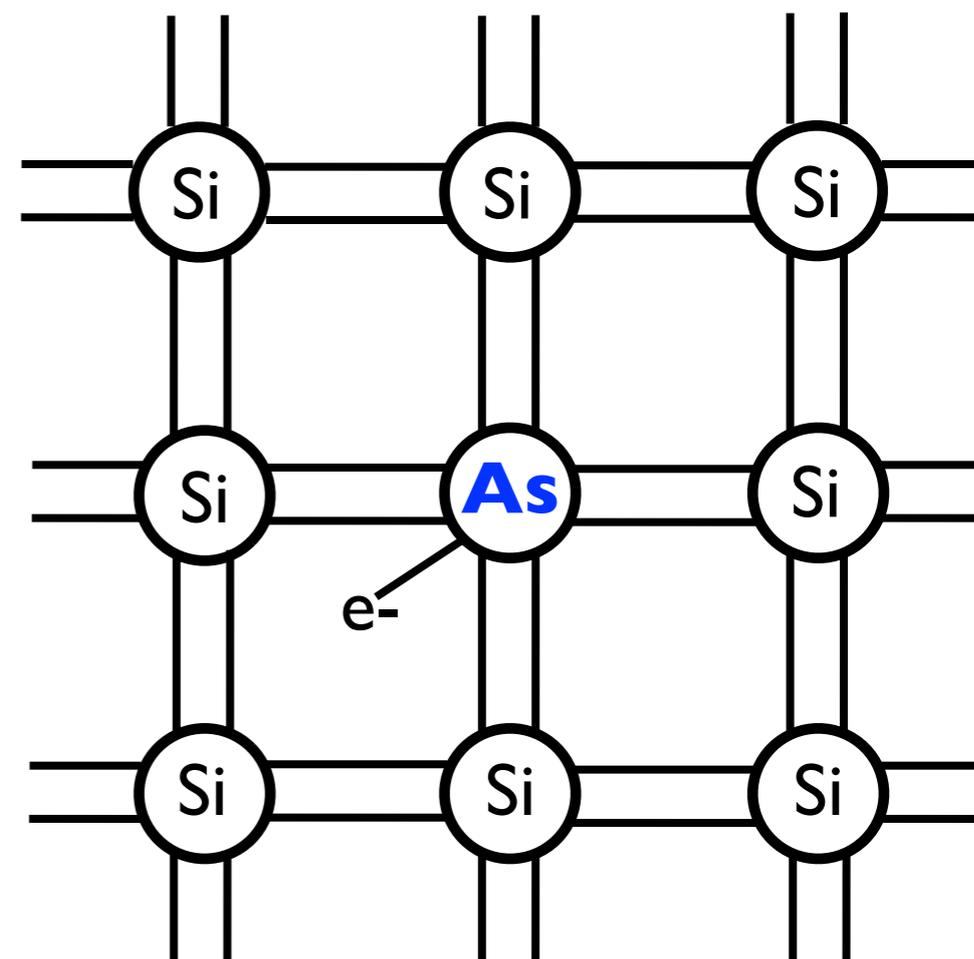
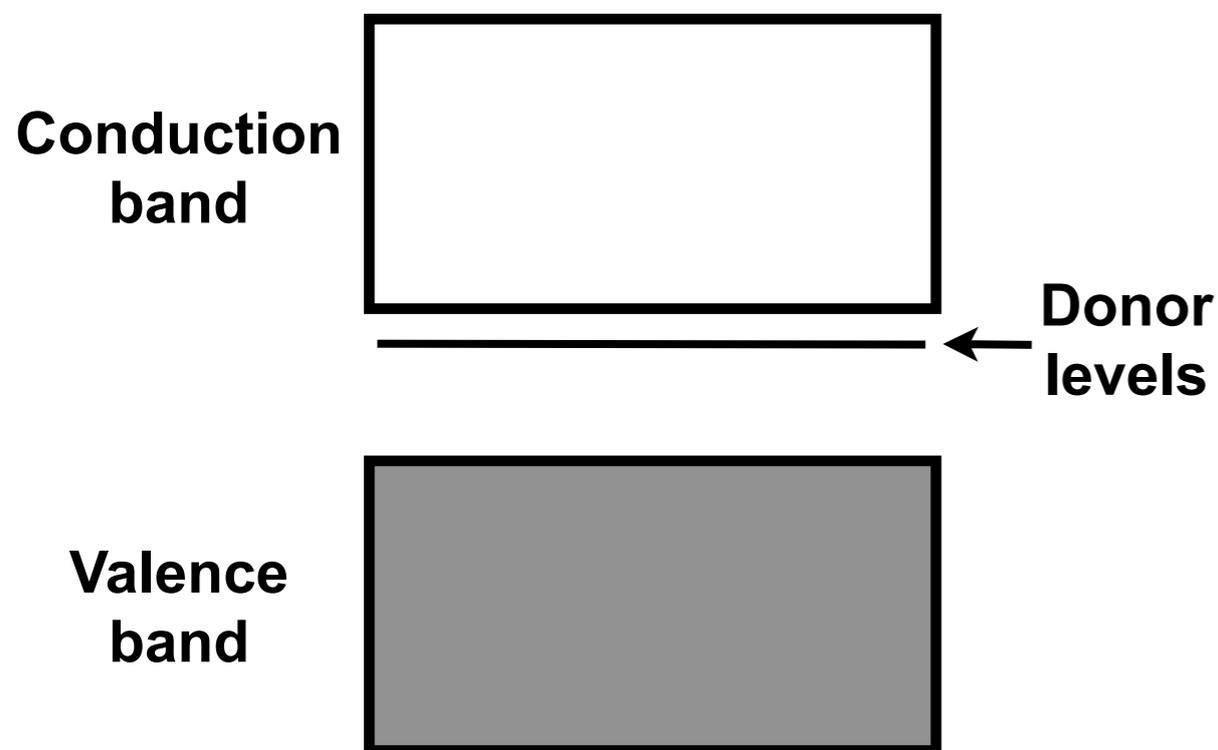
Intrinsic (pure) silicon

- At finite temperature there are on the order $n_i \sim 10^{10}$ electrons/cm³ in the conduction band that are free to move through the lattice.
- An equilibrium concentration of **electron-hole pairs** is created and the intrinsic-carrier densities are equal,
$$n_i = p_i$$
- These electron-hole pairs diffuse randomly, if we apply an electric field we can collect these charges.
- There are always impurities and defects in real crystalline silicon.



Impurities: n-type silicon

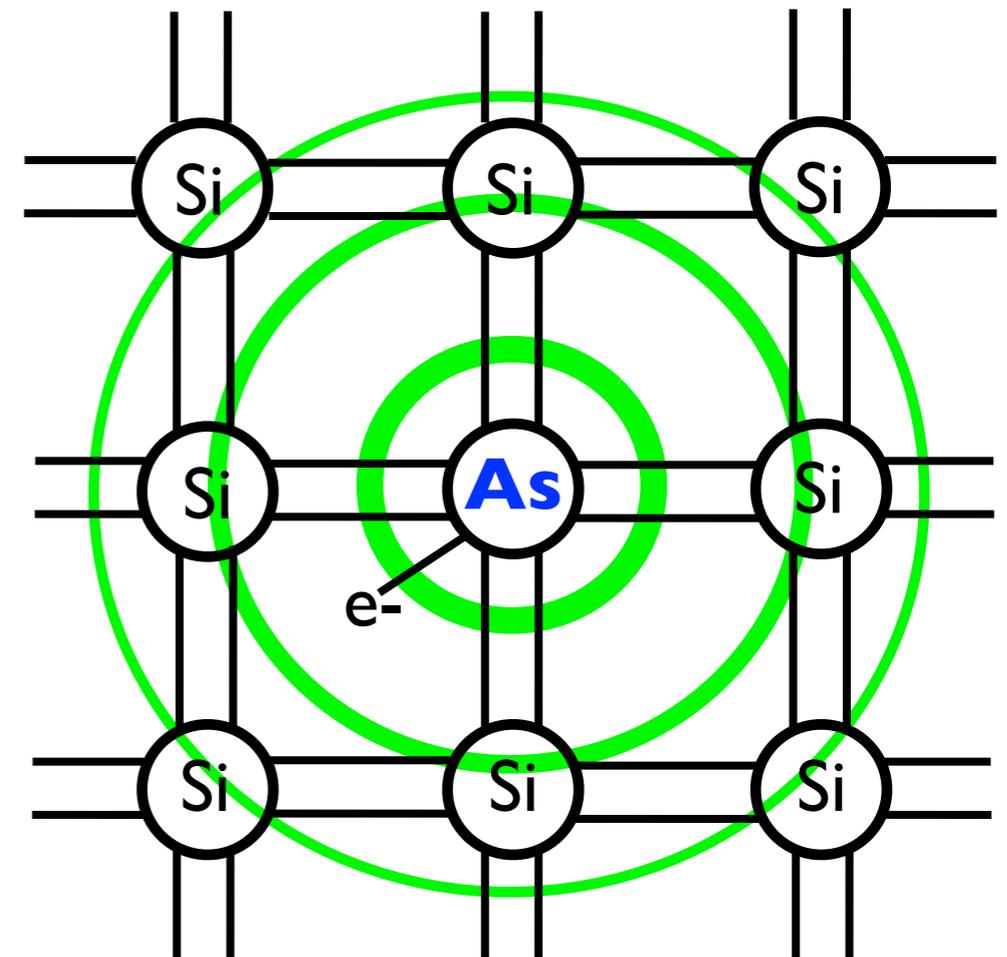
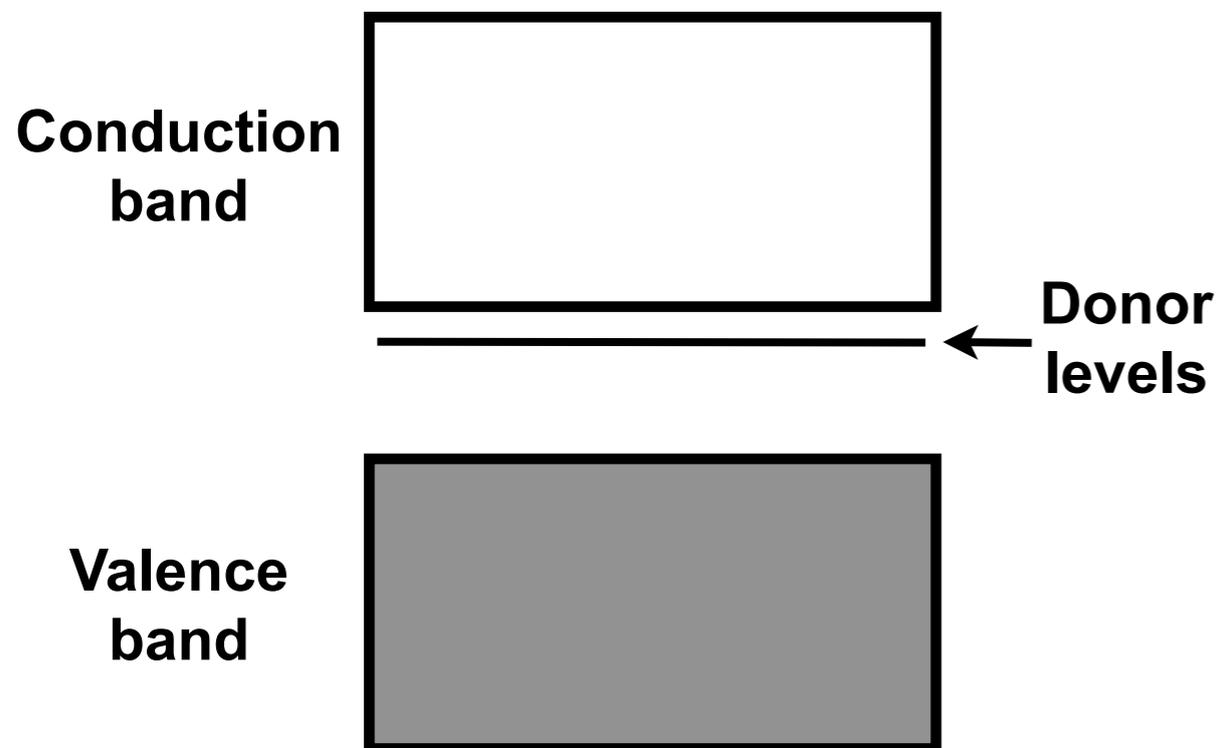
- We can dope a semiconductor in order to control the number of electrons and holes, thus altering the resistivity.
- **n-type** silicon is doped with atoms that **add electrons** to the conduction band.
- The extra electron does not participate in bonding.
- Typically come from Group V when added to Si or Ge and have a weakly-bound electron.
- The wavefunction of the impurity extends over many of its neighbor atoms.



- **Electrons** are the majority carrier.
- Energy gap between the donor levels and the conduction band is small.
- Contributes to the electron concentration without adding holes to the valence band of the lattice.

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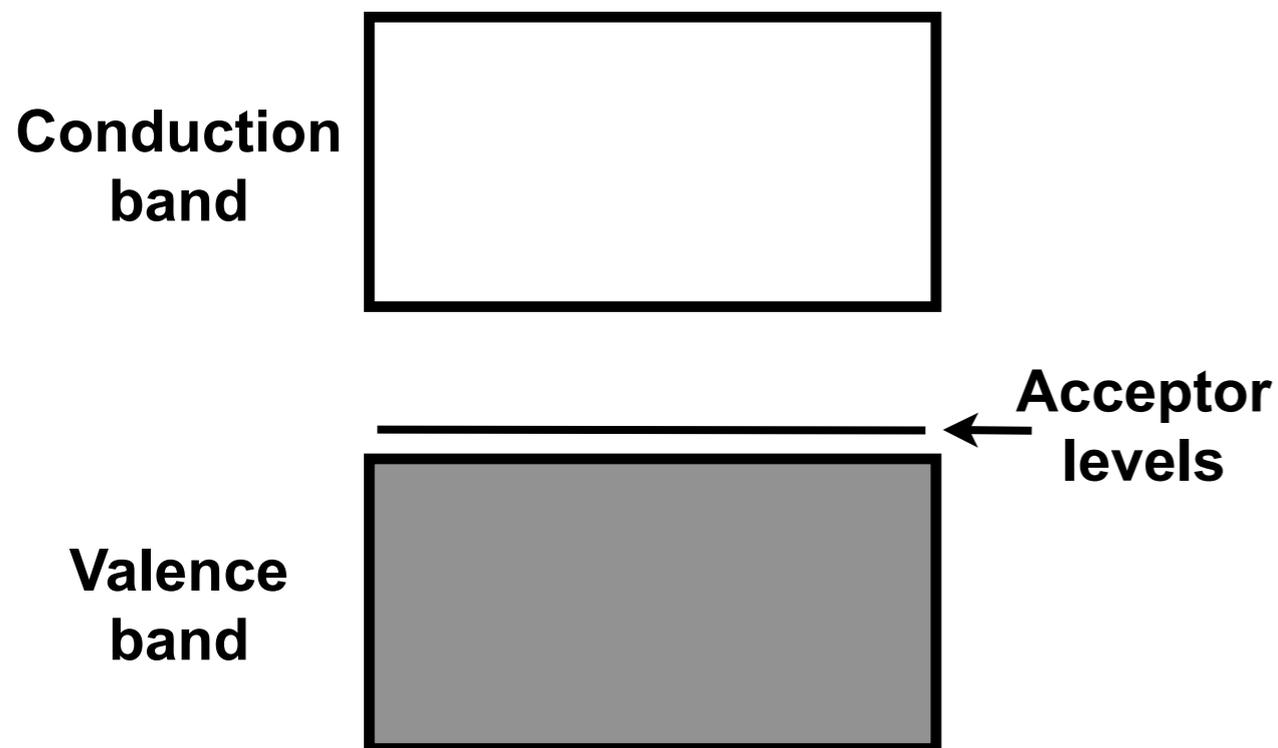
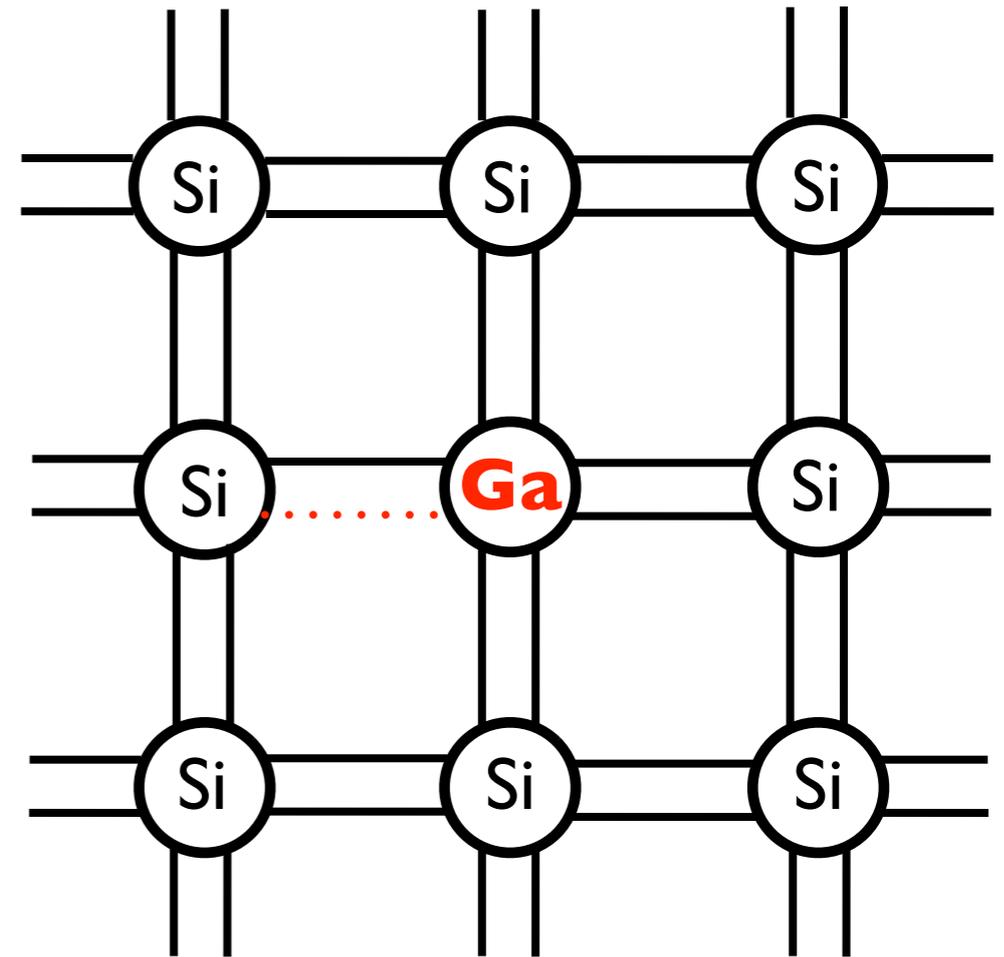
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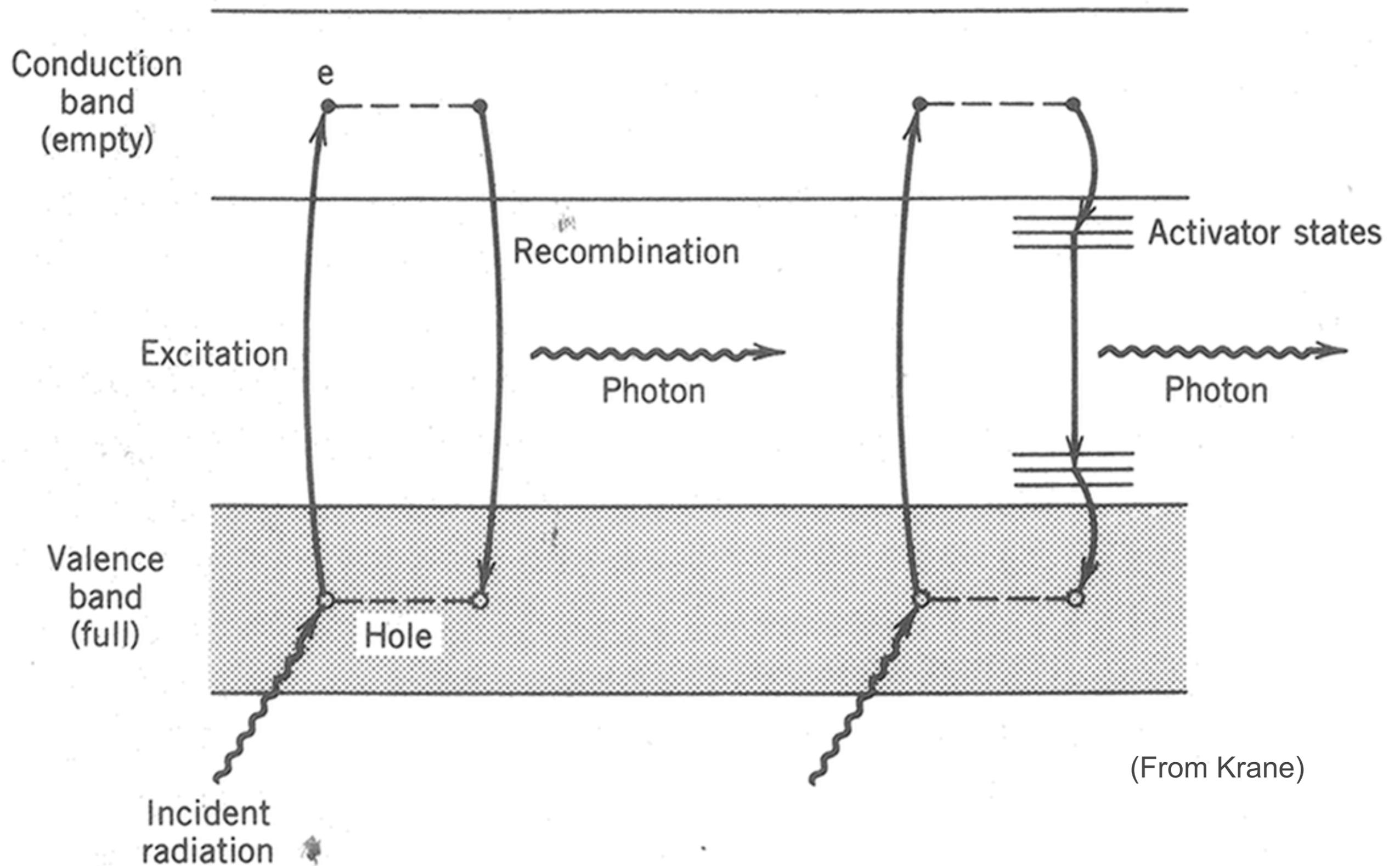
Impurities: p-type silicon

- *p-type* silicon is doped with atoms that **add holes** to the valence band.
- Typically come from Group III when added to Si or Ge and are missing a valence electron.



- **Holes** are the majority carrier.
- Energy gap between the acceptor levels and the valence band is small.
- Contributes to the hole concentration without adding electrons to the conduction band of the lattice.

Crystalline inorganic scintillators



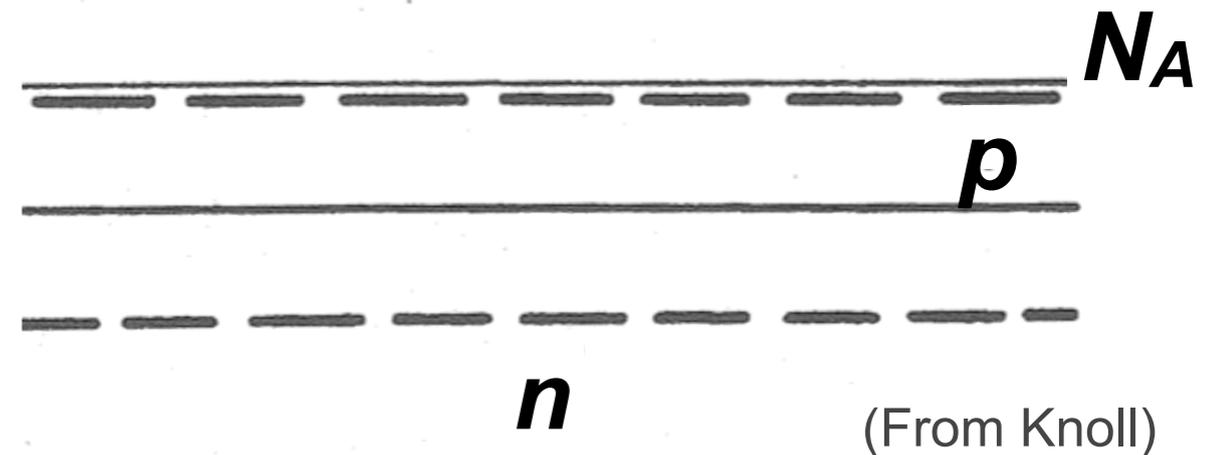
(From Krane)

The p-n junction

Concentration (log scale)

- Silicon detectors are based on the p-n junction.
- Formed by starting with a bulk n/p material and usually diffusing or implanting p/n impurities.
- Near the n-type region the concentration is dominated by the donor impurities.
- At the junction interface $N_A = N_D$ and the silicon is intrinsic.

n_i, p_i



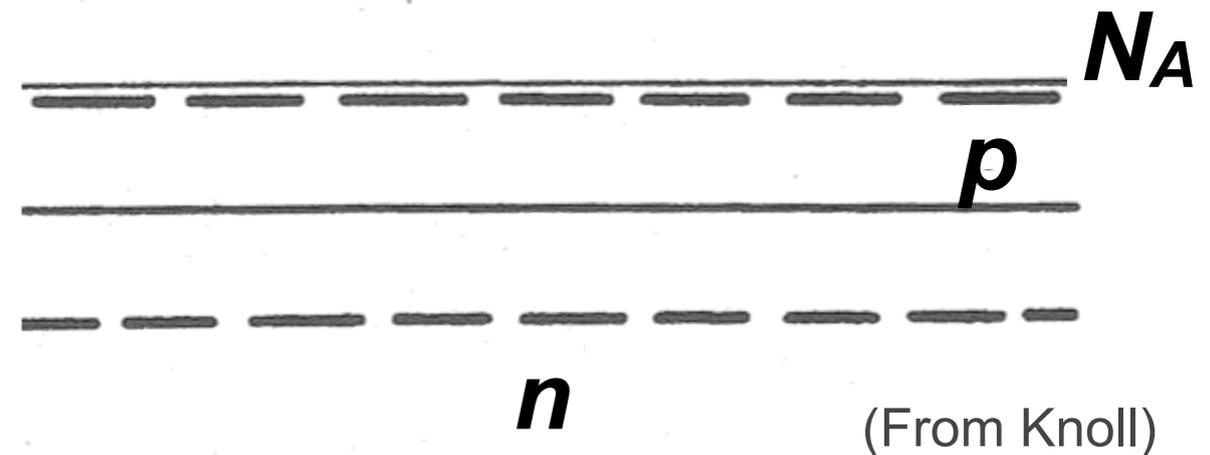
**p-type
doping**

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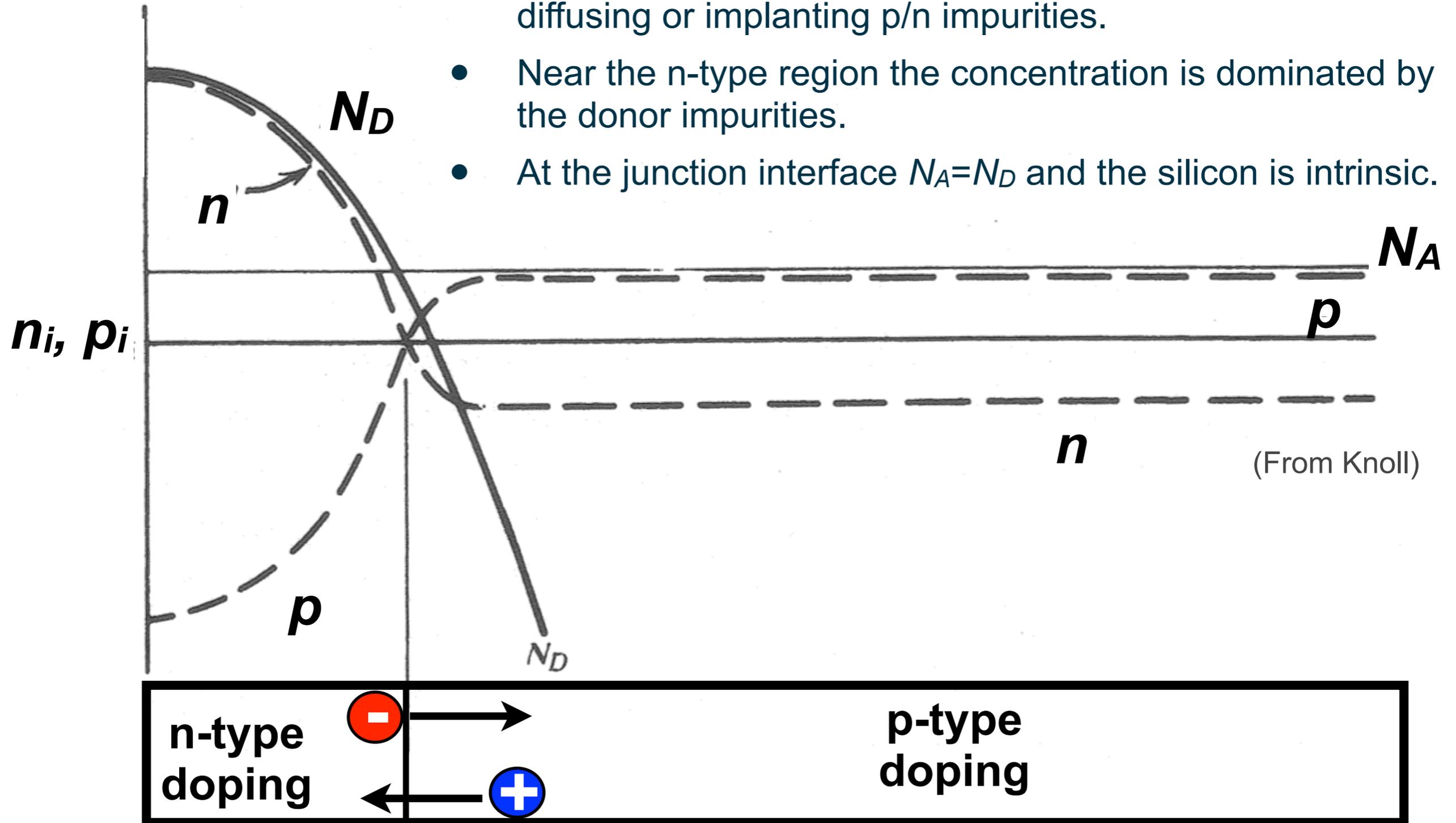
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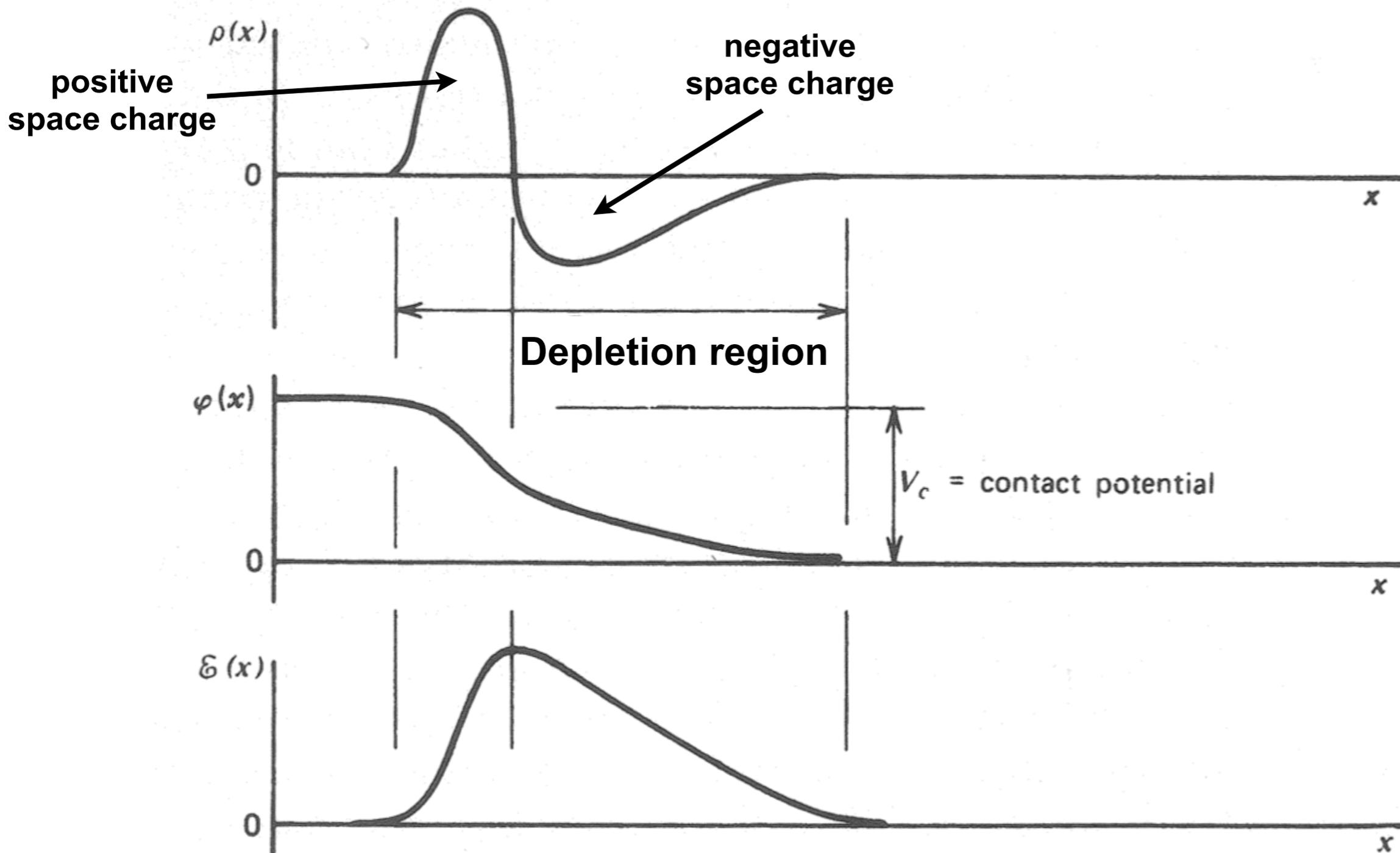
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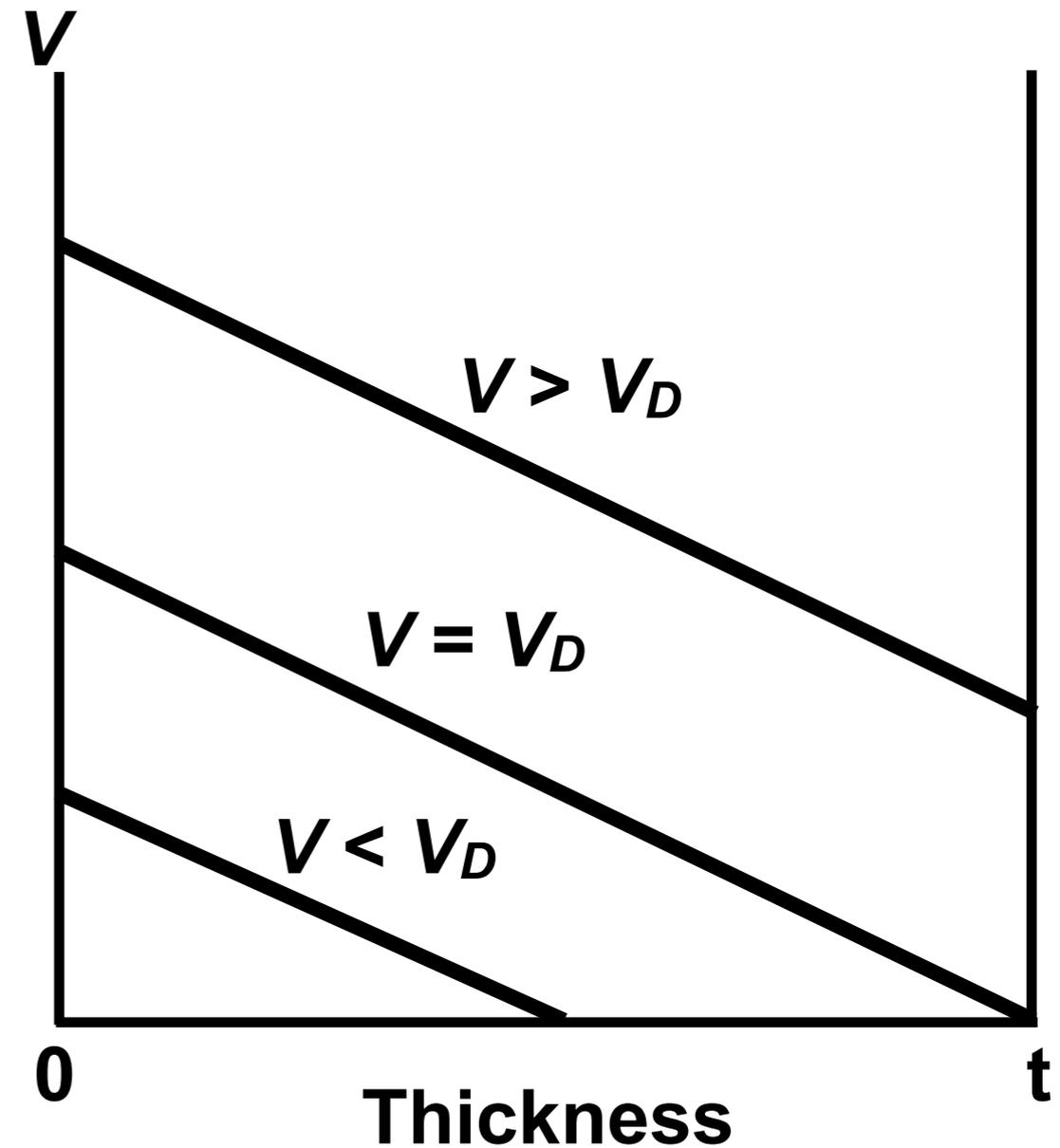
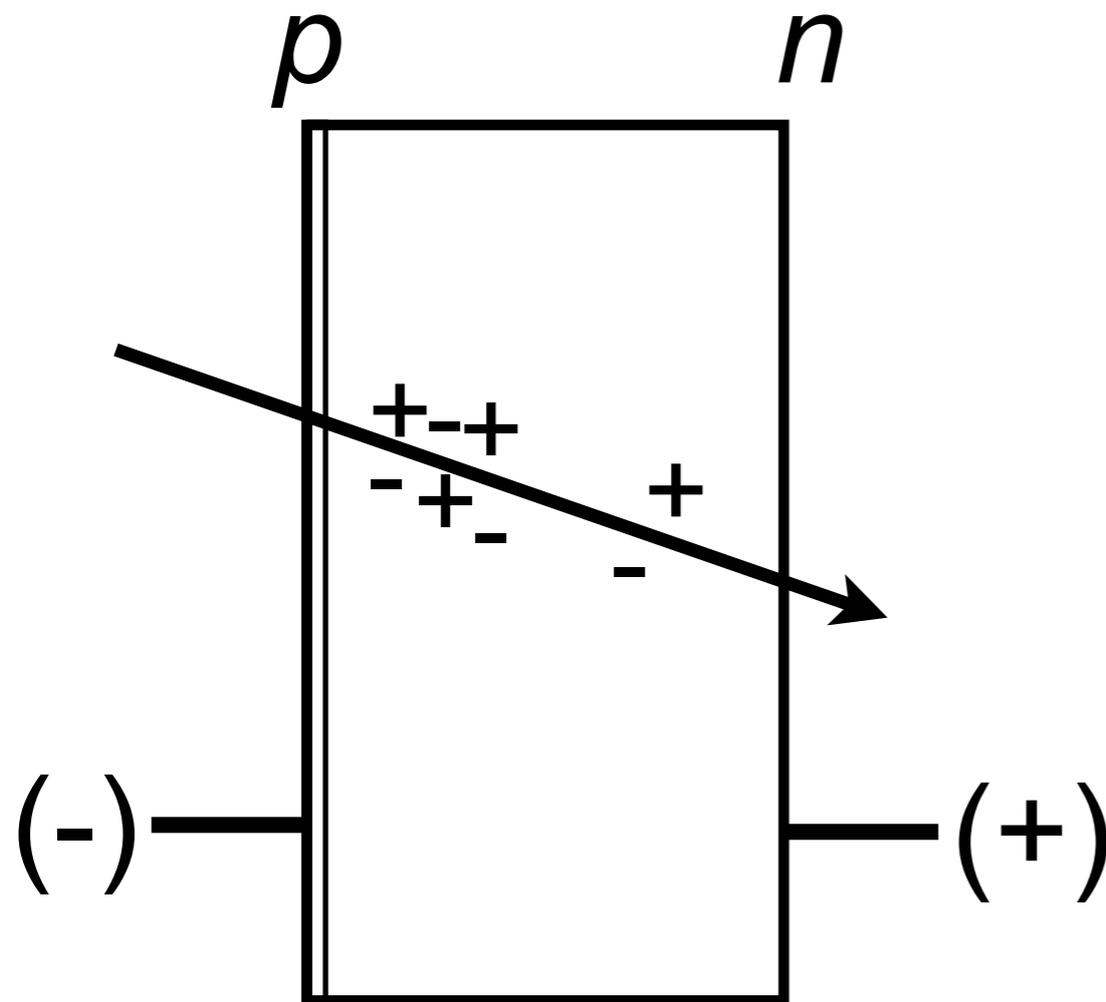
The p-n junction



(From Knoll)

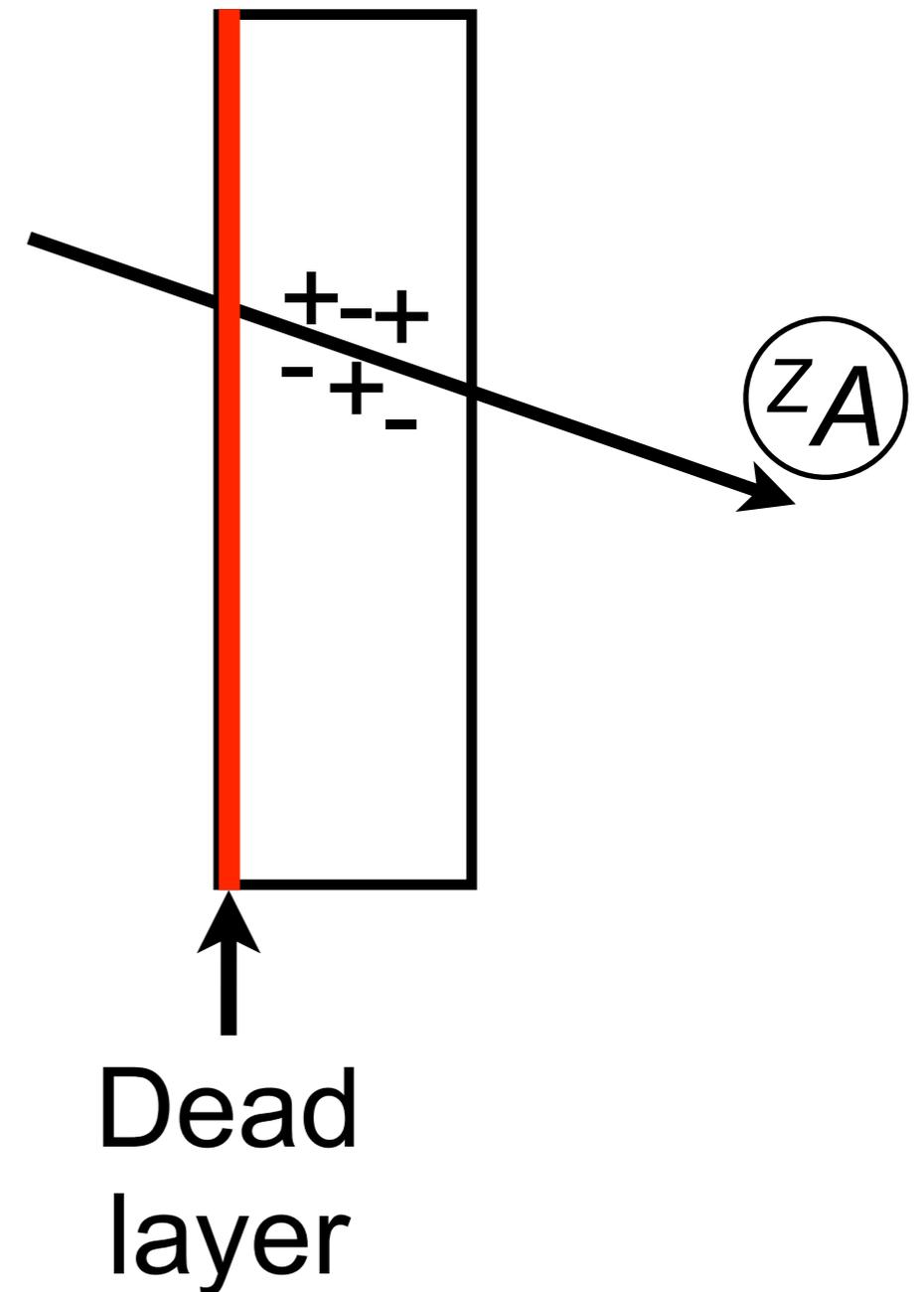
Fully depleted detector

- In the *depletion region* any electron-hole pairs are swept away by the electric field generated by the contact potential.
- **THIS IS VERY SIMILAR TO AN IONIZATION CHAMBER.**
- A detector is *fully depleted* when the electric field extends across the entire thickness of the detector.



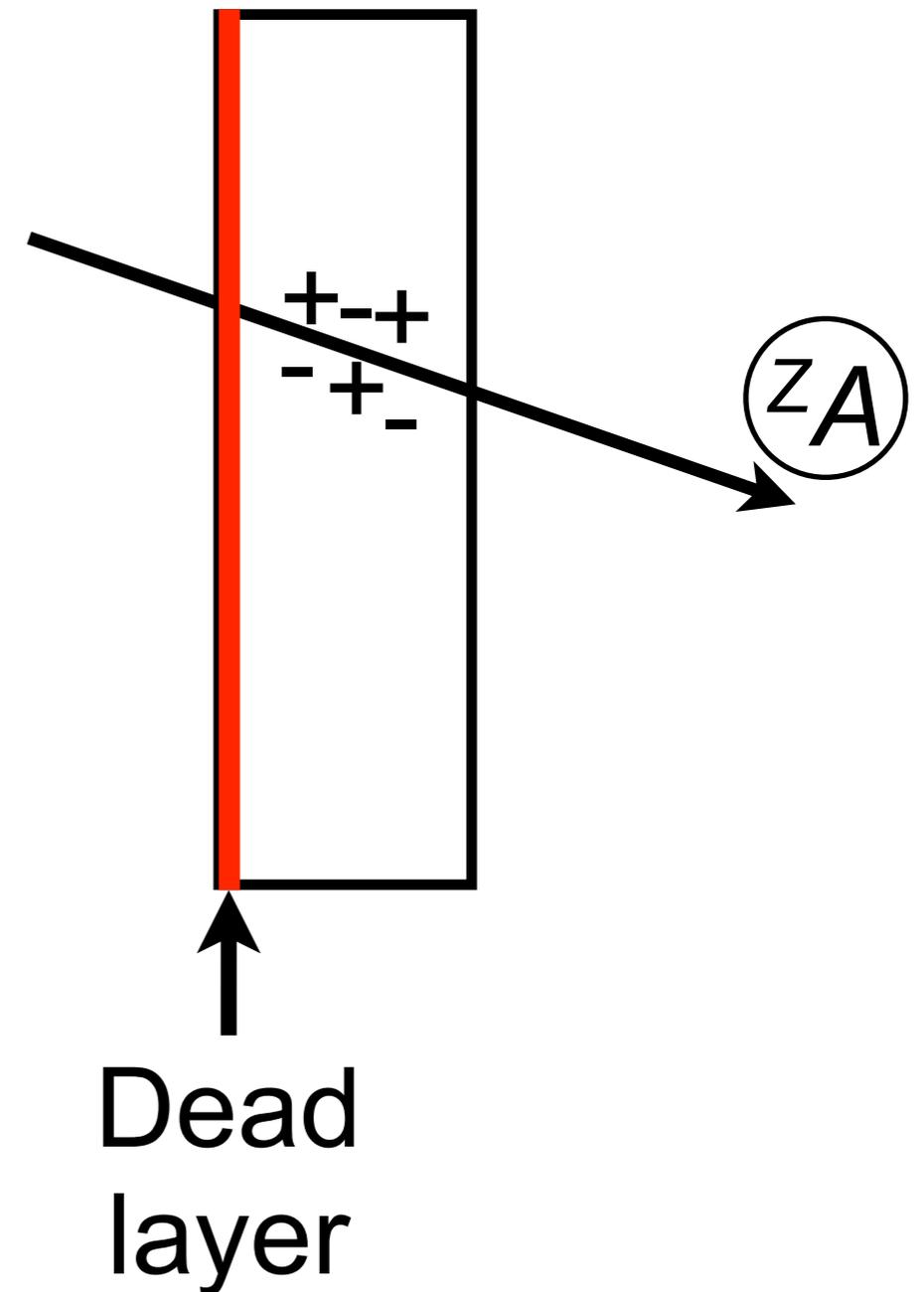
Silicon as a detector

- Silicon detectors are solid-state analogs of the ionization chamber.
- **Unlike** an ionization chamber, the mobility of the charge carriers (electrons and holes) are of the same order.
- At high enough voltages the charge-carrier velocity saturates and is on the order of, $10^7 \text{ cm/s} \implies < 10 \text{ ns}$ collection time for a detector 1mm thick.
- The amount of time it takes to collect the charge is effects the **rise time** of the signal and thus the timing response.
- Ionization energy of order 3eV compared to 30 eV for an ionization chamber.

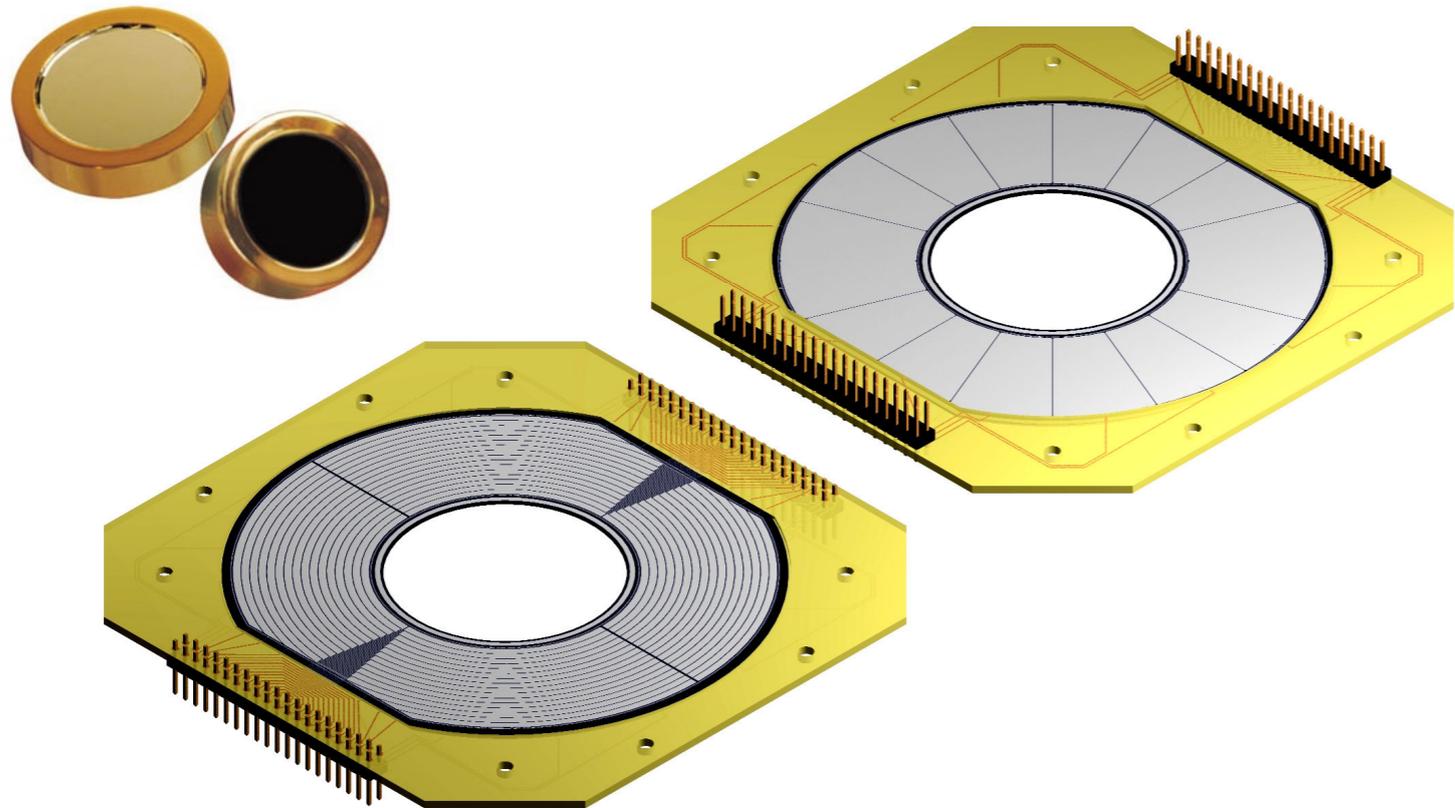


Dead layers

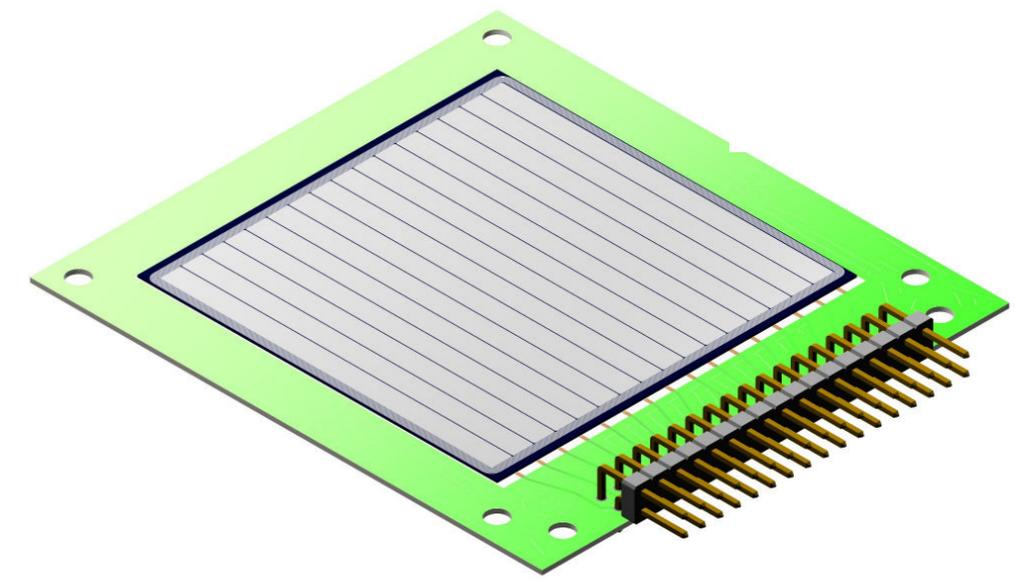
- We can control the active volume of a detector by controlling the depletion region.
- In a fully depleted detector almost the entire volume is active.
- However, there is always an inactive region of the detector called the **dead layer**.
- This may be a non-negligible source of energy loss.



Silicon detectors

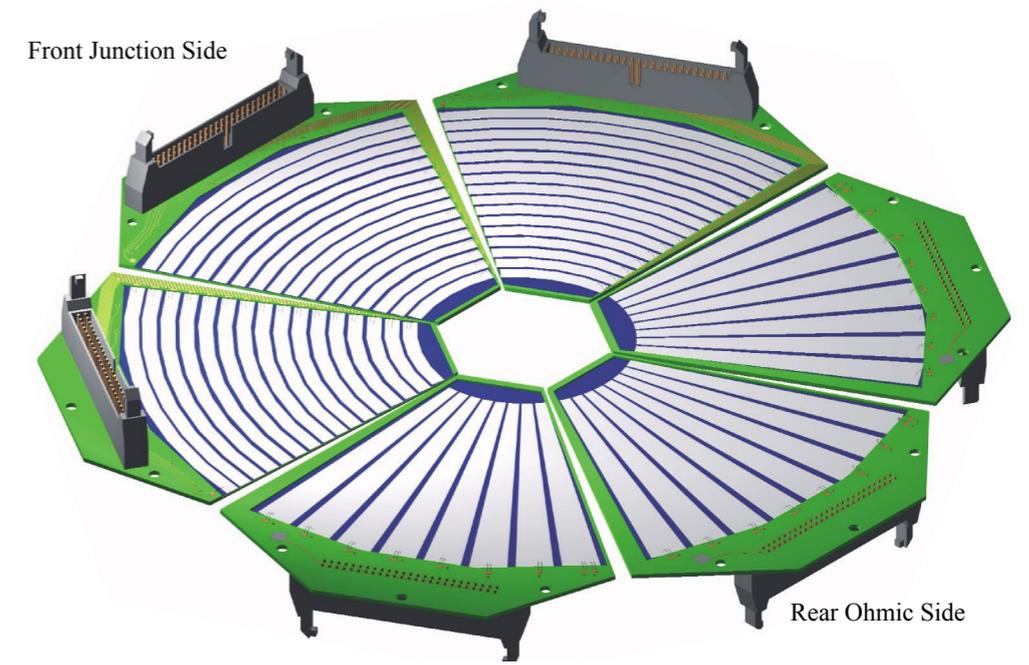
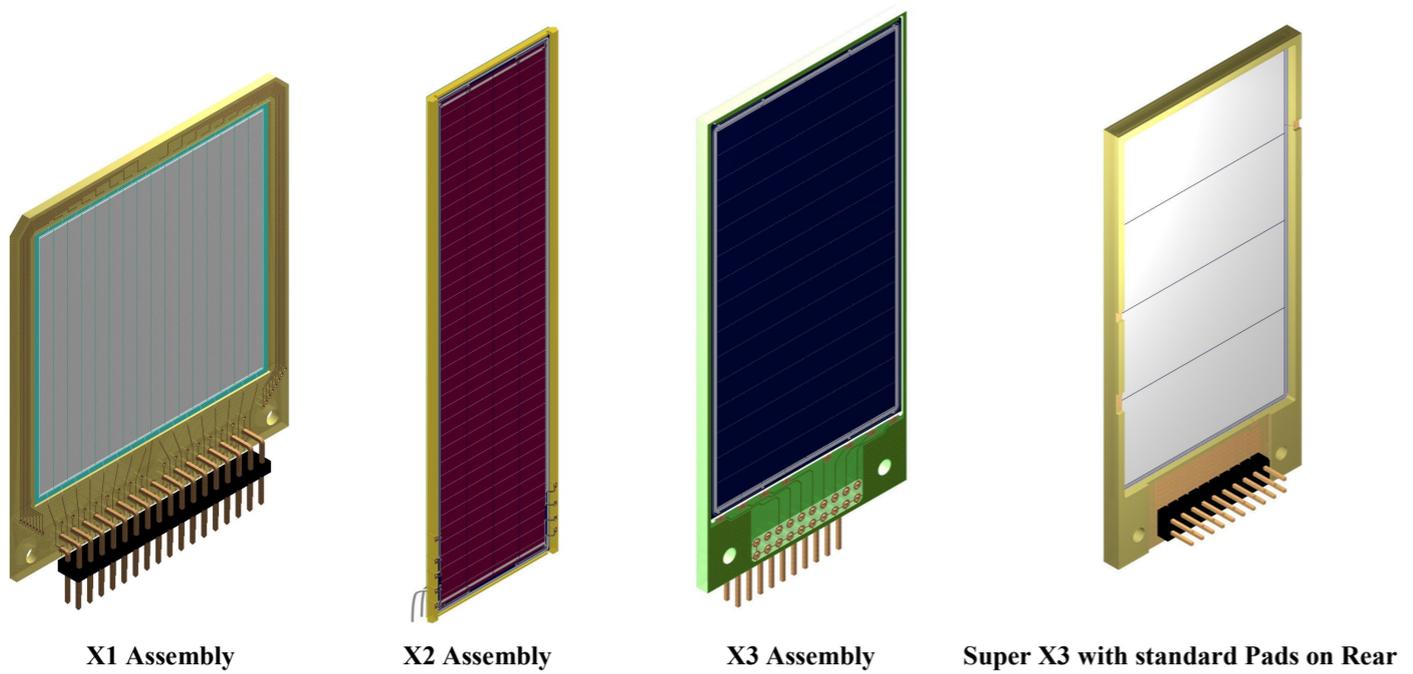


S1 detector and PCB as viewed from the p- and n-side.



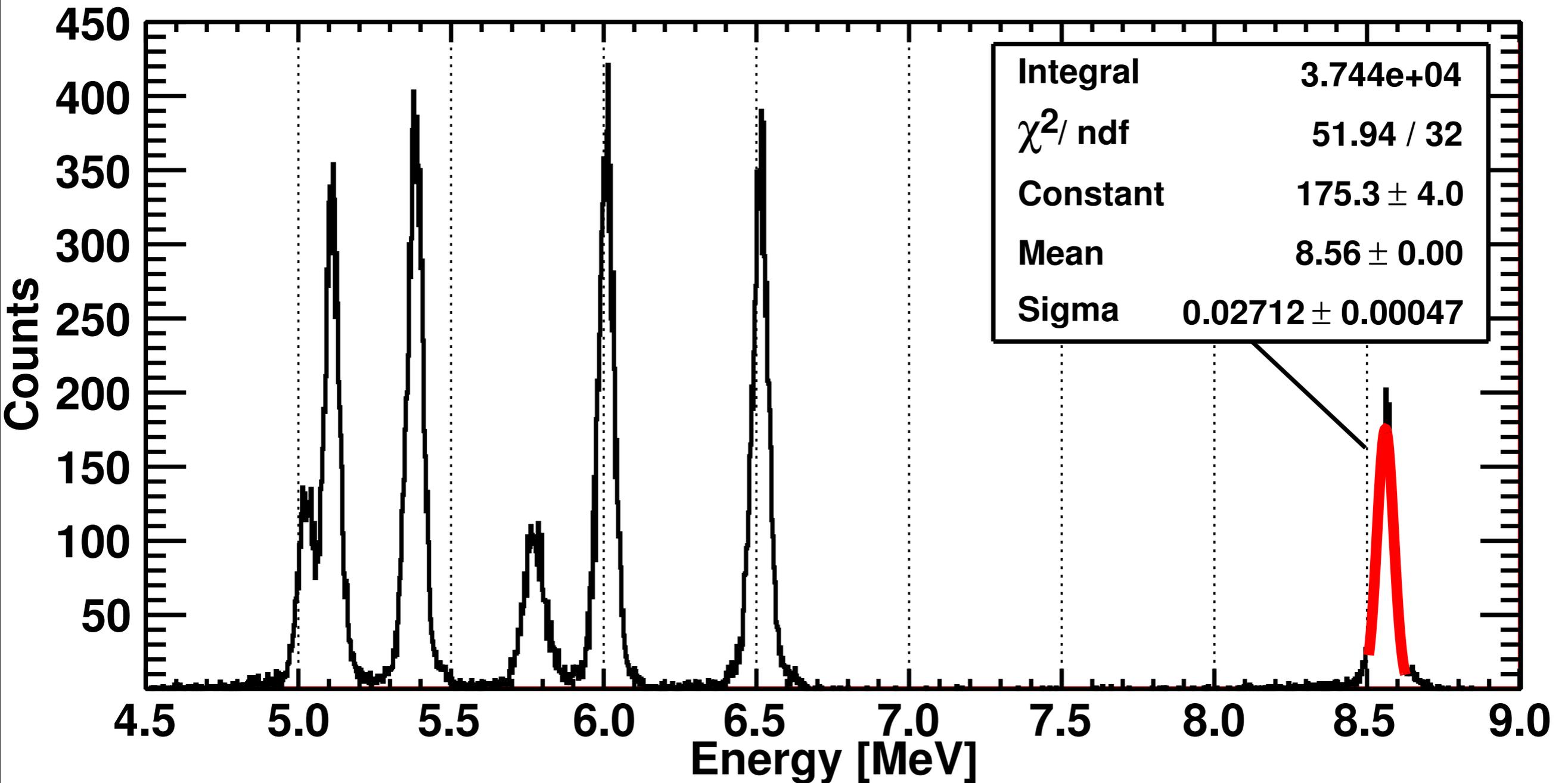
Design W1(DS)-300 2M/2M on a standard ceramic transmission package.

DESIGN MMM
DOUBLE SIDED 60° WEDGE DETECTOR FOR RADIOACTIVE BEAM PHYSICS

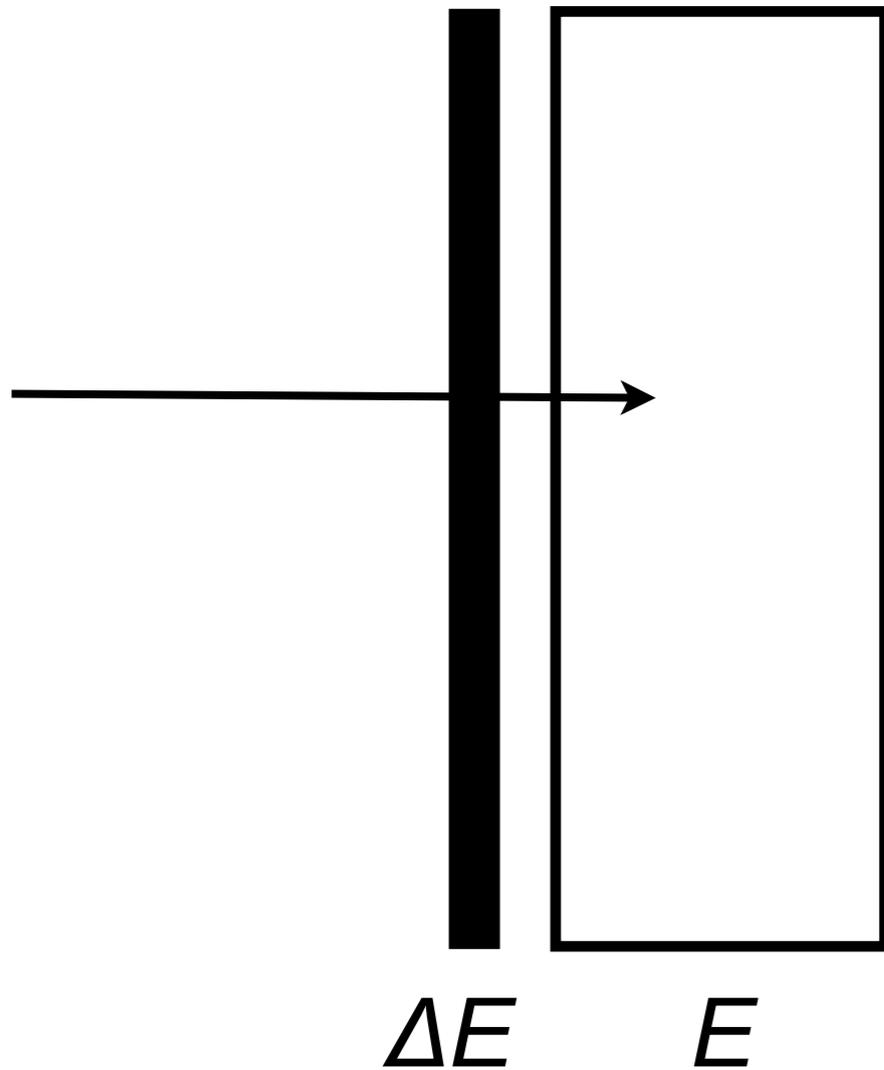


Spectroscopy with silicon

^{228}Th source



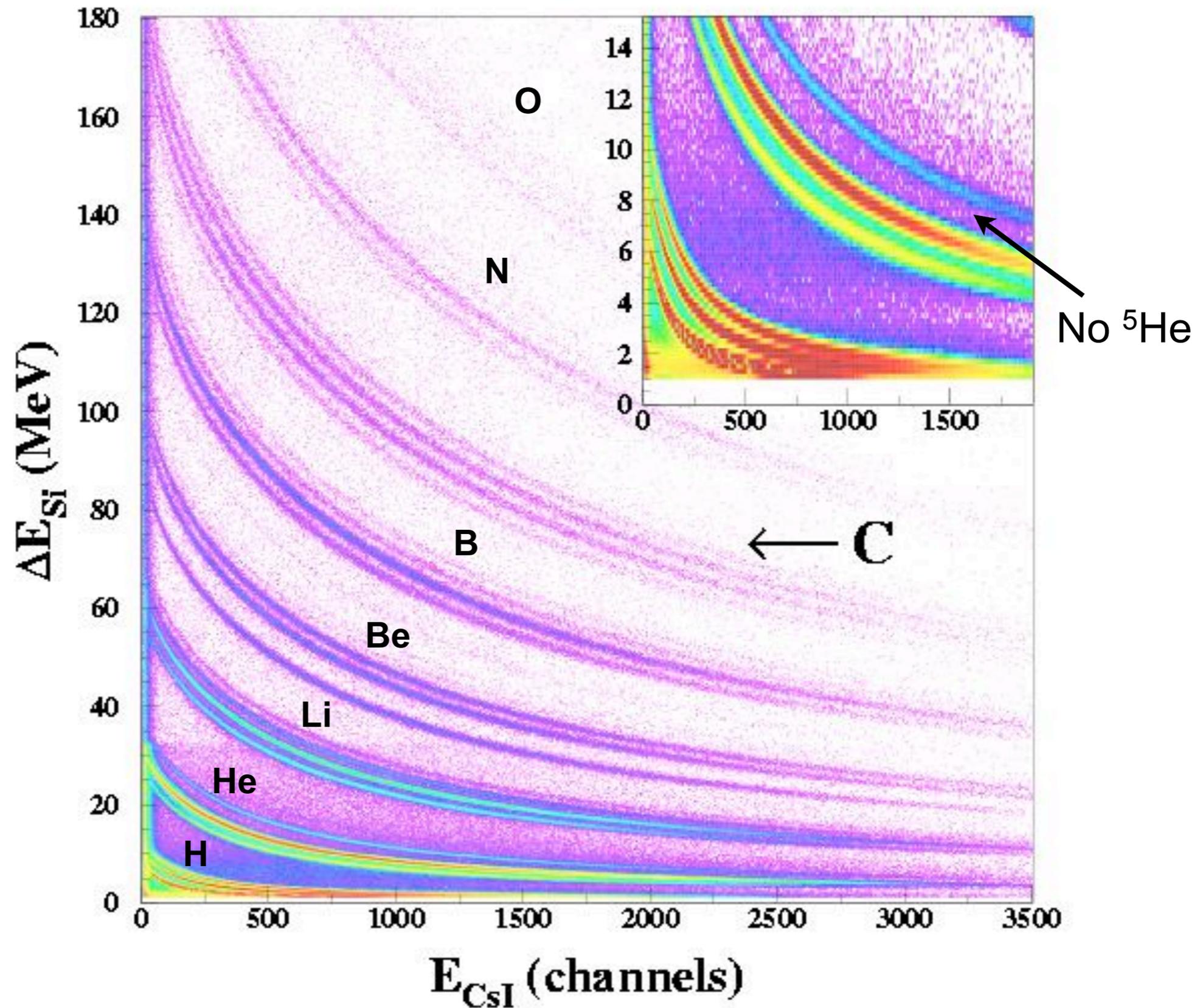
ΔE - E particle identification



- If you remember back to the Bethe equation . . .

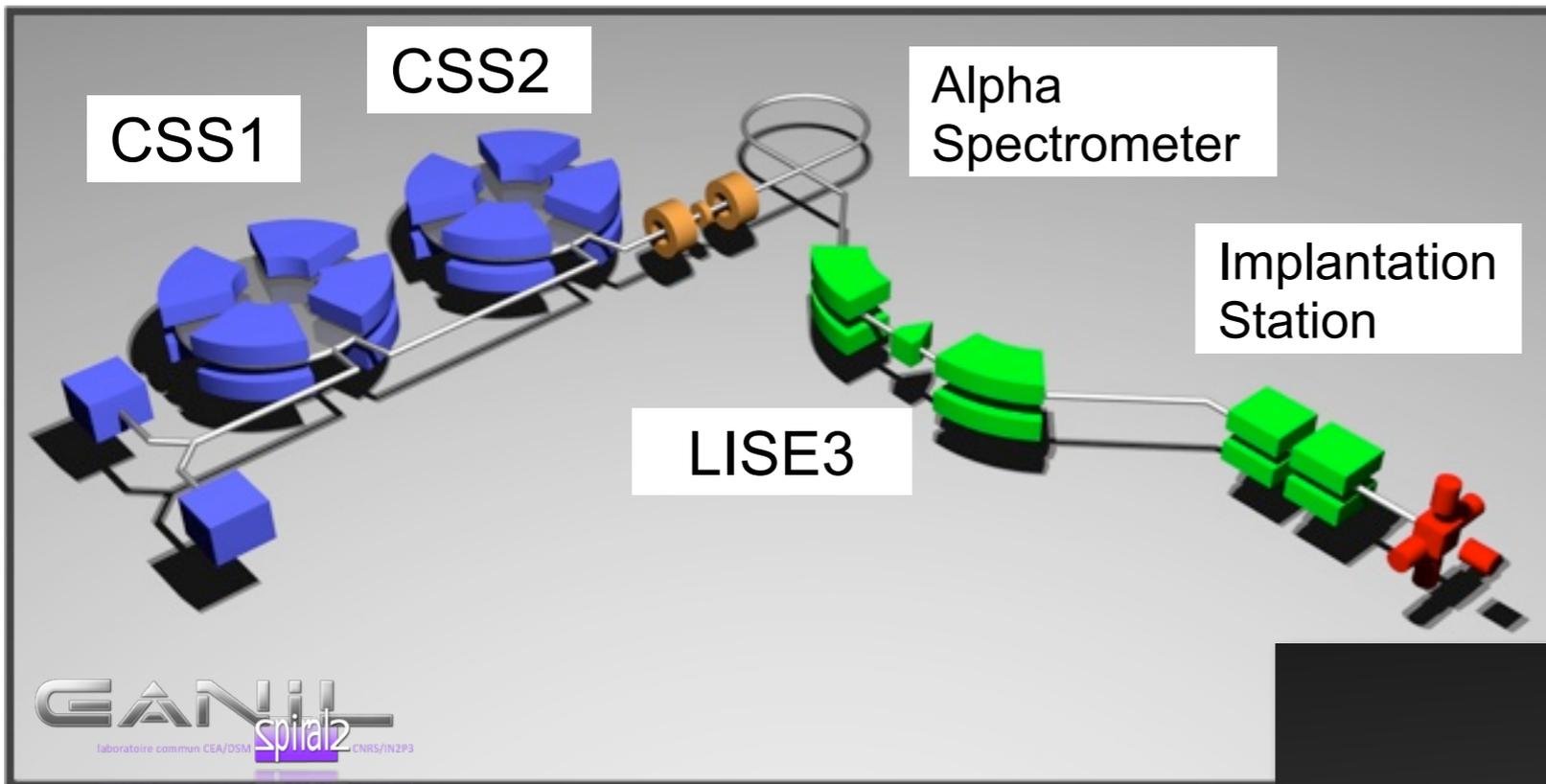
$$\frac{dE}{dx} \propto \frac{m_z z^2}{E} \ln\left(C \frac{E}{m_z}\right)$$

ΔE - E particle identification



Science with EXOTIC BEAMS

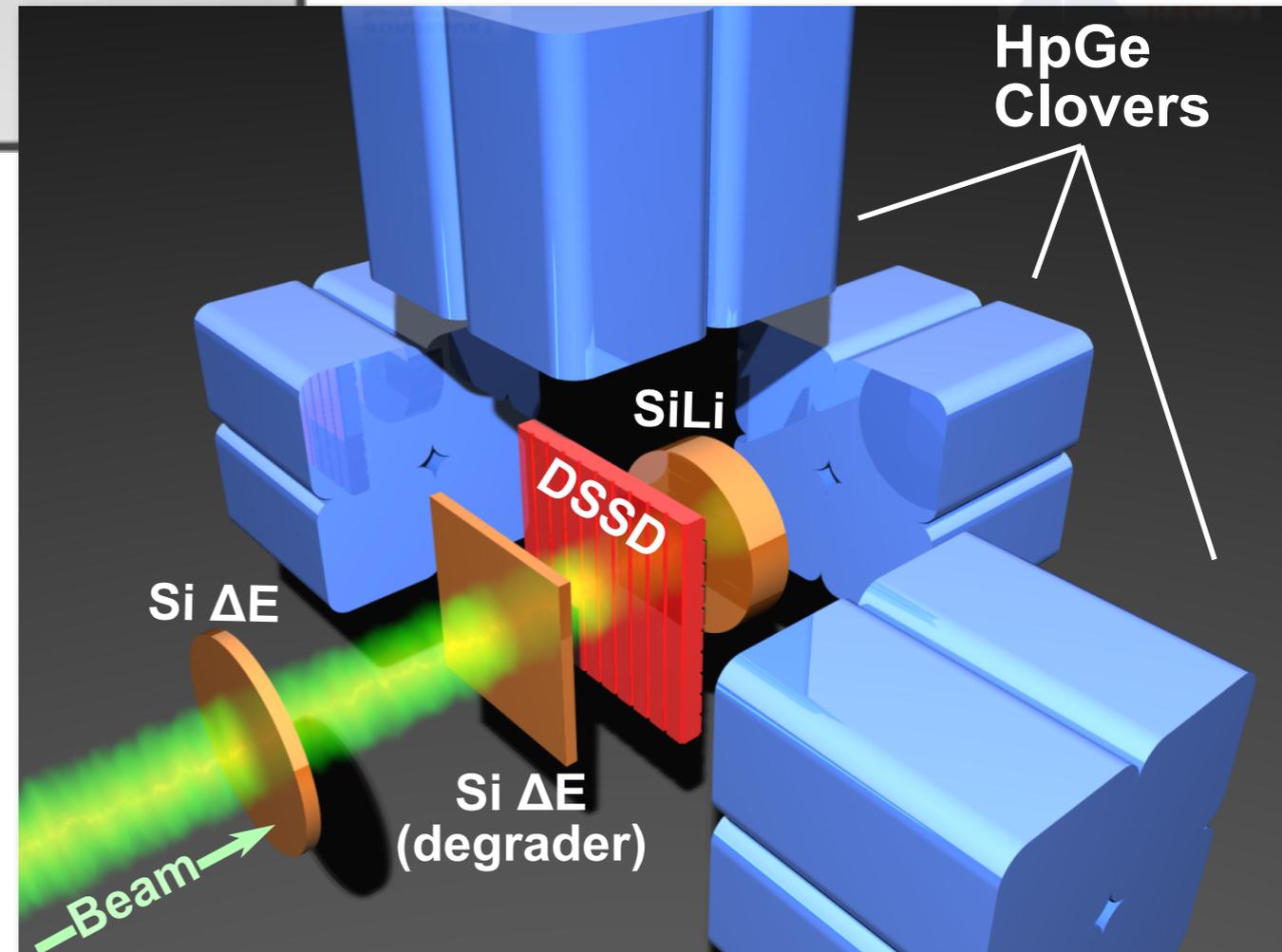
Exotic-beam decay spectroscopy



- Fragmentation of ^{78}Kr primary beam on a $^{\text{nat}}\text{Ni}$ target.
- $E = 70 \text{ MeV/u}$
- Implant-decay experiment using β - p and β - γ event tagging.

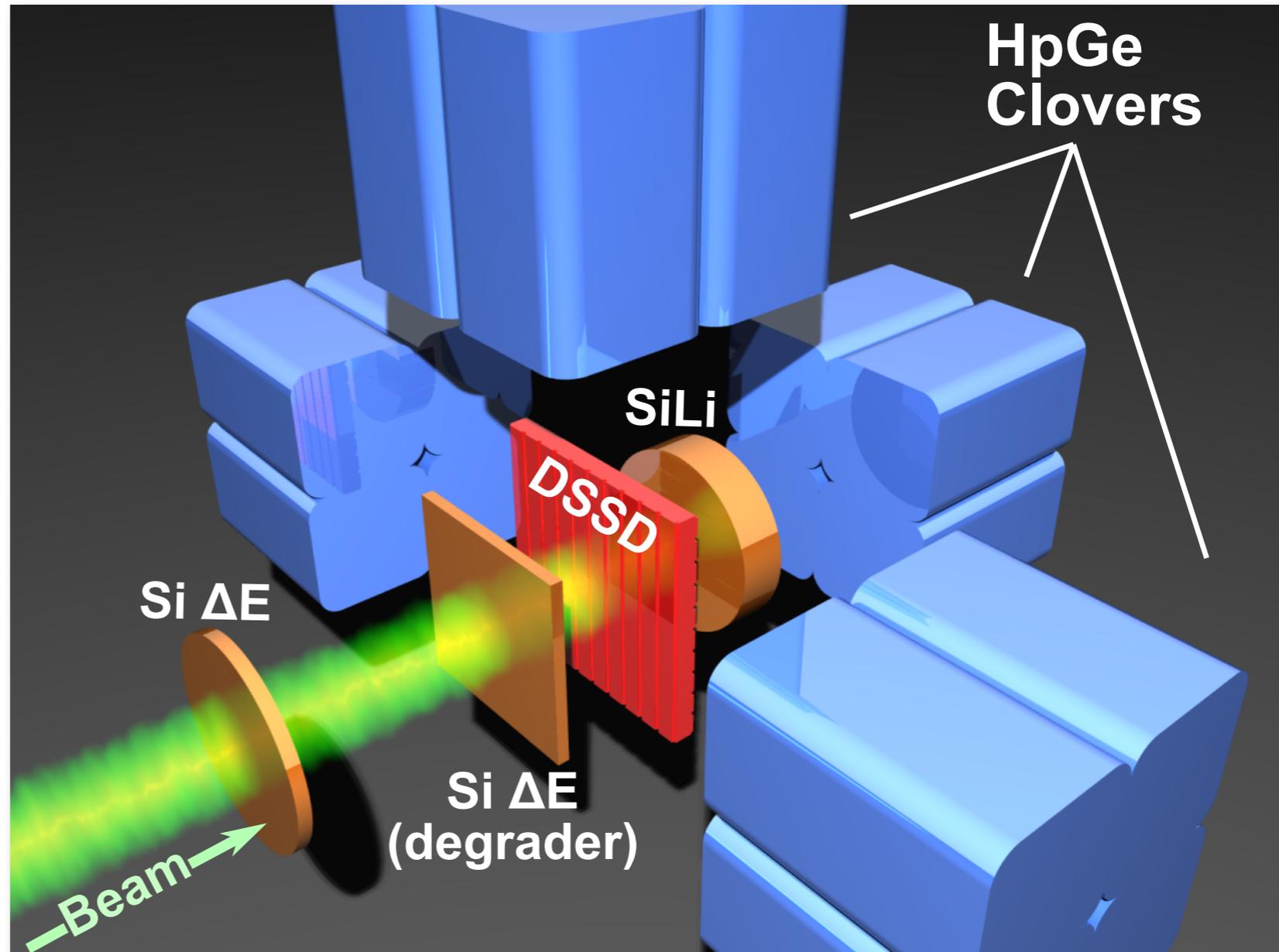


- ToF from RF and MCP's.
- **300- μm Si ΔE detector and 300- μm Si degrader.**
- Heavy ions are implanted into a **16x16 strip DSSD** (3-mm pitch, 300 μm thick).
- γ 's are measured using four high-purity germanium clover detectors (HPGe).



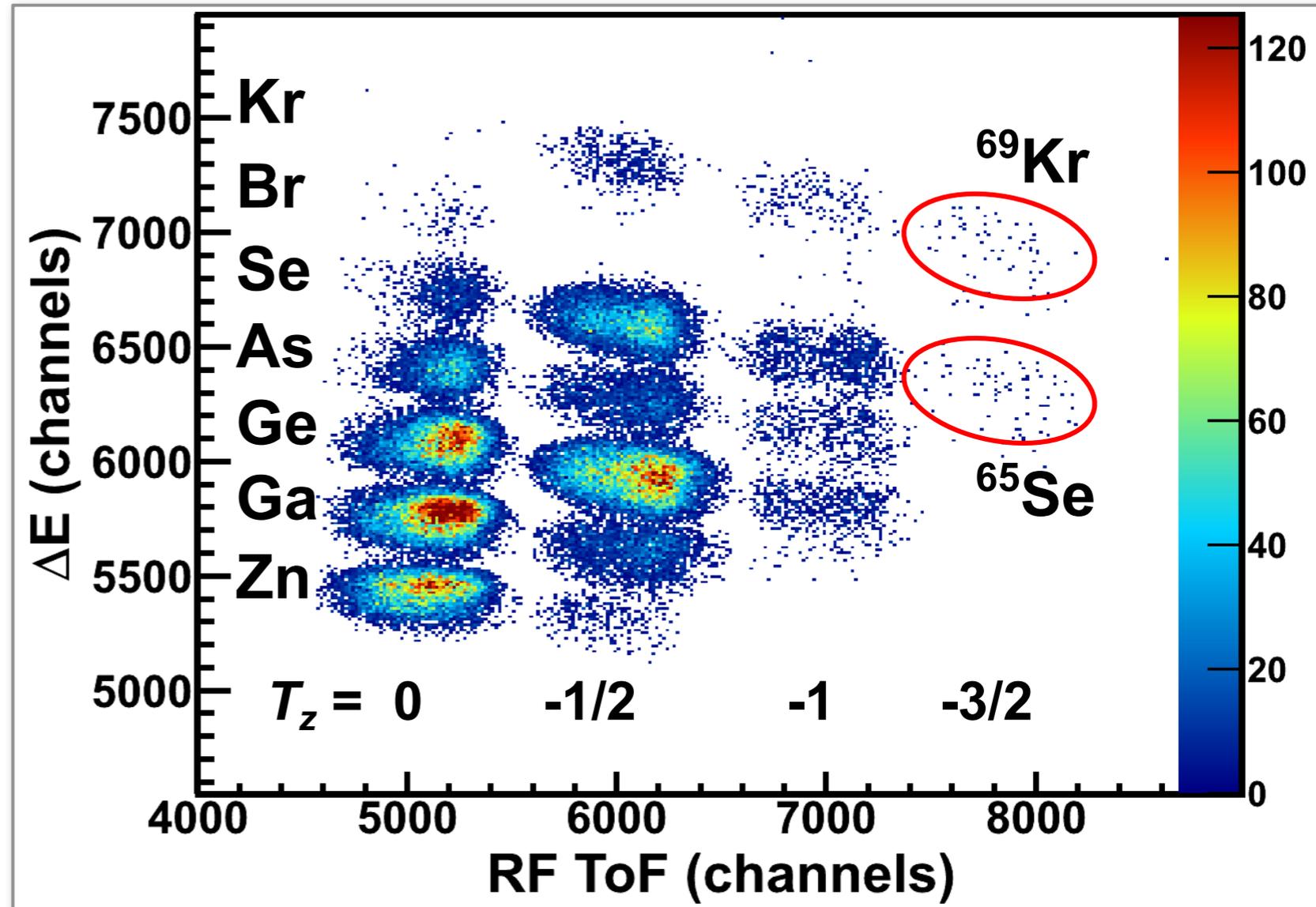
Exotic-beam decay spectroscopy

- PID
 - Energy loss from silicon
 - ToF from RF and MCP
- Energy Degradator
 - Decreases heavy ion energy
 - Optimized to stop nuclei in the middle of the DSSD
- Charged-particle spectroscopy (DSSD)
- VETO (SiLi)
- Gamma spectroscopy
 - 4 HPGe clovers
 - Detect coincident gamma rays



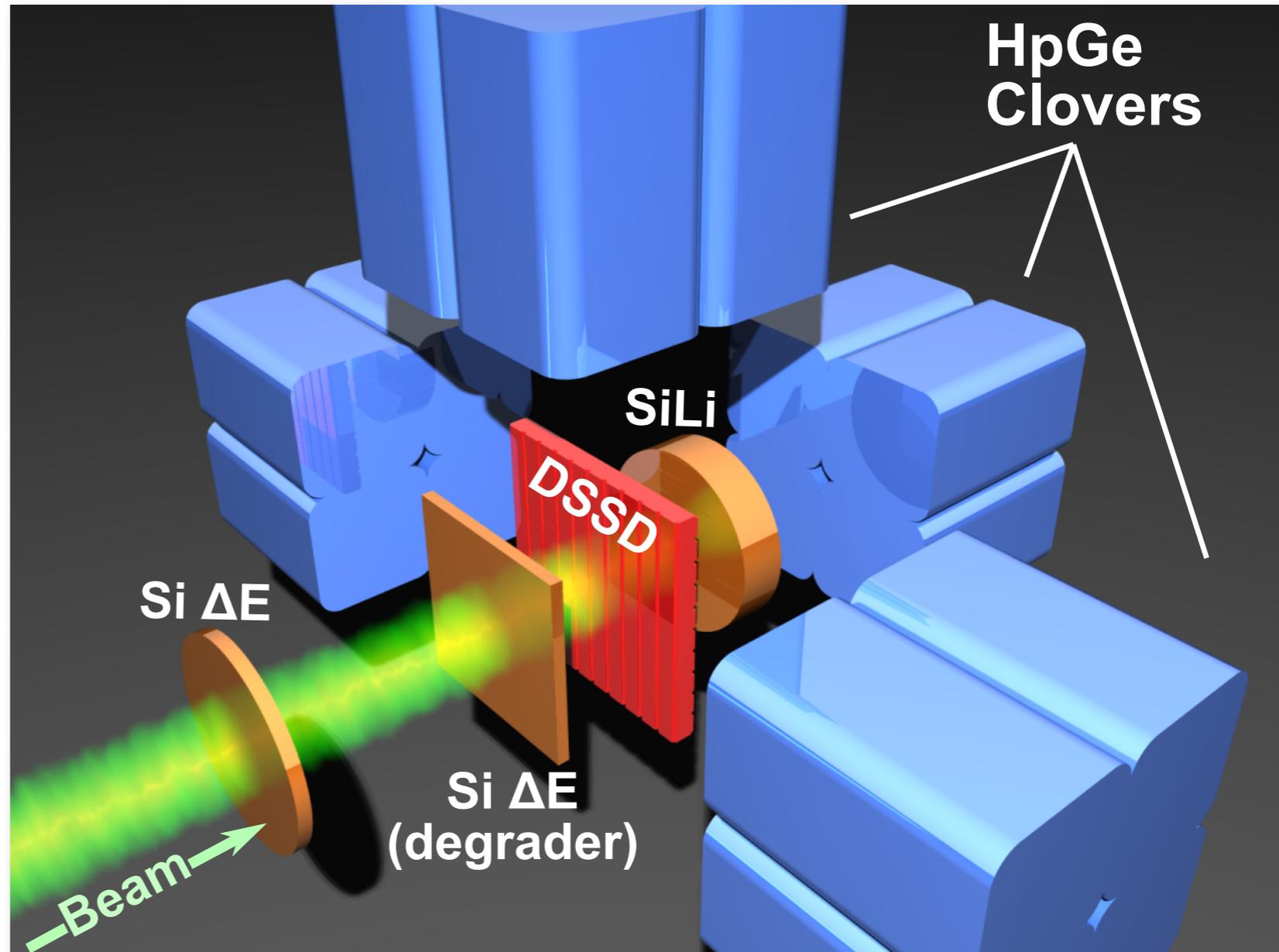
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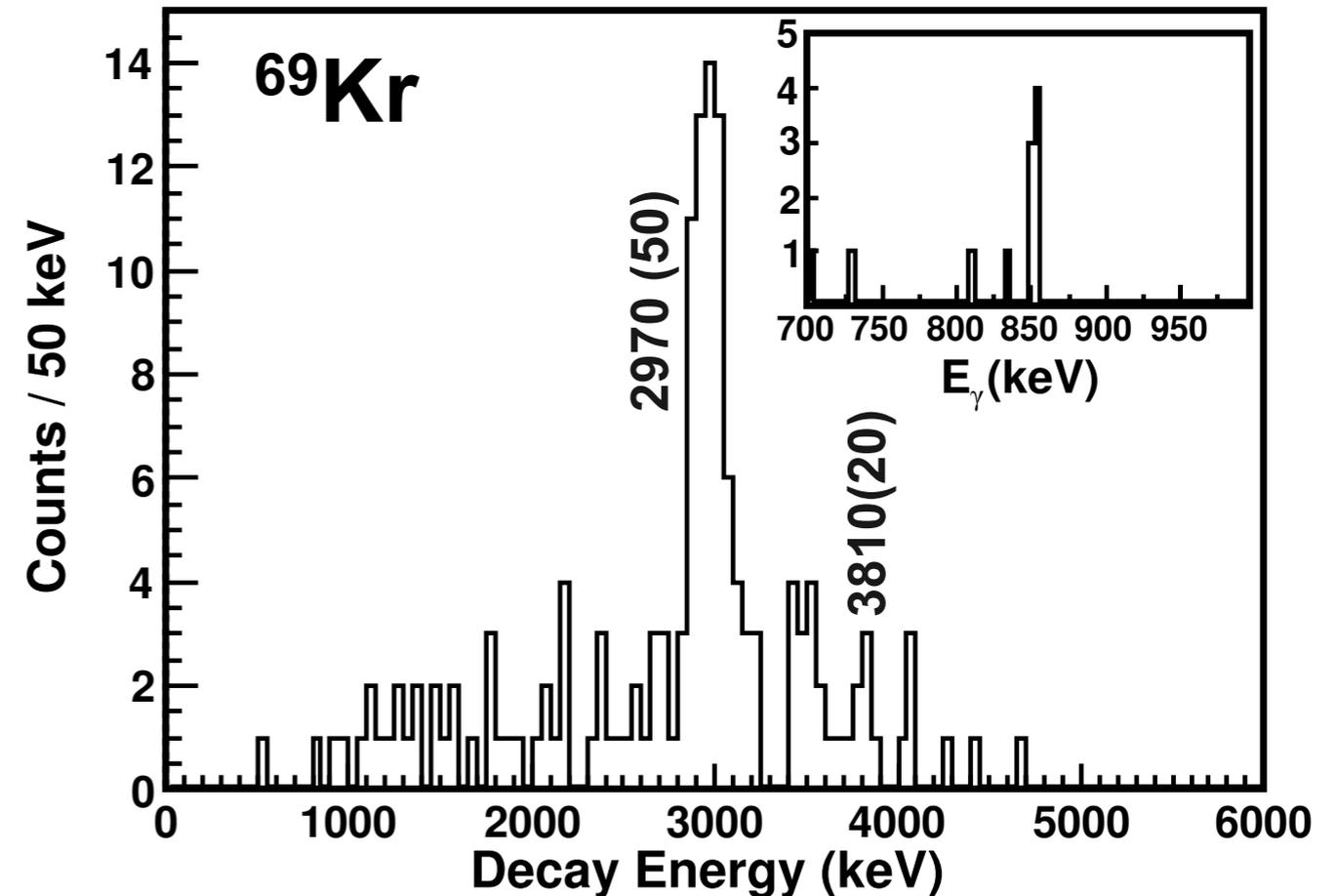
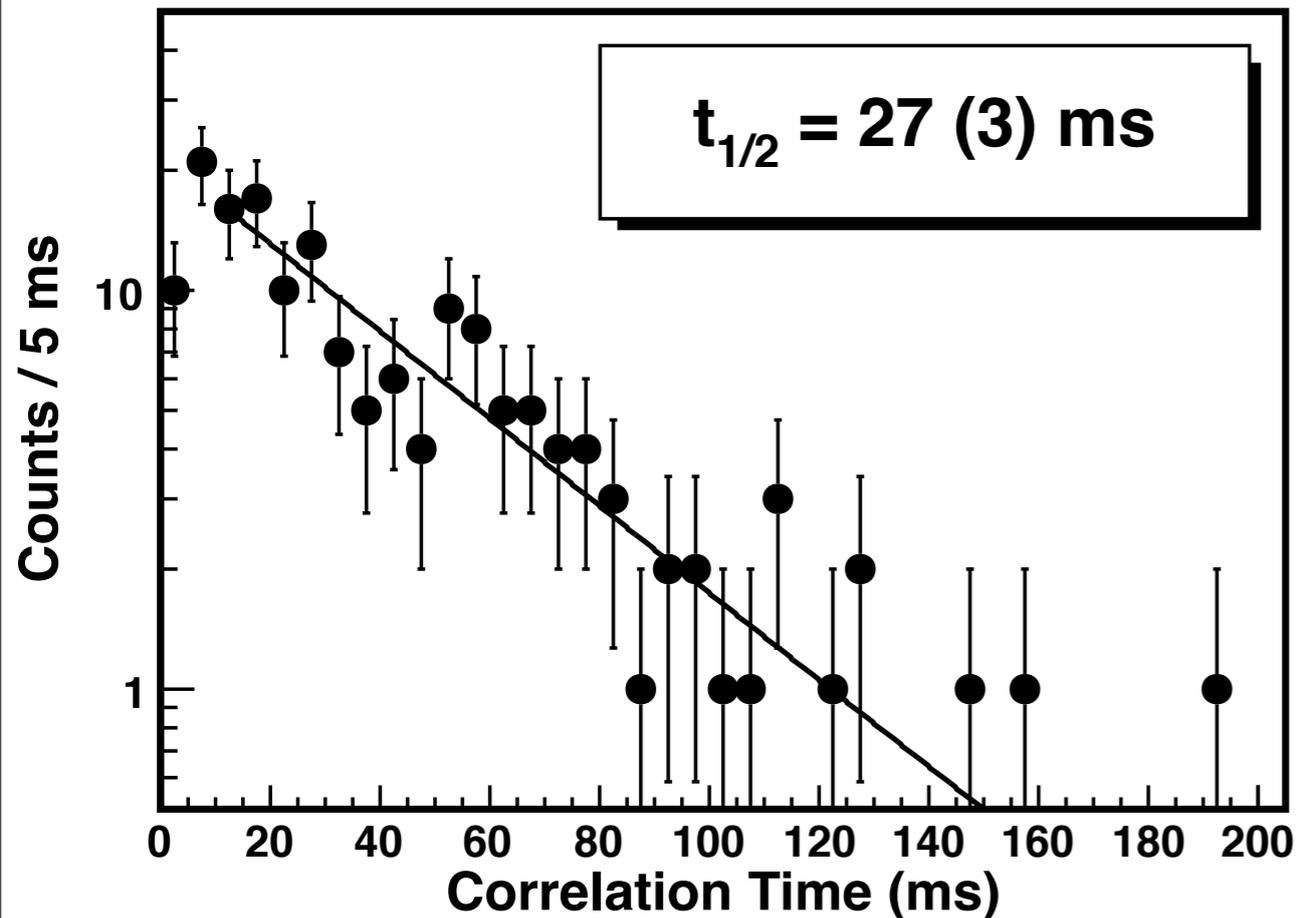


Exotic-beam decay spectroscopy

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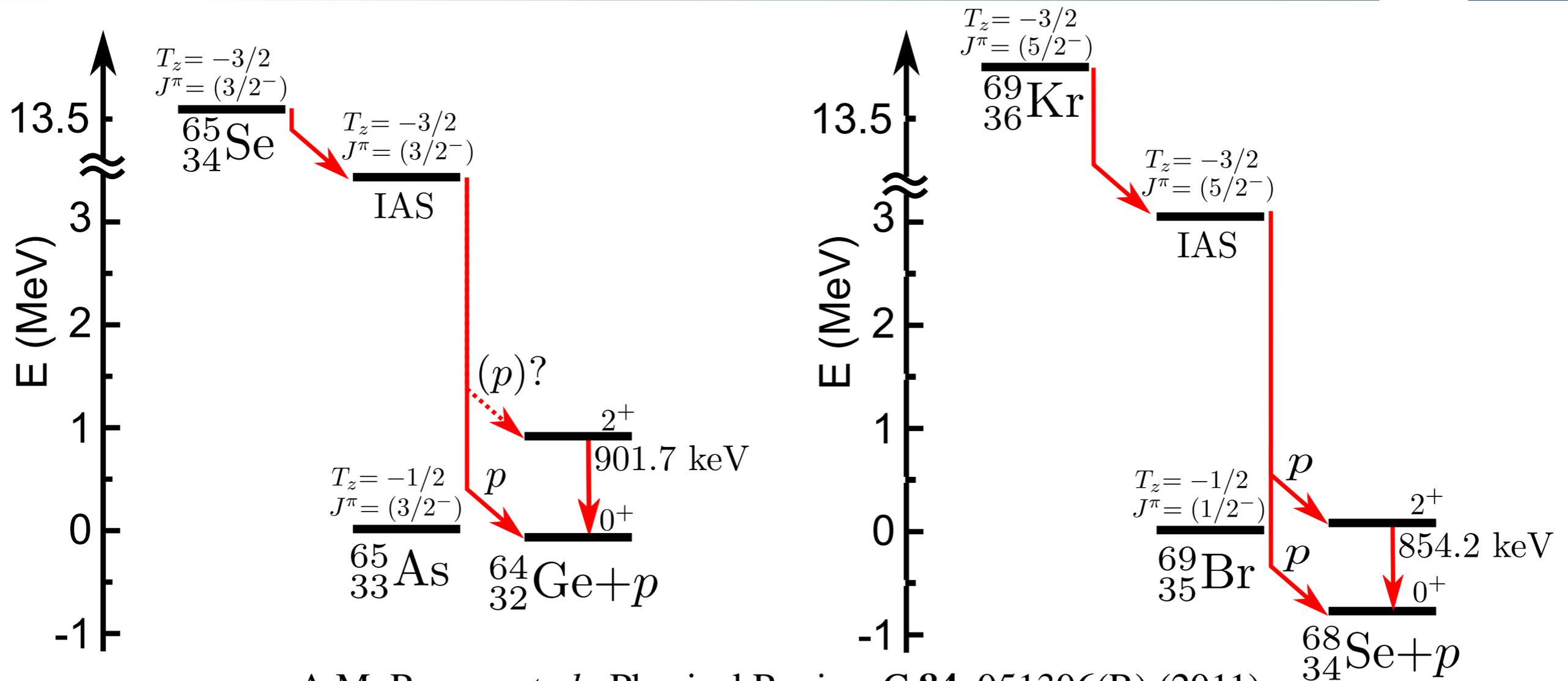


Exotic-beam decay spectroscopy



- **Time** between heavy-ion implantation event and decay event in DSSD allows us to measure the **decay curve**.
- **Charged-particle spectroscopy** in the DSSD allows us to observe proton emission.
- **DSSD pixelation** allows us to spatially correlate the correct heavy ion with its charged-particle decay.

Exotic-beam decay spectroscopy



A.M. Rogers *et al.*, Physical Review C **84**, 051306(R) (2011)

Nucleus	$t_{1/2}$ (ms)	Feeding to IAS (%)	$\log(ft)$	ME (keV)	ΔME_{AME} (keV)
^{65}Se	33 (4)	52 (18)	3.44 (17)	-33358 (141)	+438
^{69}Kr	27 (3)	50 (19)	3.53 (18)	-32128 (96)	-312

- Upper limit on proton-branching ratio to the ^{69}Br ground state of $< 5\%$.

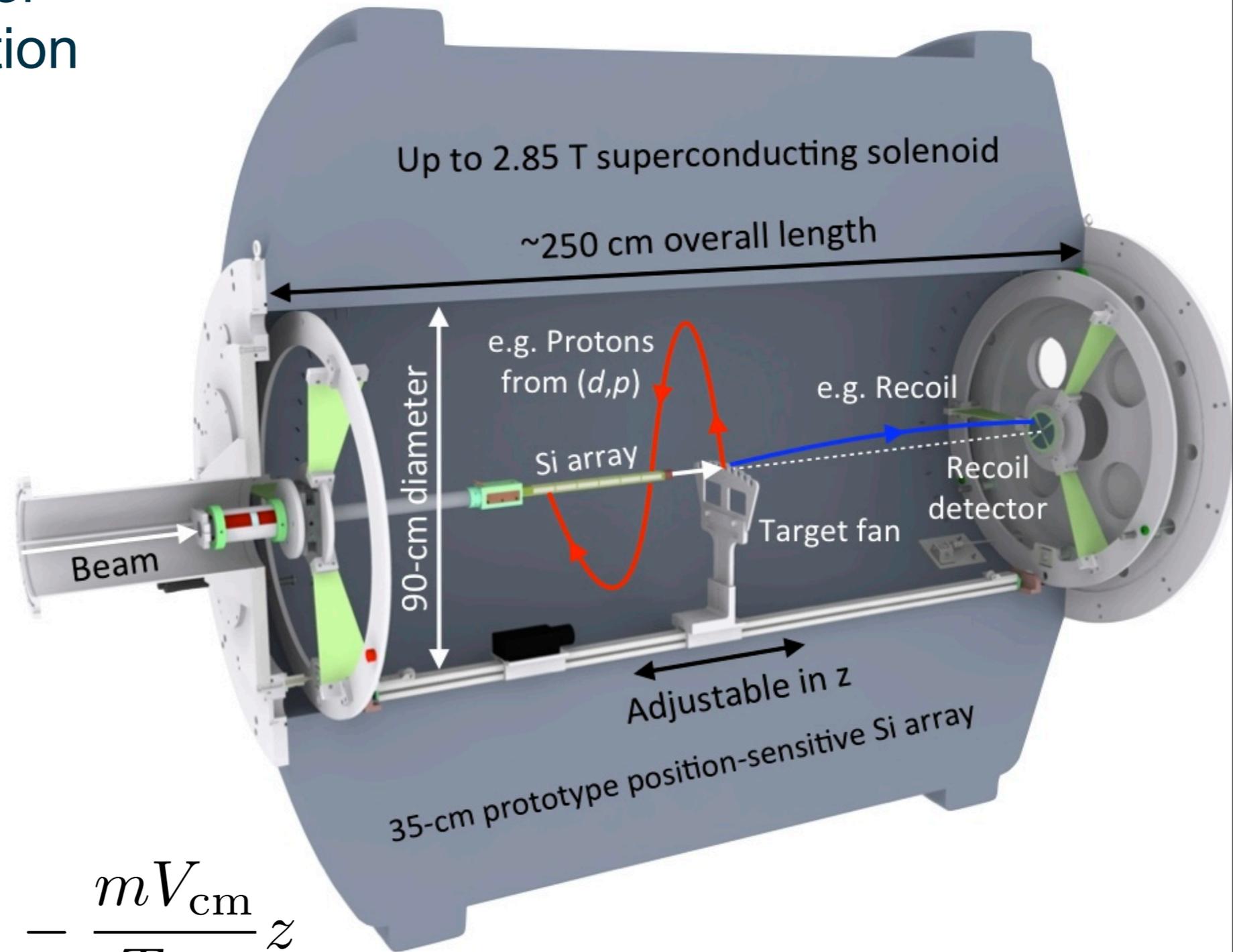
HELICAL Orbit Spectrometer (HELIOS)

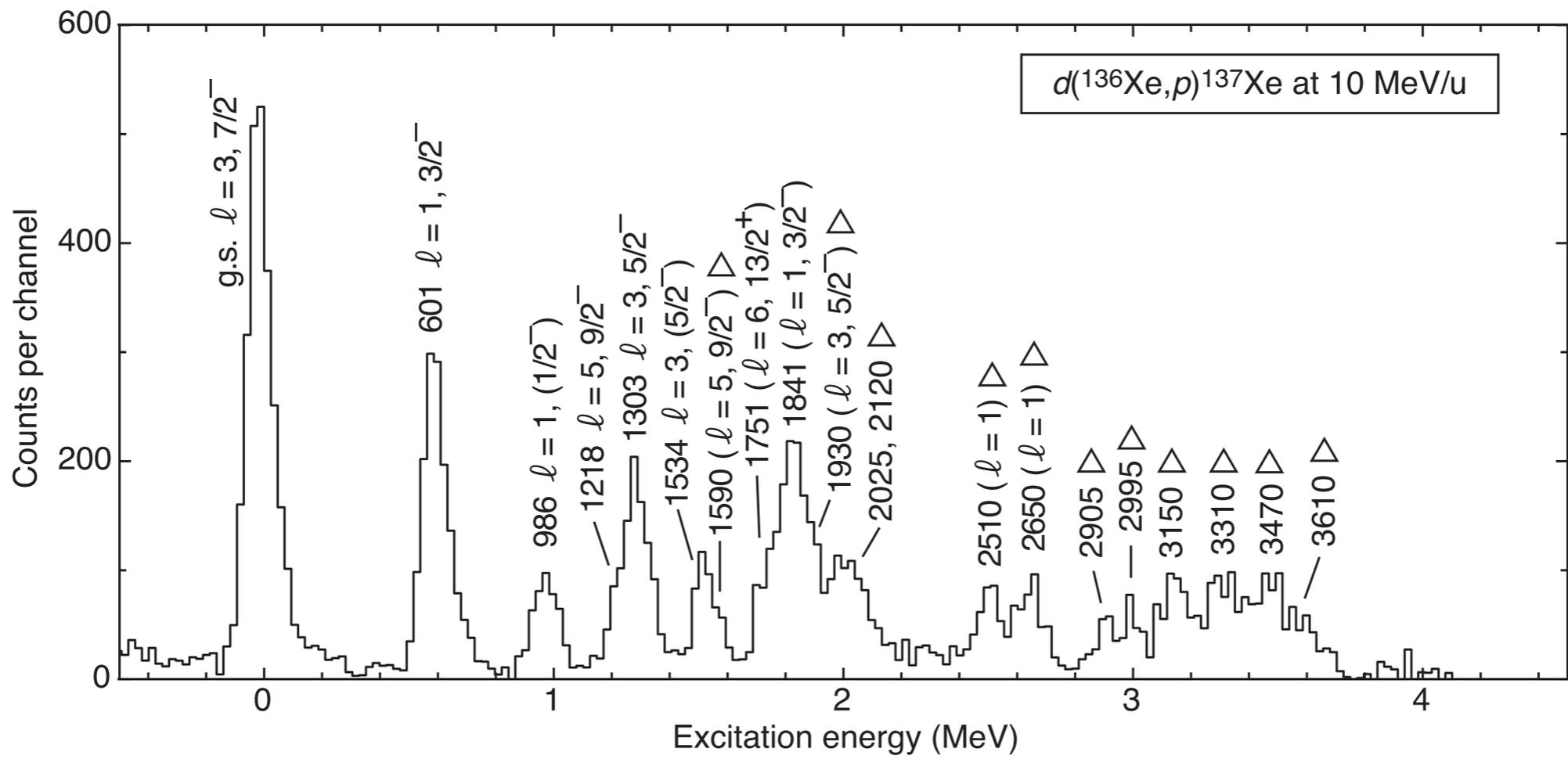
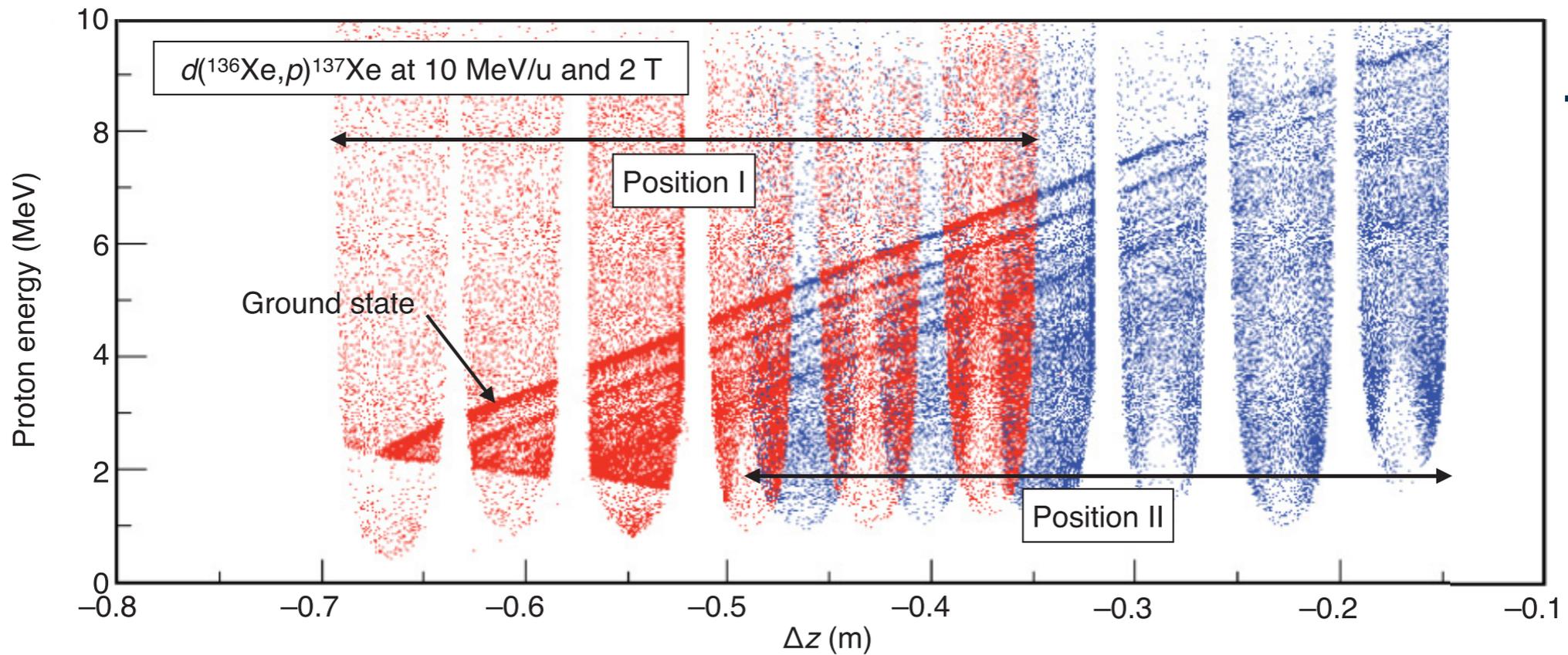
- Novel spectrometer designed for reaction studies in inverse kinematics.
- ATLAS and future CARIBU beams.

$$r = \frac{mv_{\perp}}{qeB}$$

$$T_{\text{cyc}} = \frac{2\pi r}{v_{\perp}} = \frac{2\pi m}{B qe}$$

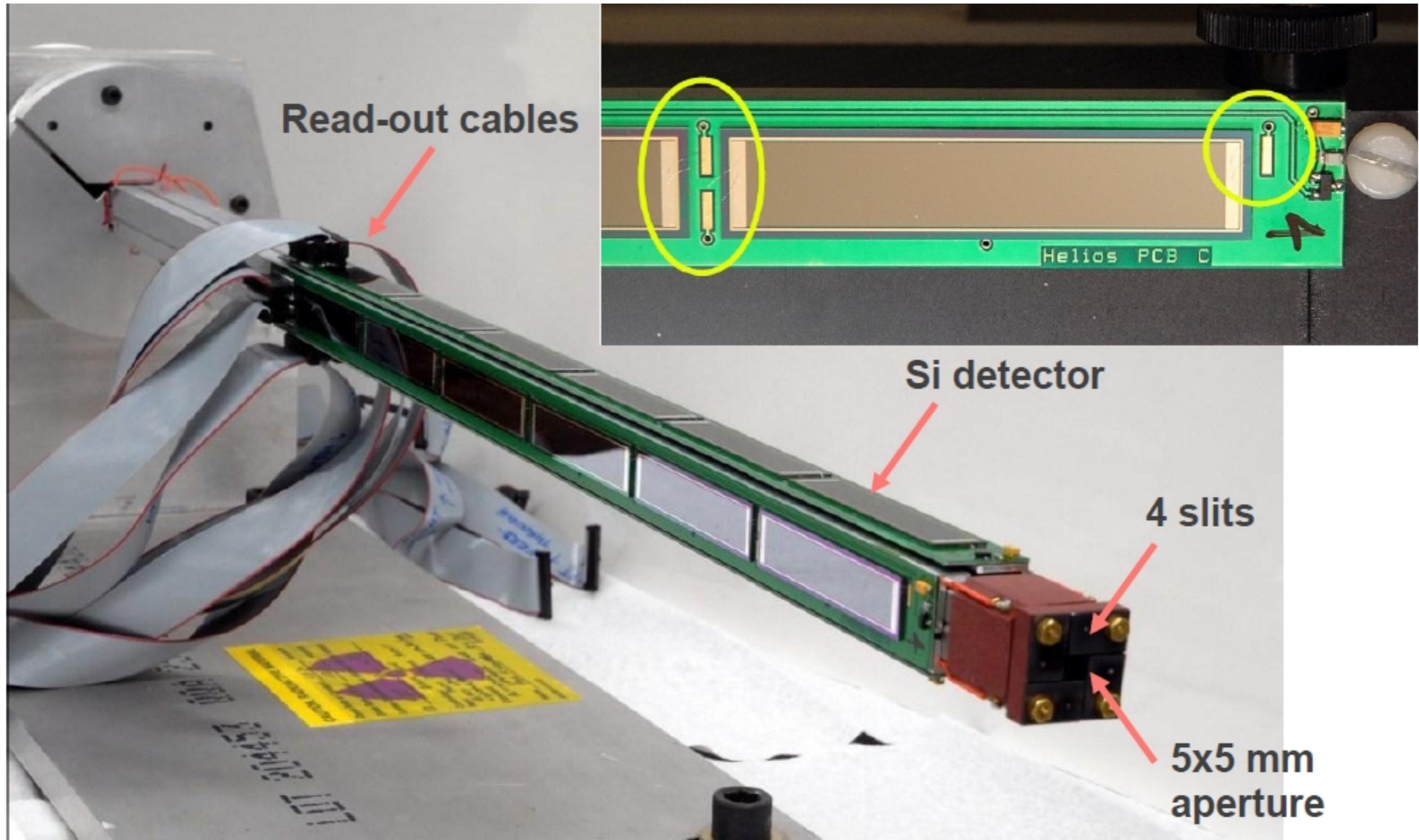
$$E_{\text{cm}} = E_{\text{lab}} + \frac{m}{2} V_{\text{cm}}^2 - \frac{mV_{\text{cm}}}{T_{\text{cyc}}} z$$



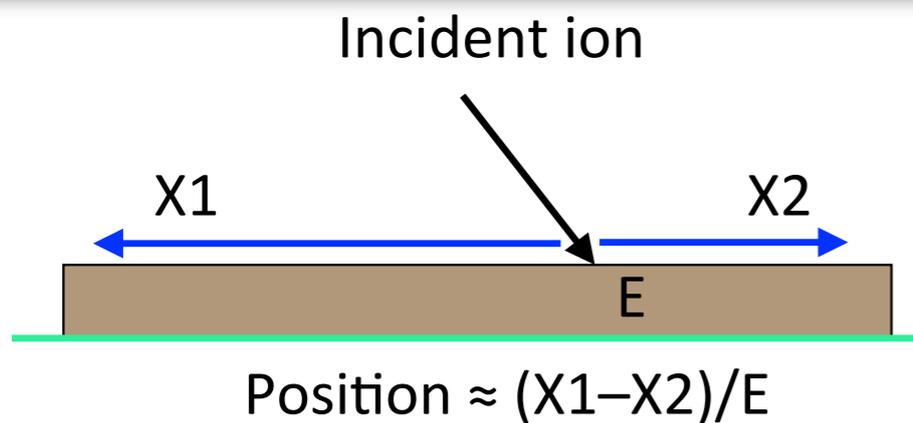


B.P. Kay *et al.*

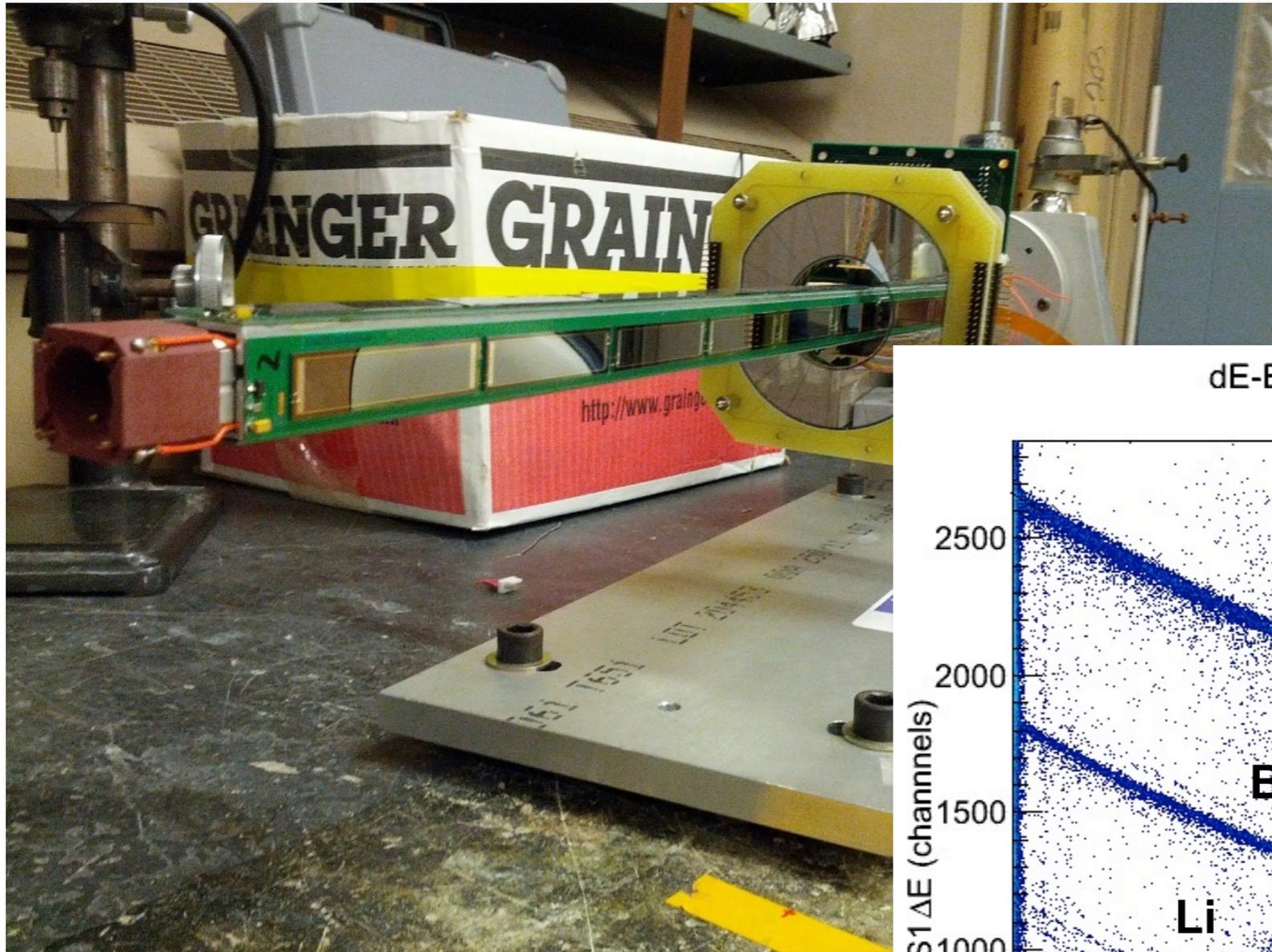
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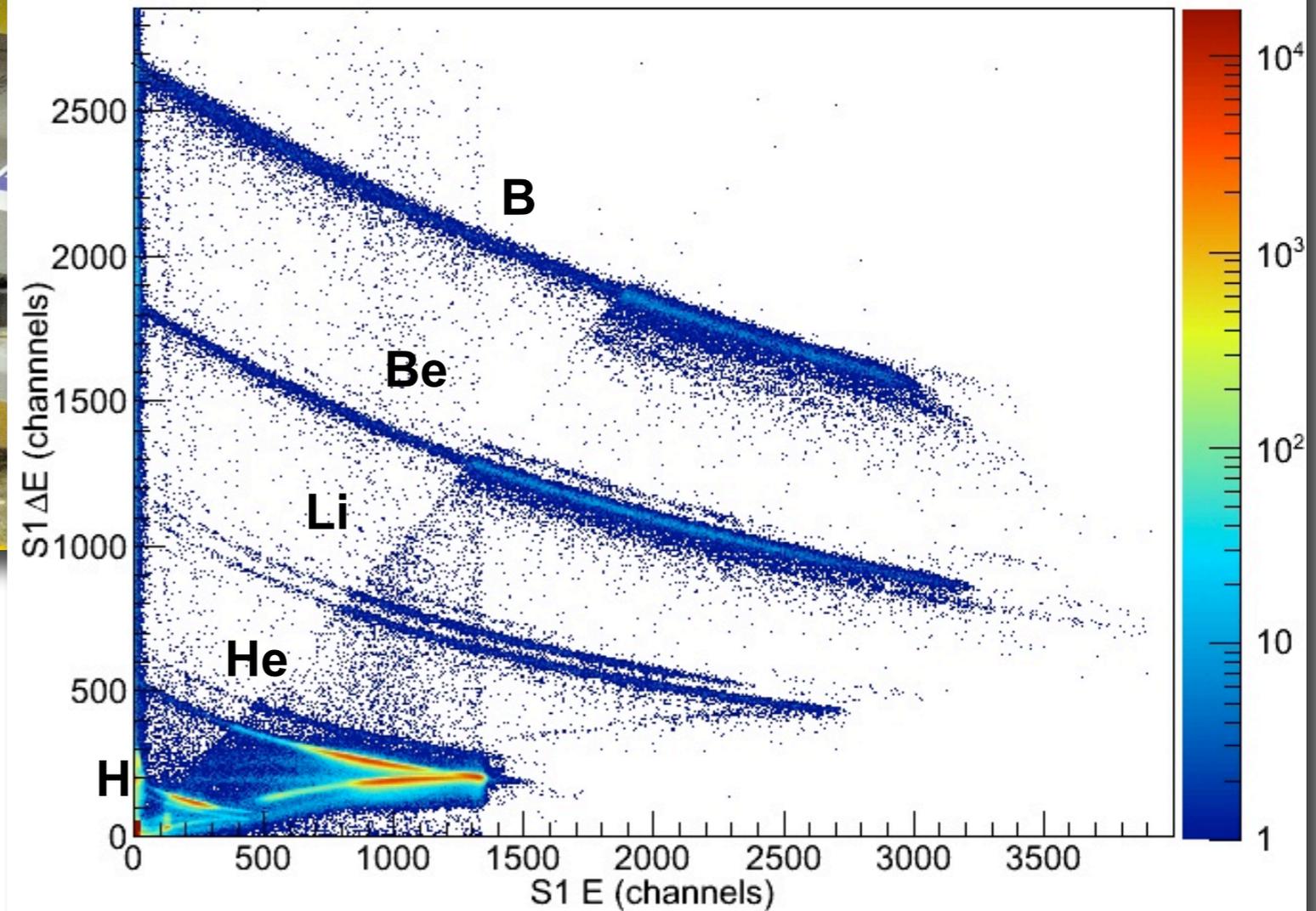
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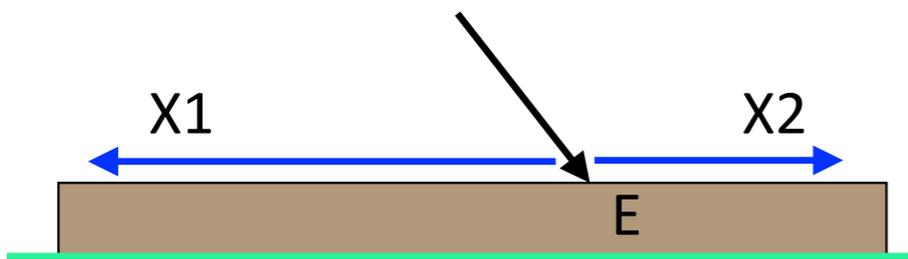
HELICAL Orbit Spectrometer (HELIOS)



dE-E Back/Back with Front-Back < 25 all



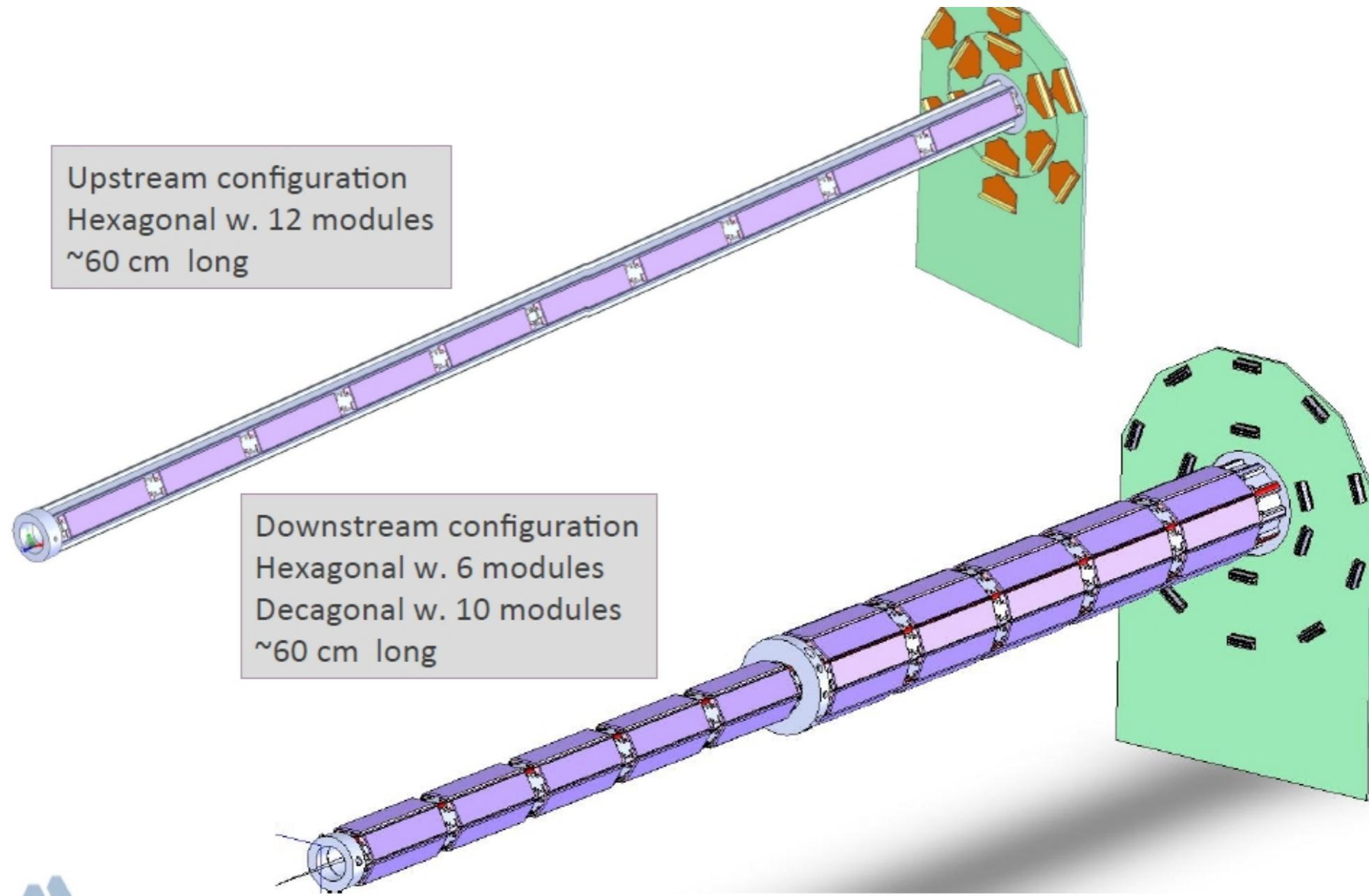
Incident ion



$$\text{Position} \approx (X1 - X2) / E$$

HELICAL Orbit Spectrometer (HELIOS)

Mechanical Design of NEW PSD Array (Heimsath)



Fast-counting ionization chamber

- Entrance window (<7" diameter)
- Kapton window (25um thick)
 - Tested to 600 Torr
 - Ran between 50 - 300 Torr
 - Isobutane (C_4H_{10}) and CF_4 used
- Alternating cat - anode grids
 - gold plated W wires (20 um)
 - Spaced 2 cm apart
 - Perpendicular to beam direction
 - 1% loss for each grid
- Similar to chamber at ANASEN (ORNL, RIKEN...)
- Presently used with analog electronics



Catherine Deibel
Jianping Lai

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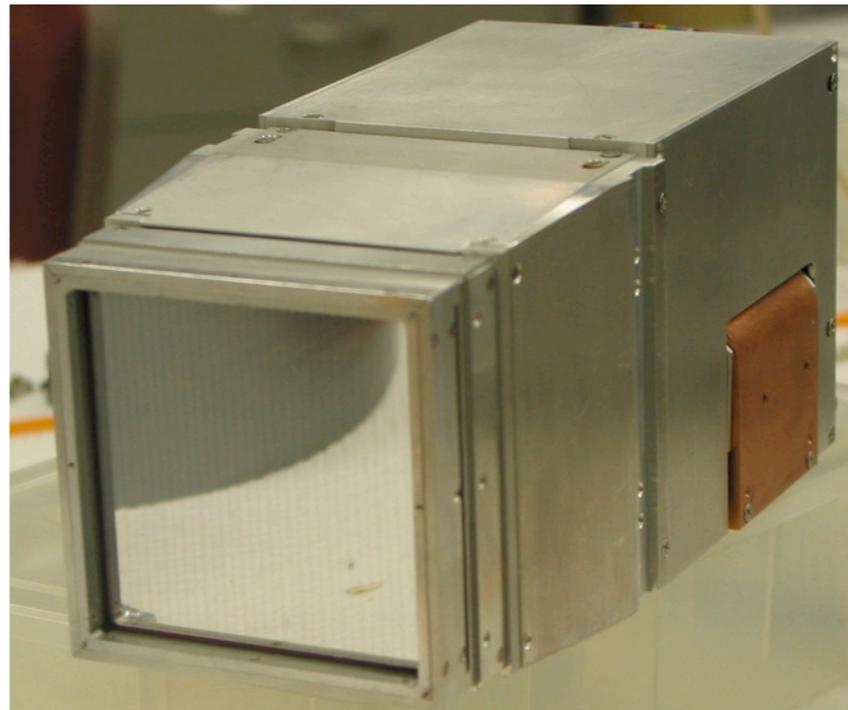
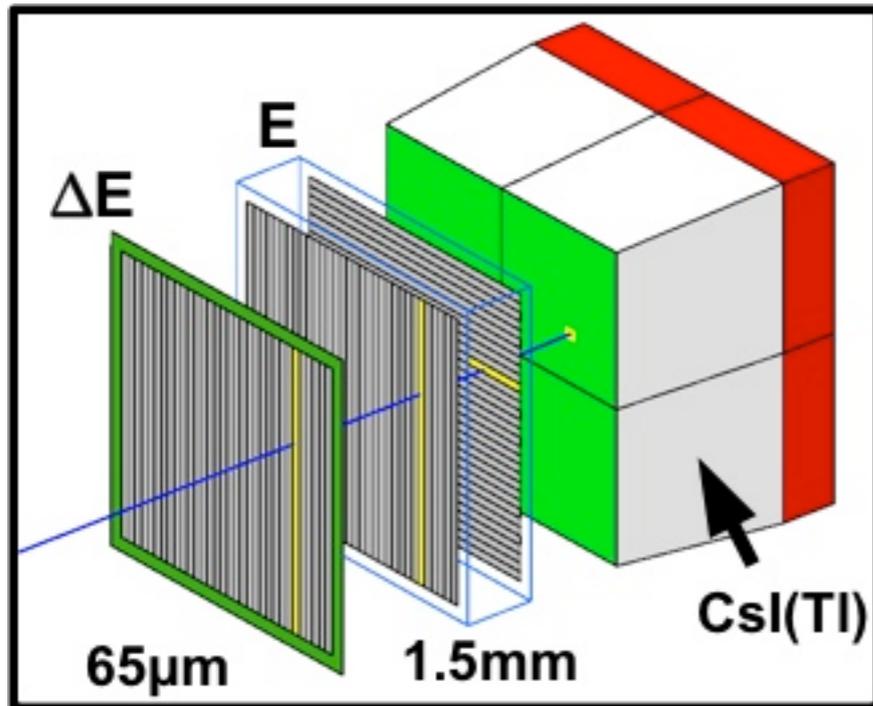


Catherine Deibel
Jianping Lai

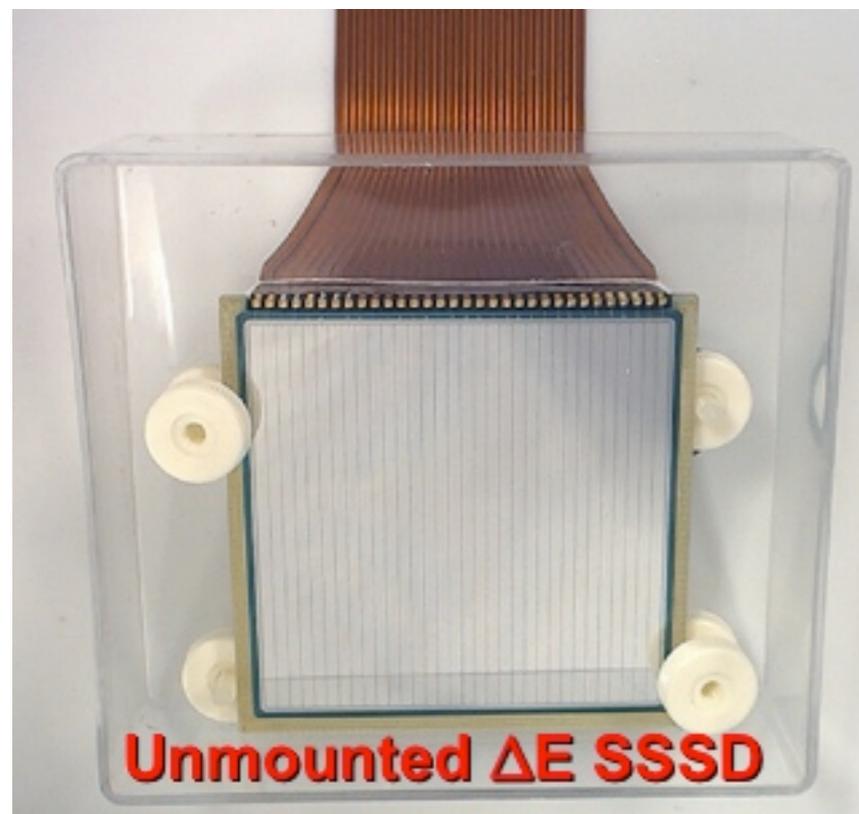
High Resolution Array (HiRA)

- Modular array of 20 ΔE - E telescopes
- 65- μm 32-strip SSSD
- 1.5-mm 32x32-strip DSSD
- Four 4-cm thick CsI(Tl) crystals with photodiode readout

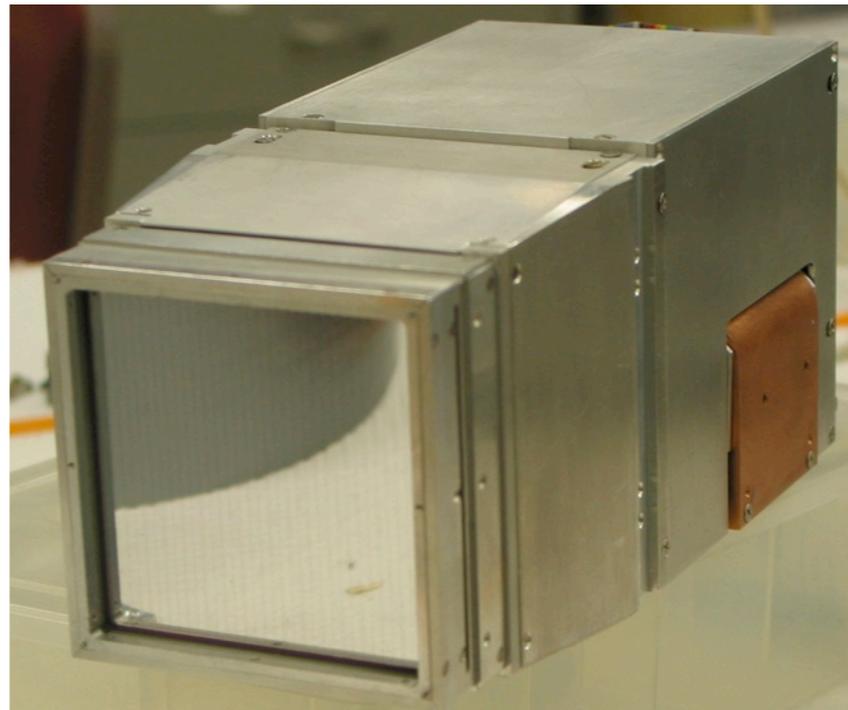
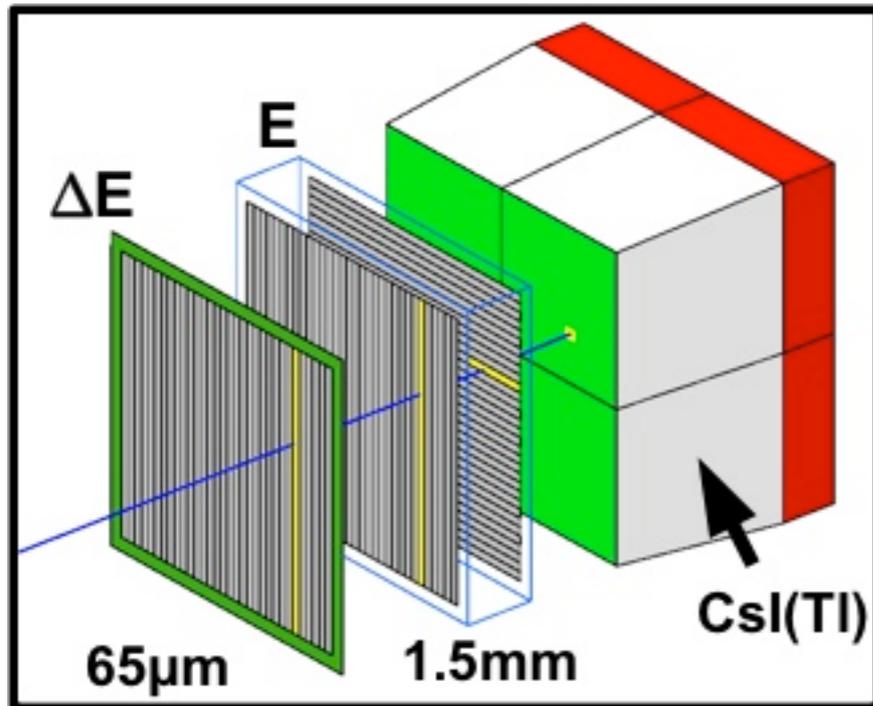
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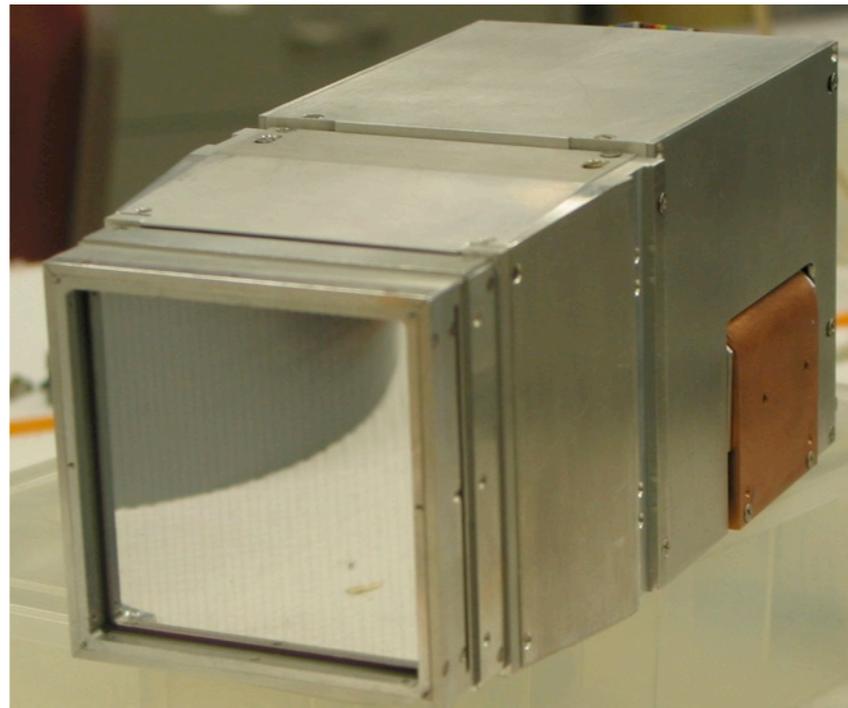
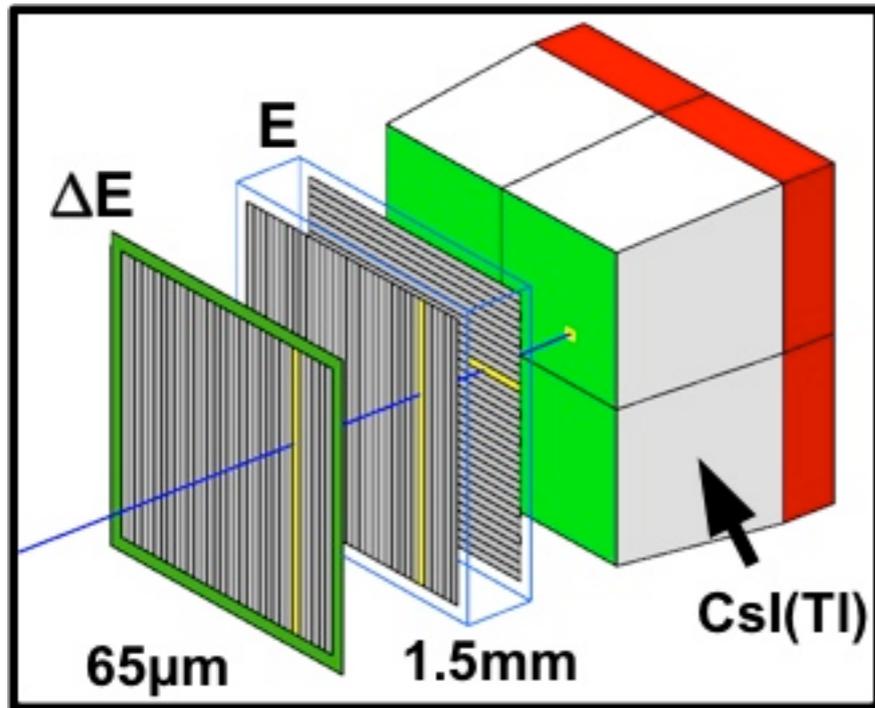


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G.L. Engel *et al.* NIM A 573(3) 2007

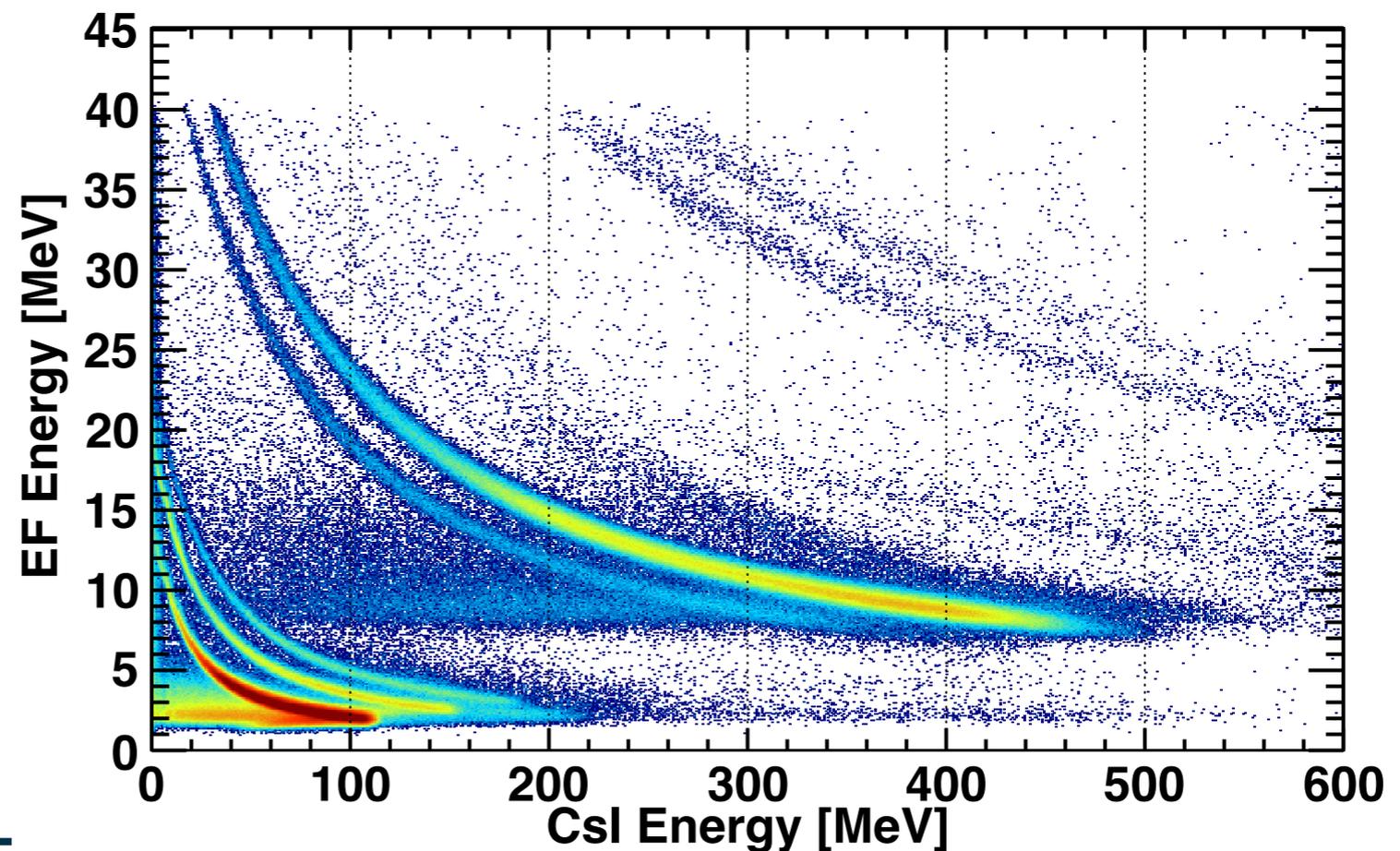
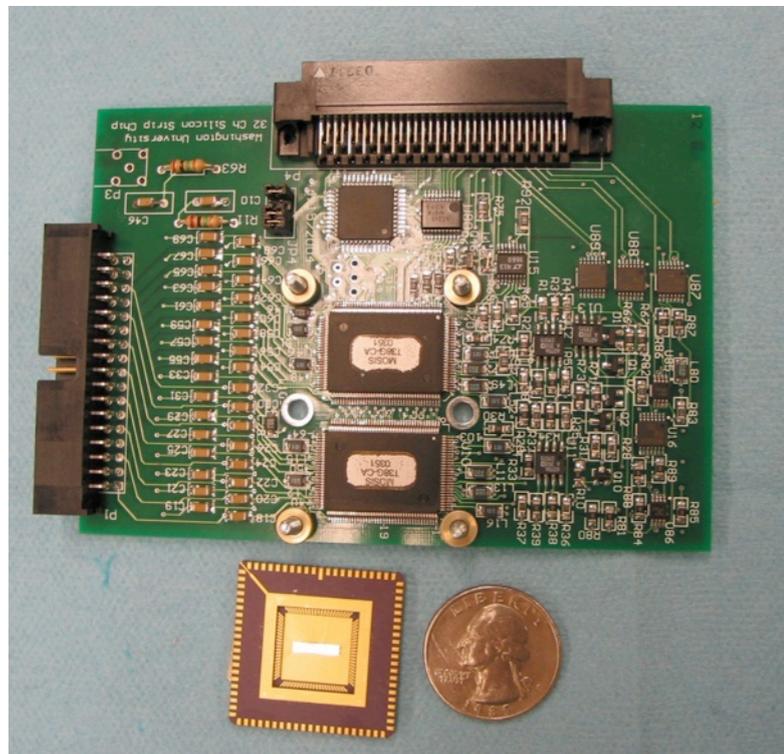


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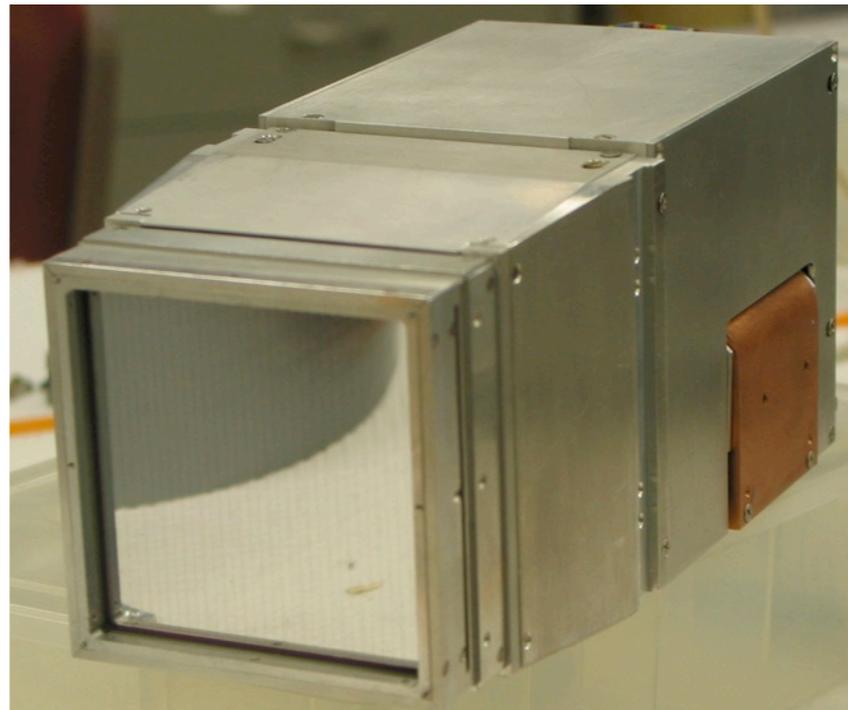
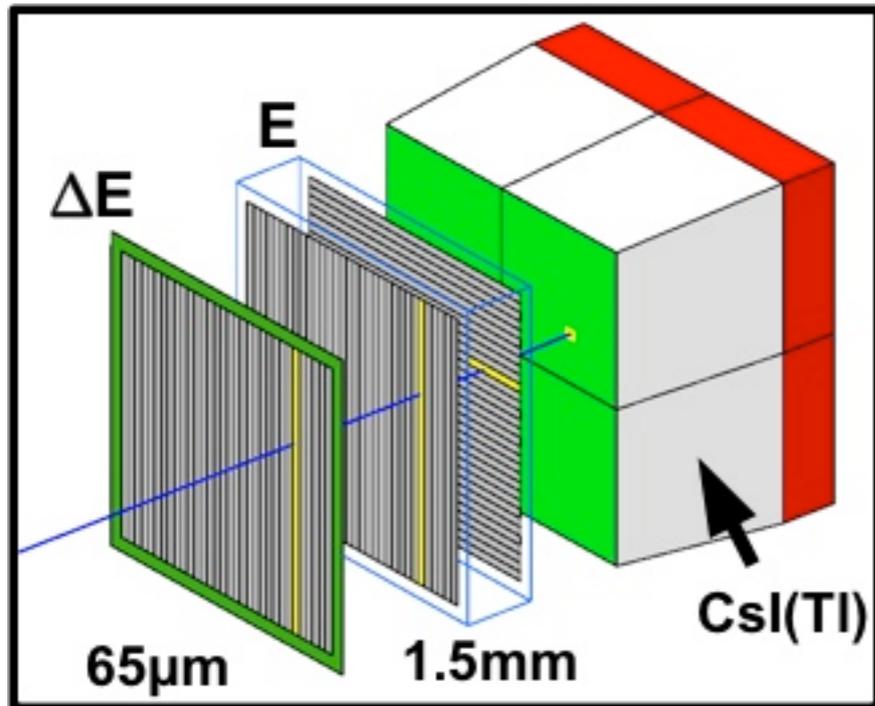


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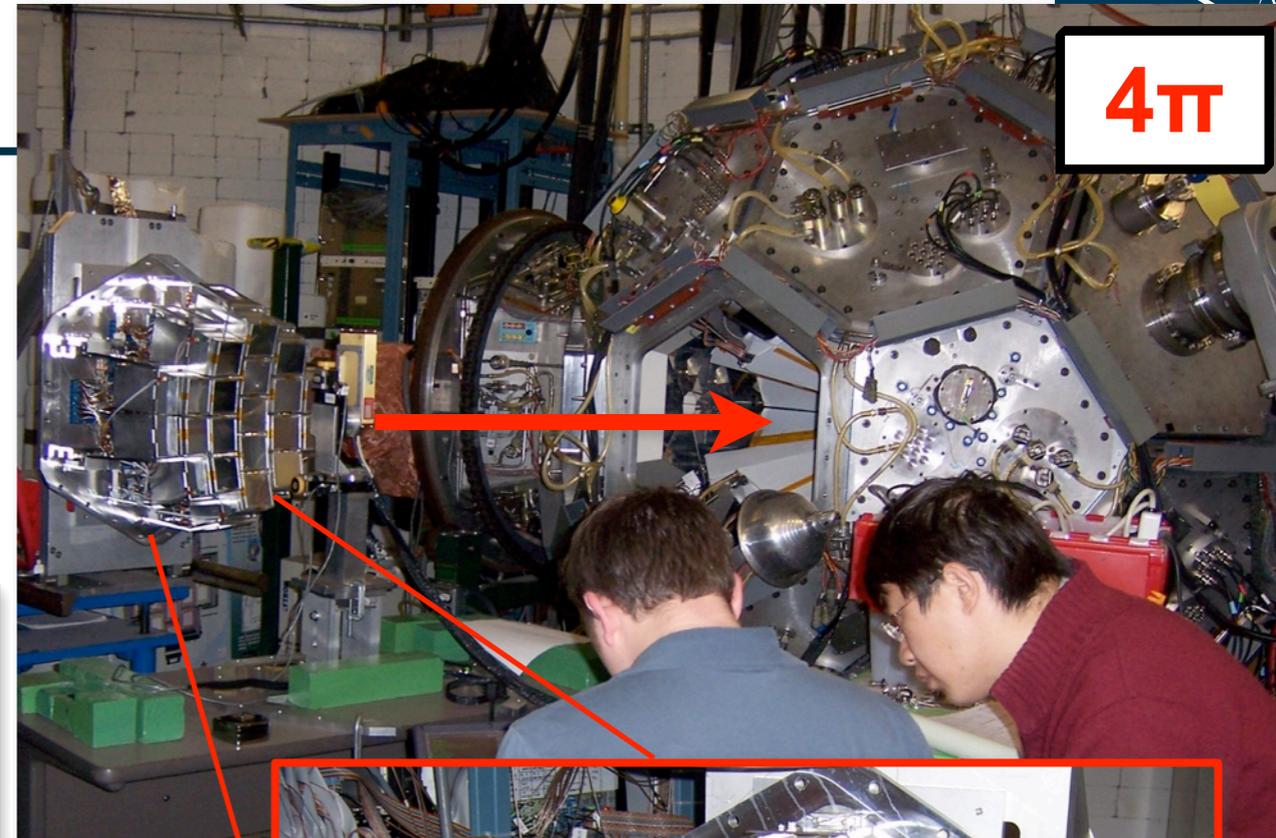
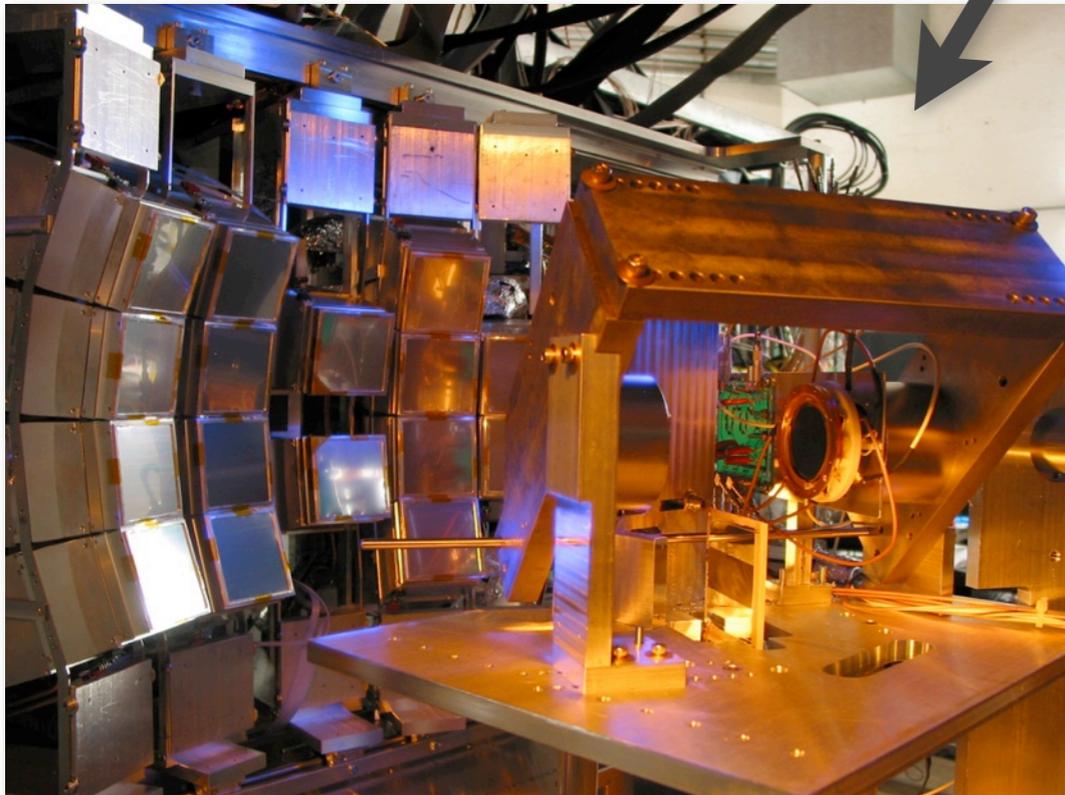


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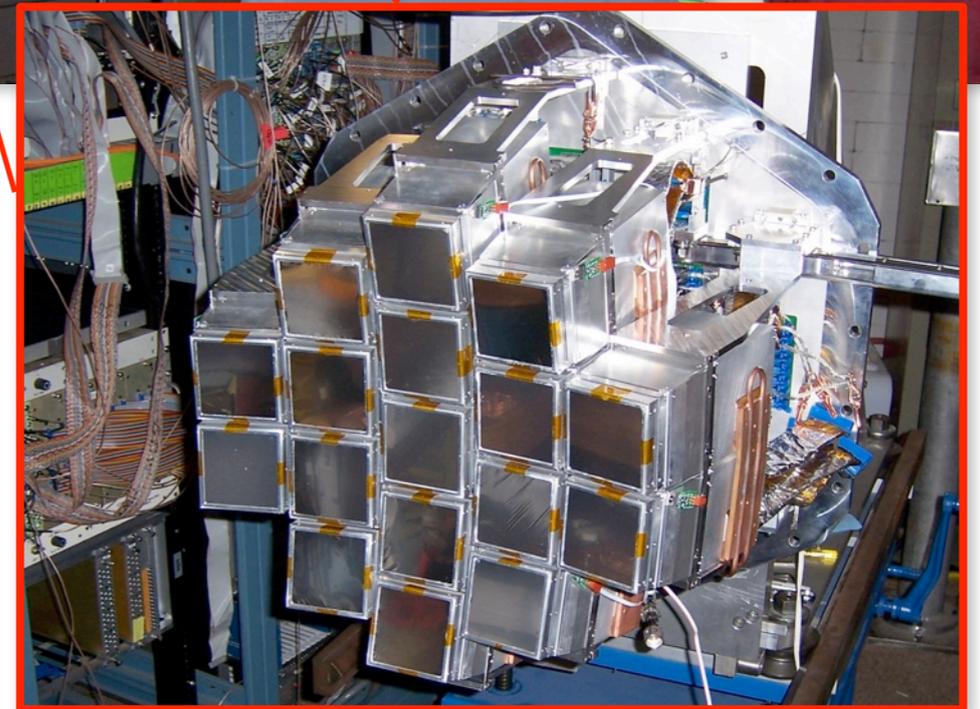


Study of one-proton knockout on ${}^9\text{C}$

${}^{46}\text{Ar}(p,d)$ and ${}^{34}\text{Ar}(p,d)$ neutron transfer reactions

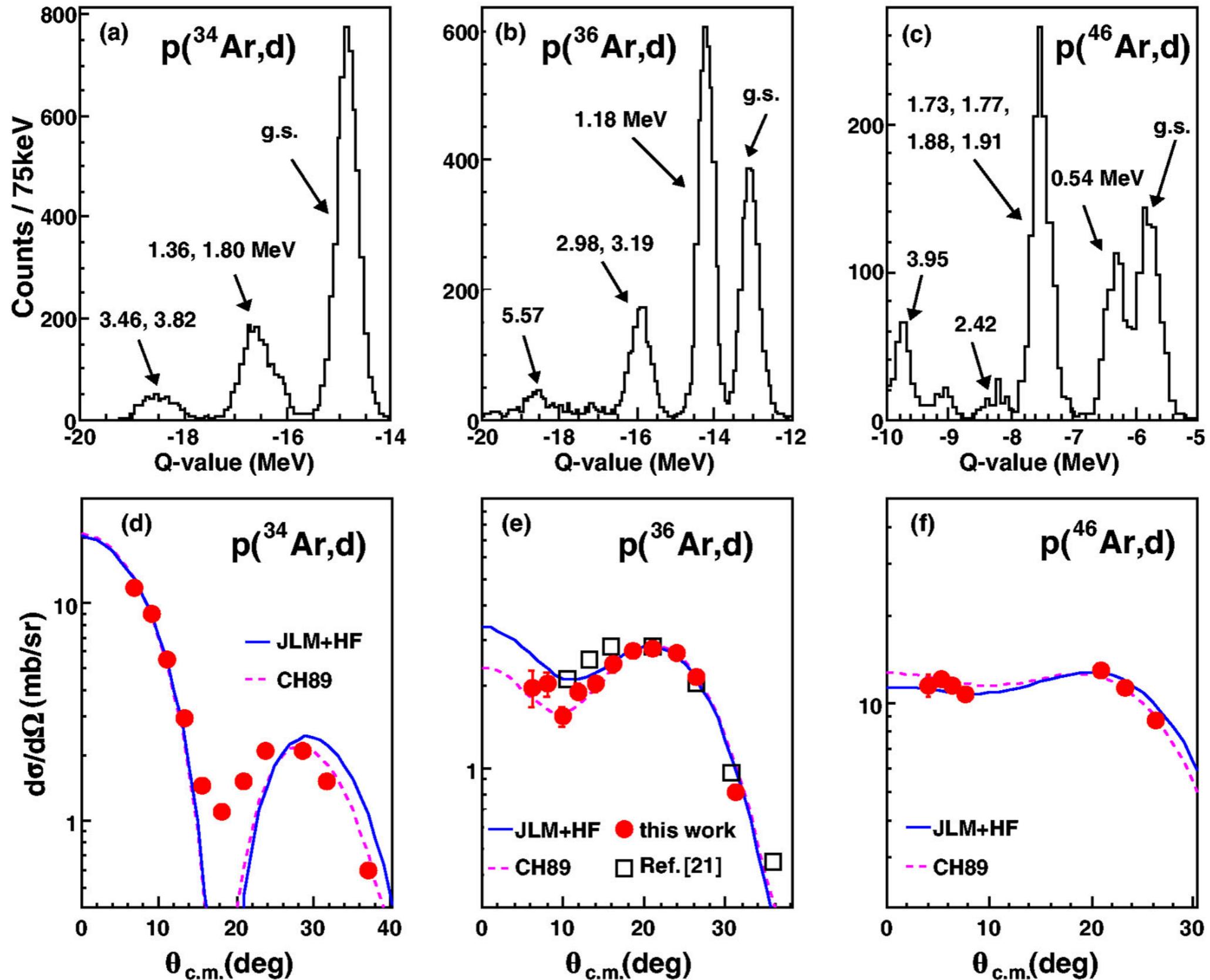


4π



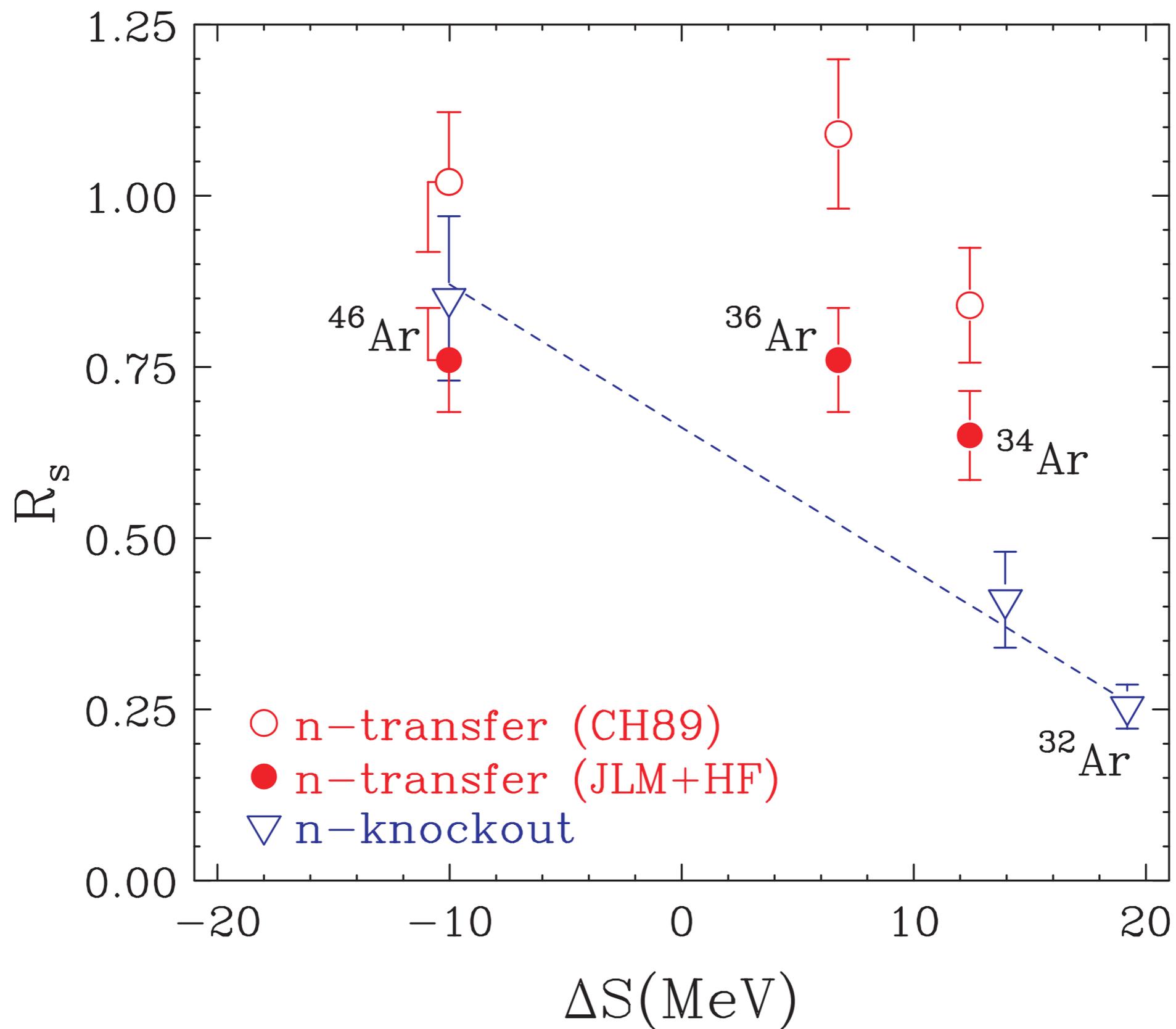
Nuclear EOS via two-particle correlation functions

HiRA exotic-beam transfer reactions



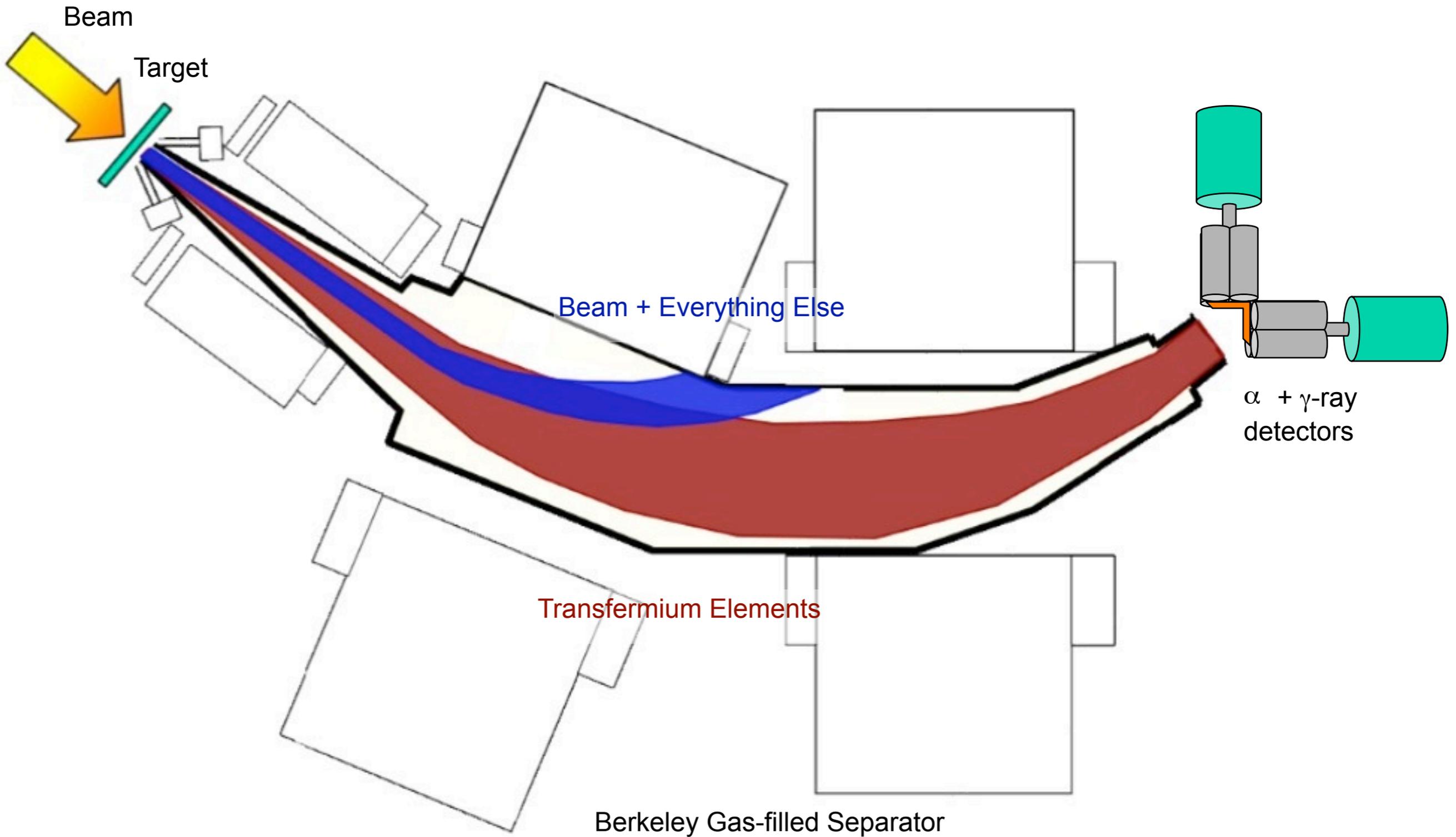
J. Lee et al.

HiRA exotic-beam transfer reactions

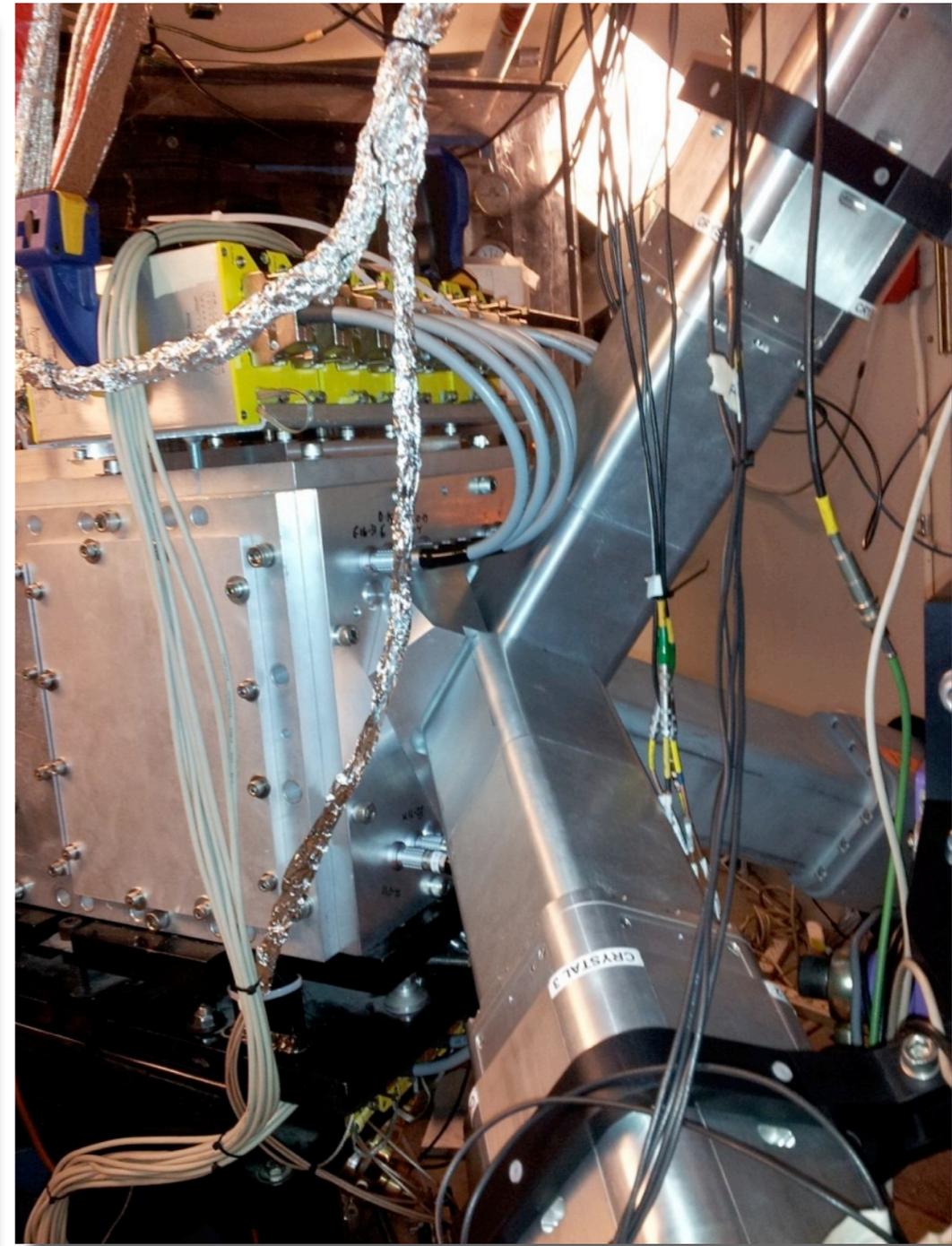
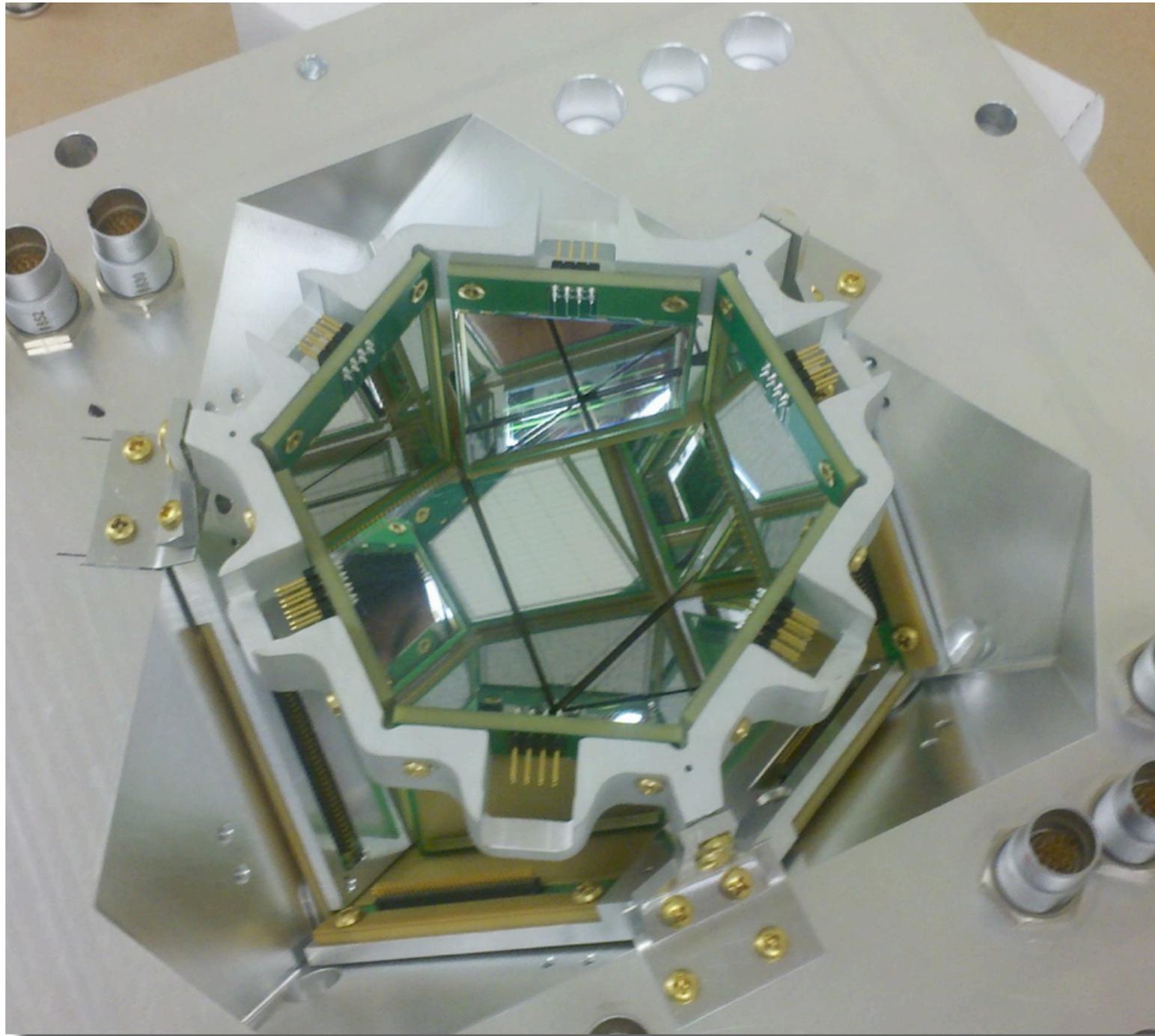


J. Lee *et al.*

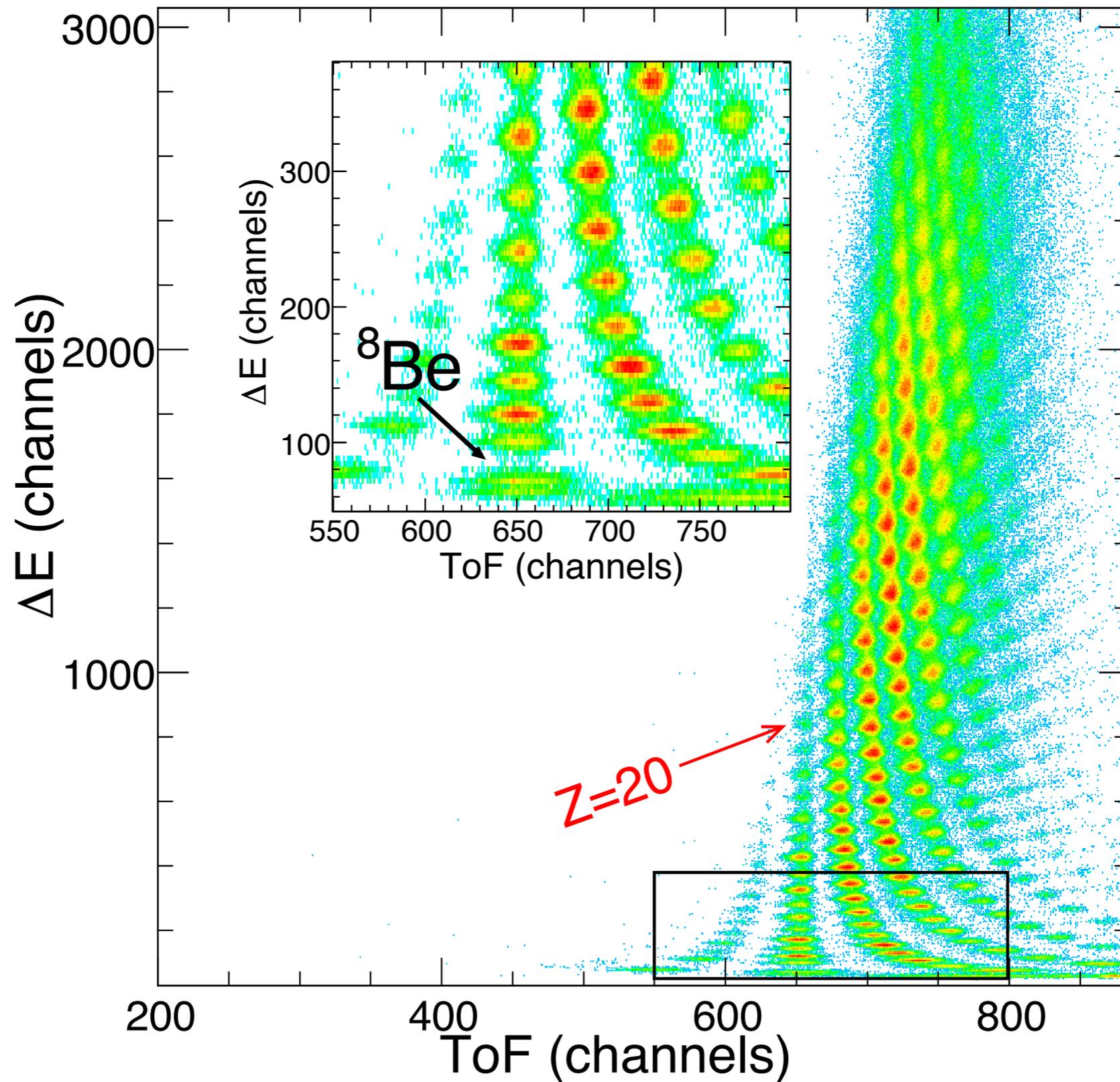
The BGS (J. Gates)



The BGS Si cube



Fragmentation and isotope discovery



MoNA (Thanks to C.R. Hoffman)

Experimental setup

^{26}F beam @ 85 MeV/u ~20 pps



Neutrons detected around 0°

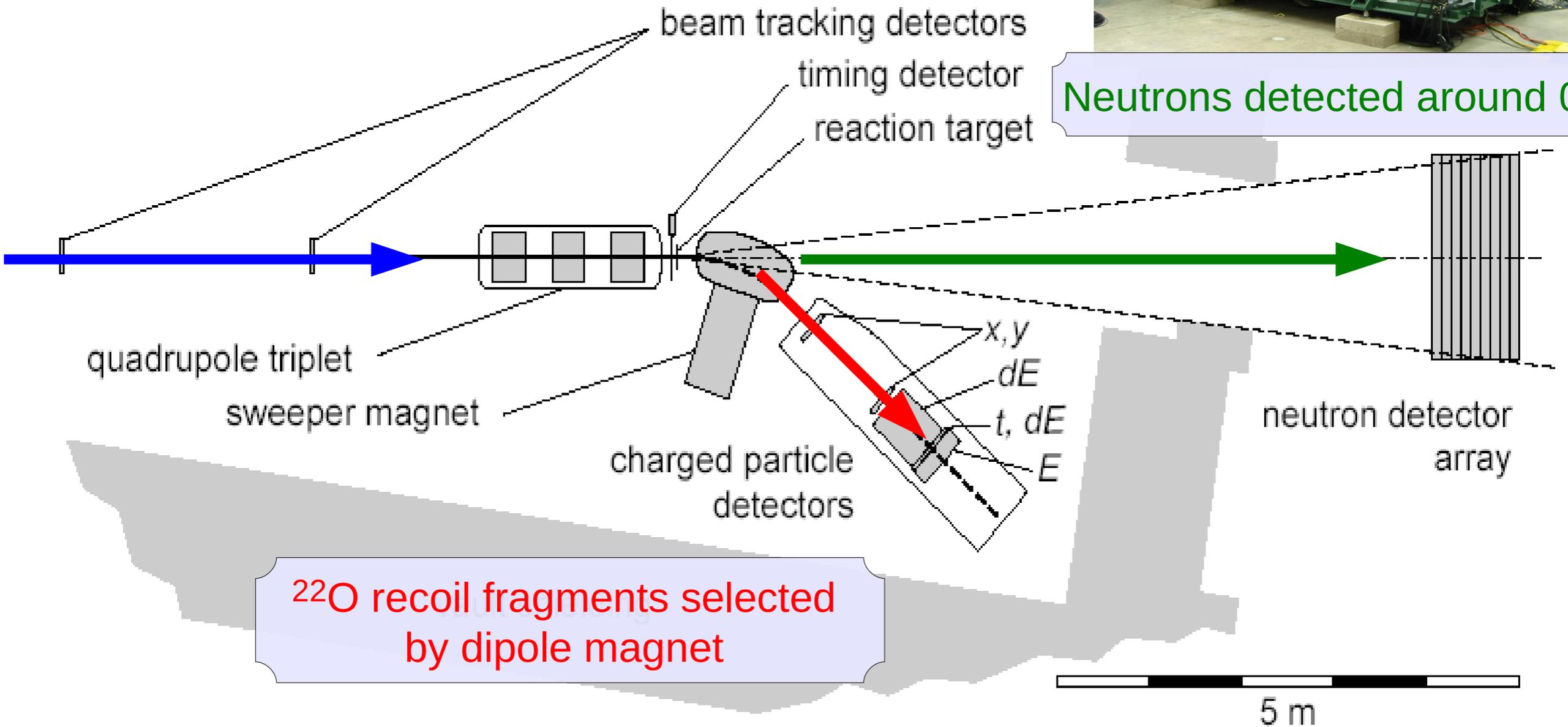
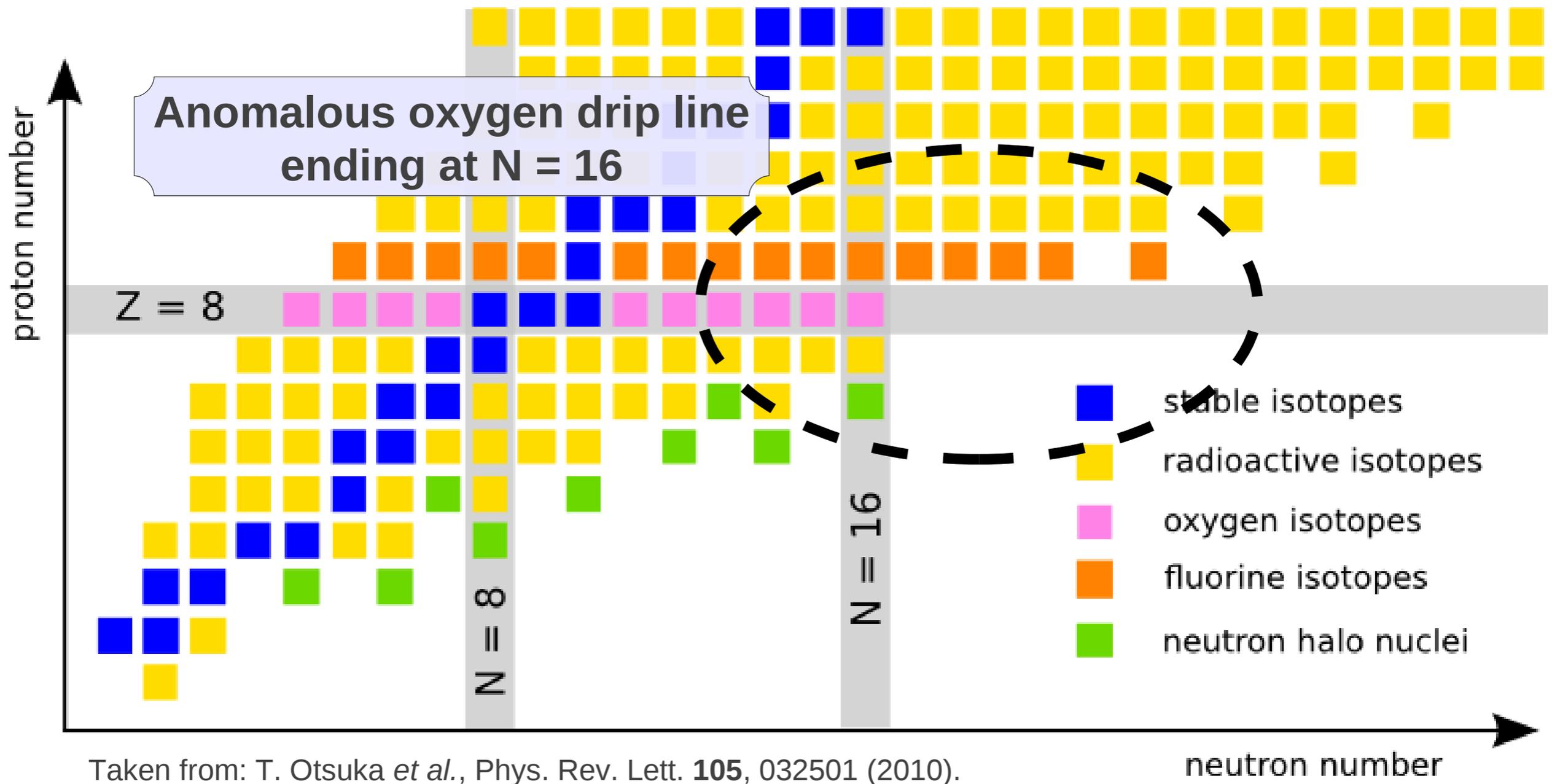
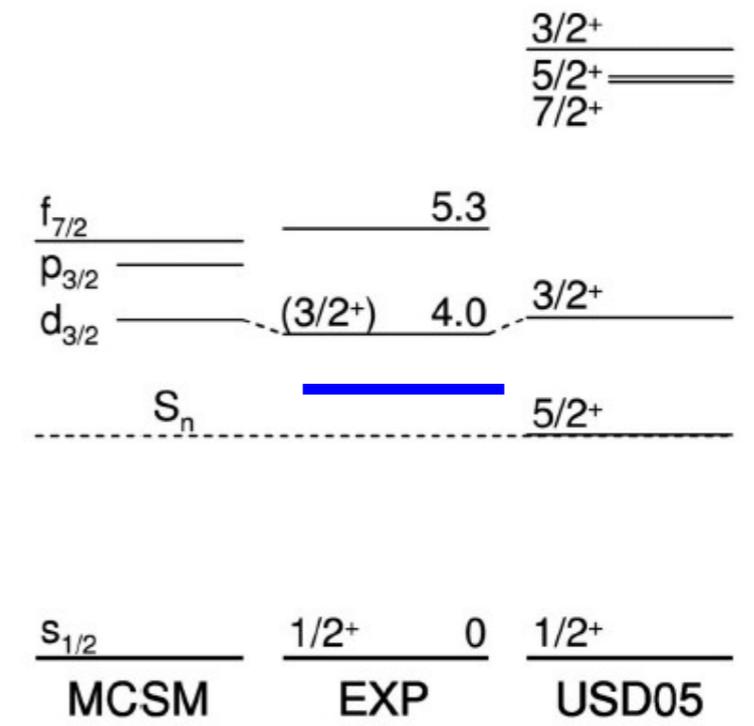
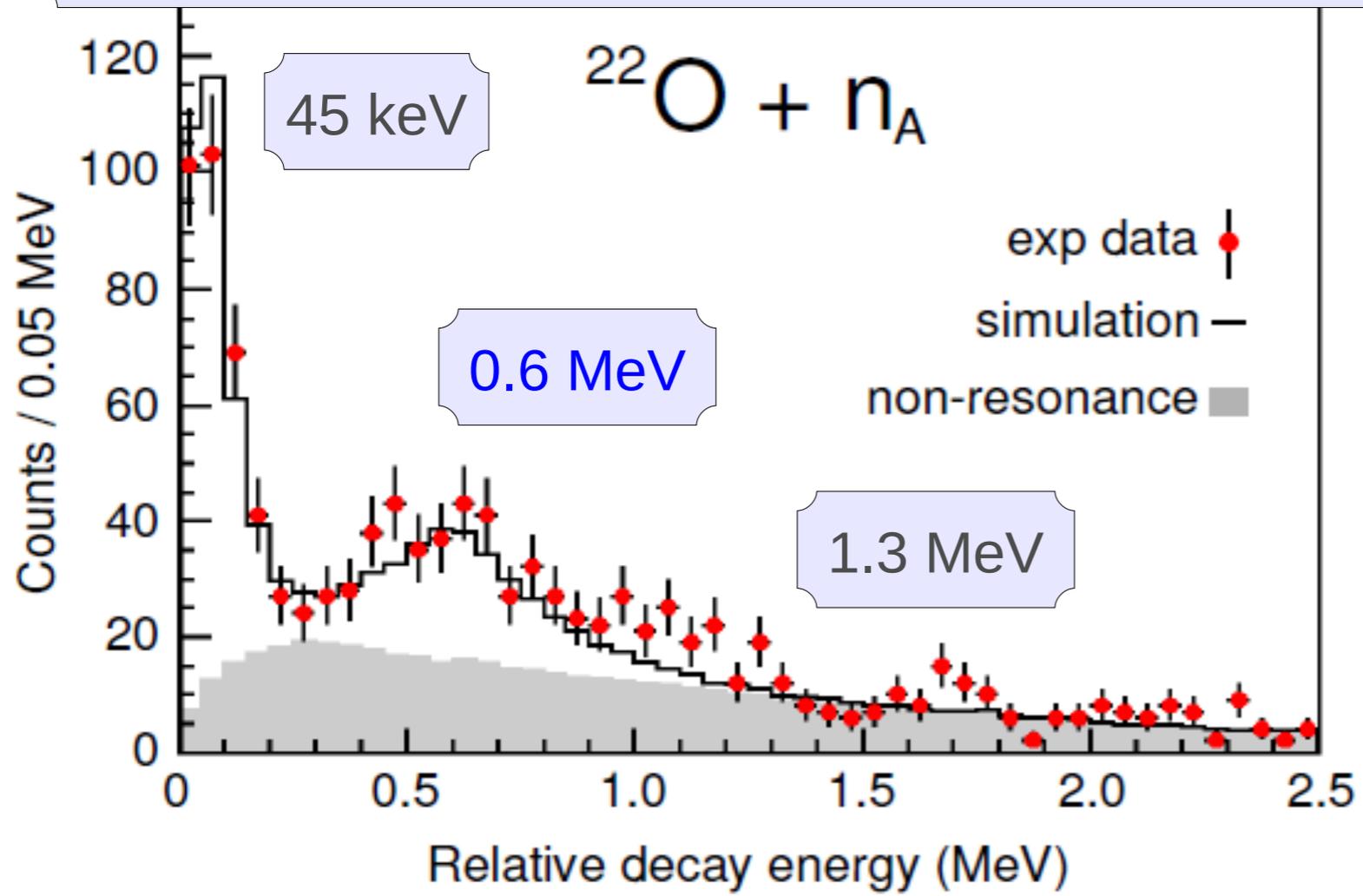


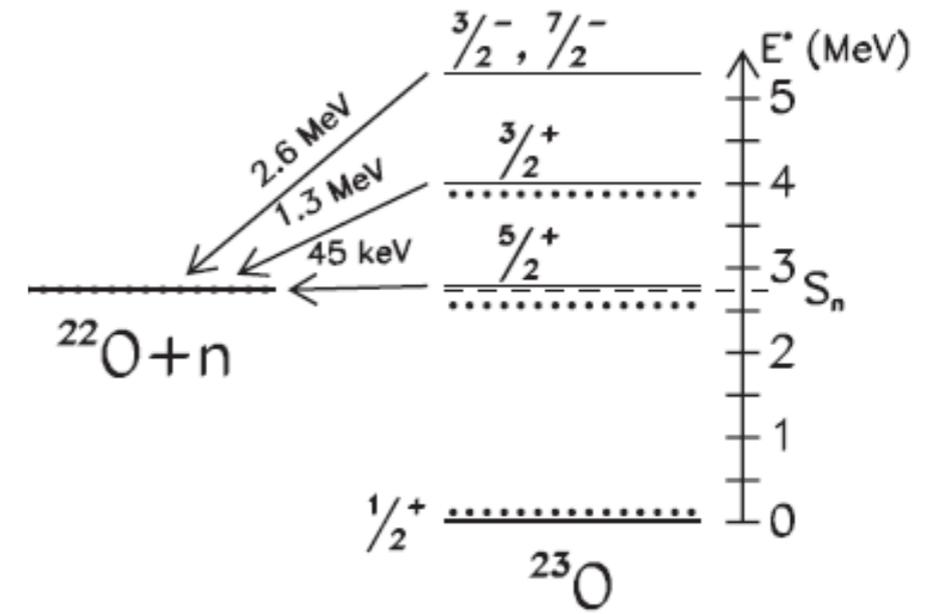
Chart of the nuclides ($Z < 15$)



$$E_{\text{decay}} = \sqrt{m_f^2 + m_n^2 + 2[E_f E_n - p_f p_n \cos(\Theta_{\text{open}})]} - m_f - m_n$$



Taken from: Z. Elekes *et al.*, Phys. Rev. Lett. **98**, 102502 (2007).



Taken from: A. Schiller *et al.*, Phys. Rev. Lett. **99**, 112501 (2007).

- Previously unobserved resonance at ~0.6 MeV
- Origin: No nearby states suggested by shell model
- Possible candidate for two-neutron coincidence

- Energy loss of charged particles.
- Semiconductor and silicon detectors.
- The *p-n junction* results in a contact potential and fixed space charges, creating a *depletion region*. This region is the solid-state analog of an ionization chamber.
- Silicon and charged-particle detection techniques are used throughout physics.
- There is a lot of science being carried out with exotic beams that relies on the beneficial properties of silicon.
- There are a great deal of other detectors that I could not discuss!

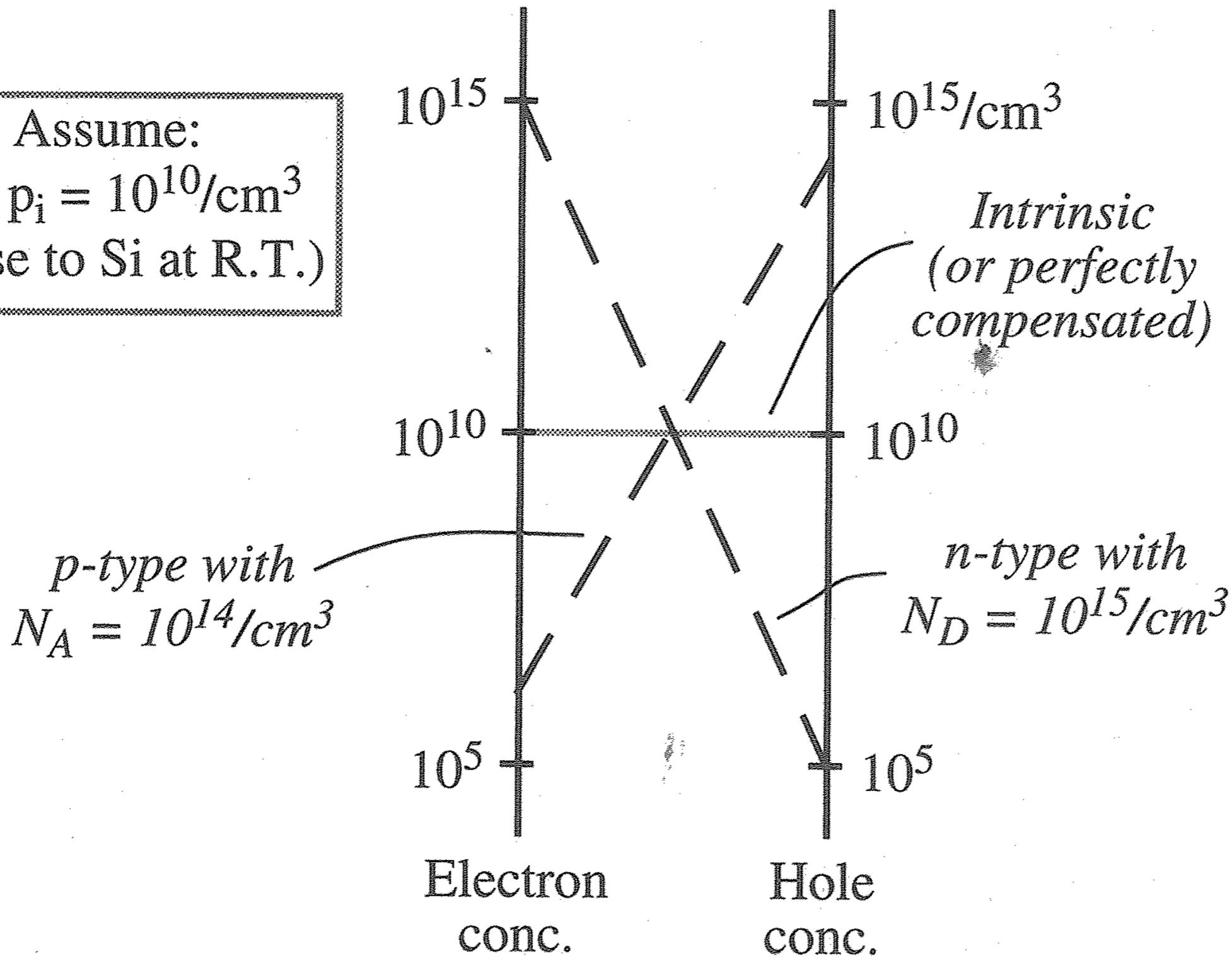
References

1. Knoll, Glenn F. Radiation detection and measurement. Wiley. com, 2010.
2. Brownell, Gordon L., et al. "Positron tomography and nuclear magnetic resonance imaging." *Science* 215.4533 (1982): 619-626.
3. Leo, William R. Techniques for nuclear and particle physics experiments: a how-to approach. Springer, 1994.
4. Kittel, Charles, and Paul McEuen. Introduction to solid state physics. Vol. 7. New York: Wiley, 1996.
5. Carron, Neal Jay. An introduction to the passage of energetic particles through matter. CRC Press, 2006.
6. Tsoufanidis, Nicholas. Measurement and detection of radiation. Taylor & Francis, 1995.

Additional Material

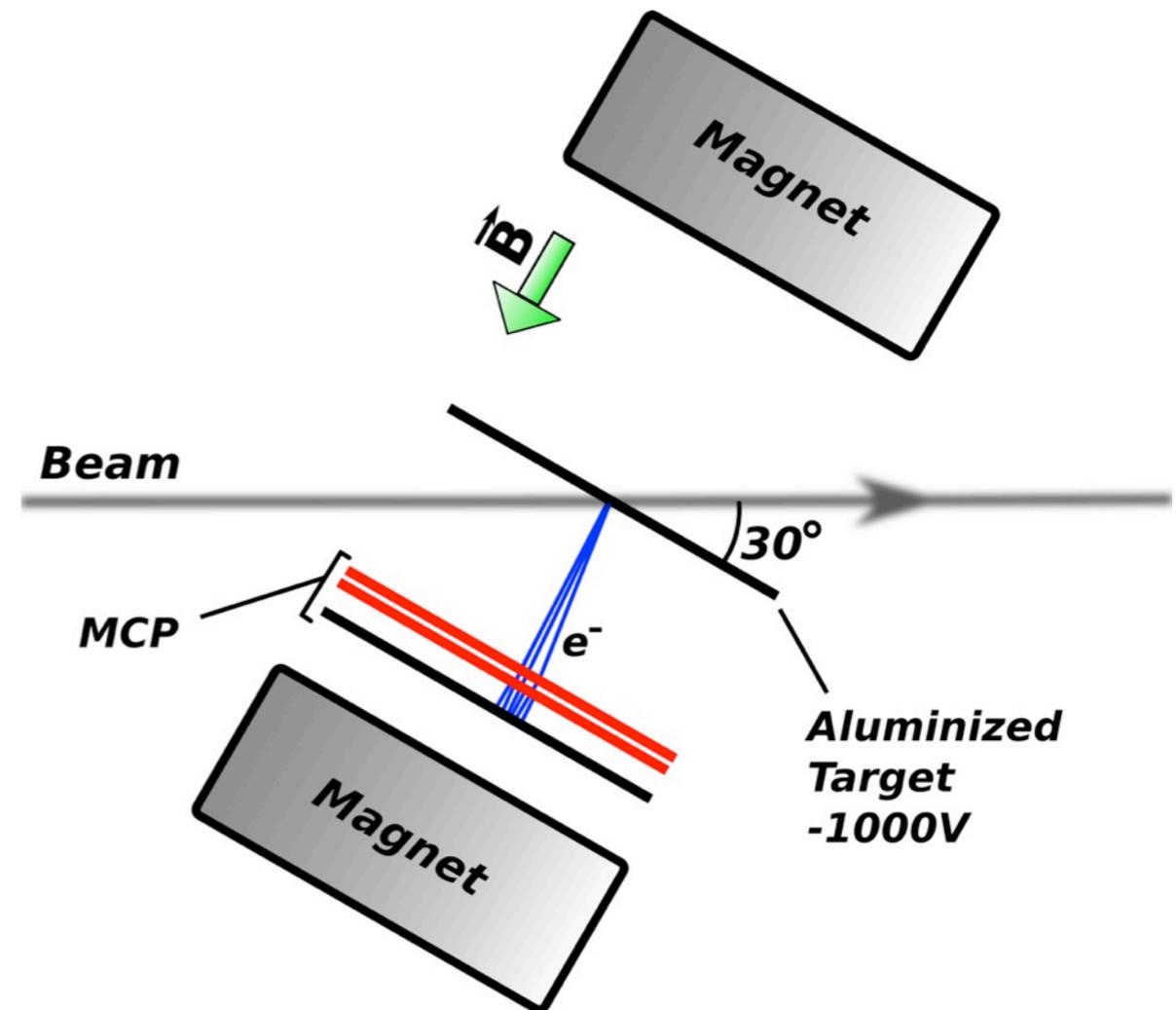
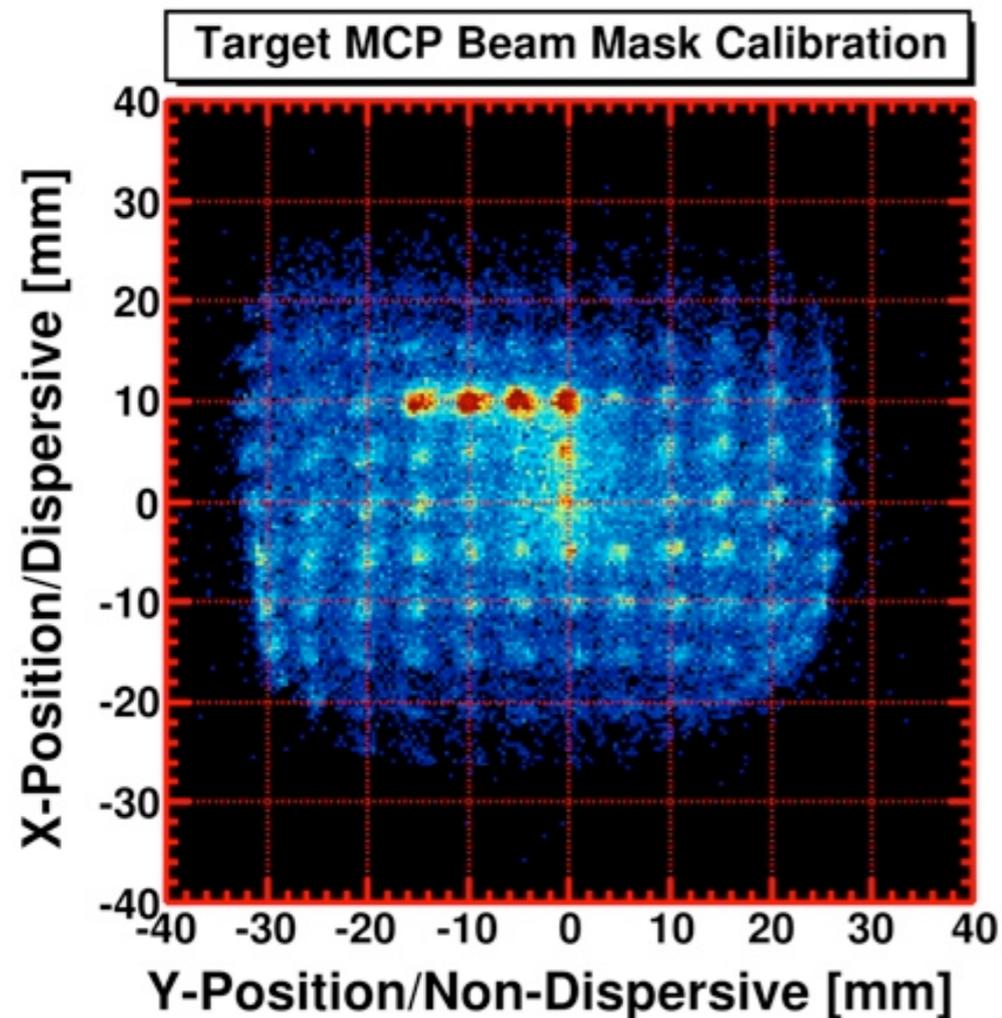
Electron-hole equilibrium concentrations

Assume:
 $n_i = p_i = 10^{10}/\text{cm}^3$
(Close to Si at R.T.)



Micro-channel plate (MCP) tracking system

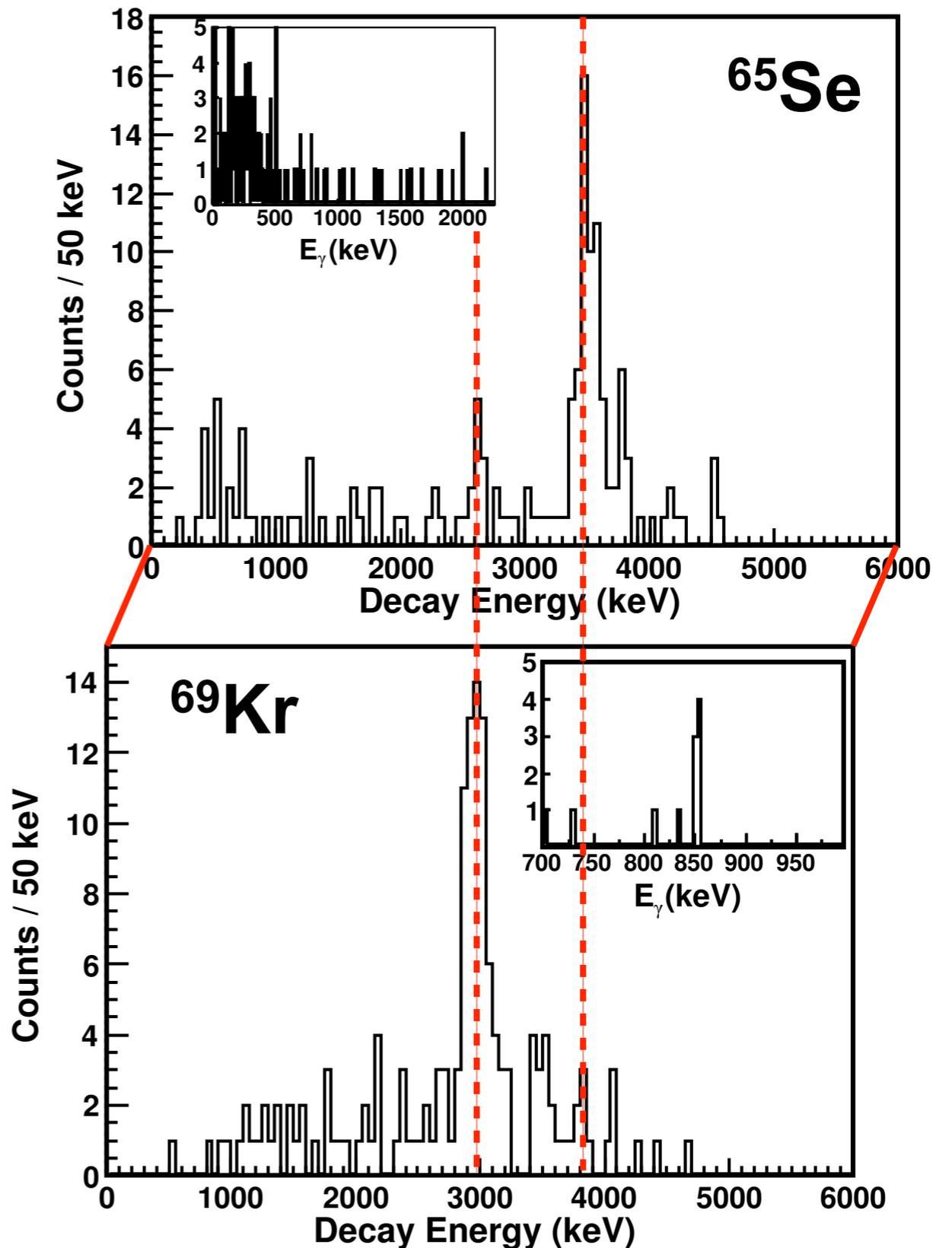
- Secondary electrons ejected from the beam interaction on target are detected by the MCP.
- E -field accelerates e^- while B -field confines trajectories.



- Electron multiplication occurs in the channels of the MCP.
- Anode provides timing.
- Position information readout from four corner signals taken from a resistive anode.
- Capable of rates approaching 10^6 Hz.

Analogous proton decay

- ^{65}Se and ^{69}Kr are analogous systems:
 - Both $T_z = -3/2$ nuclei
 - Similar relative energies for states of interest.
- However, their decays are strikingly different!!!
- We can explain this difference if the spin of the analog state in ^{69}Br is higher than in ^{65}As .
- From mirror nuclei one expects $J^\pi = 3/2^-$ for the ^{65}As IAS while ^{69}Br must have $\ell \geq 3$, most likely $J^\pi = 5/2^-$.

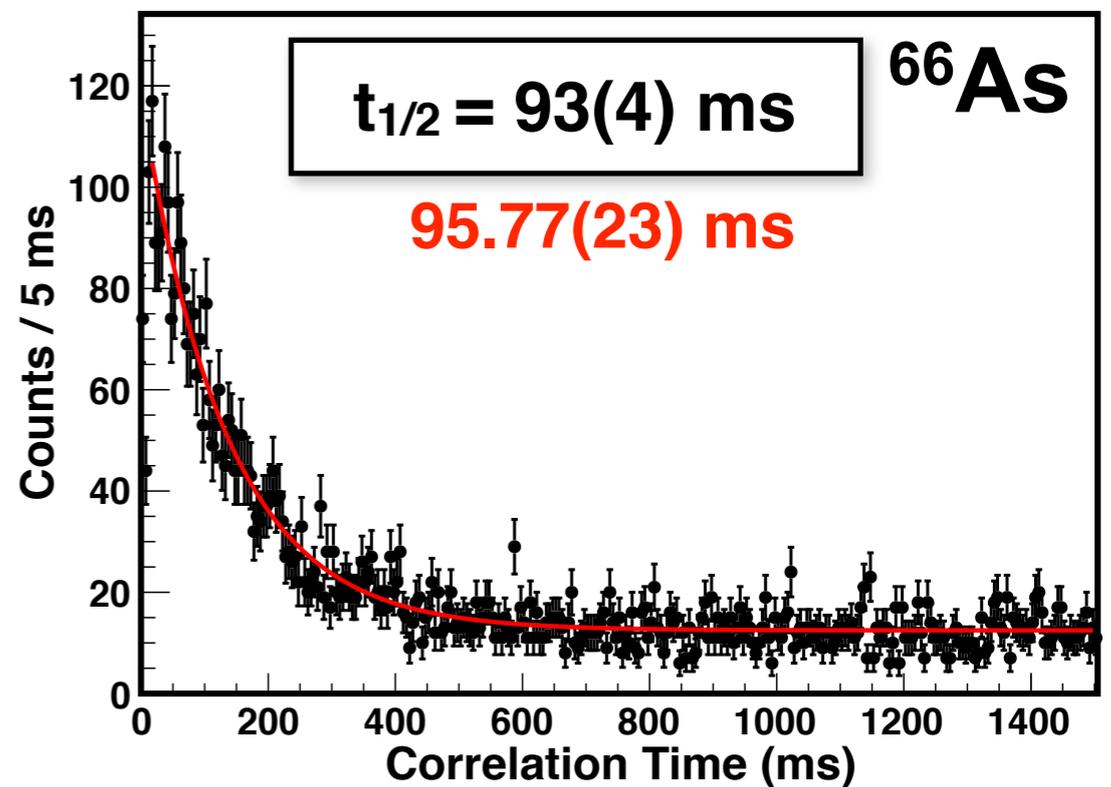
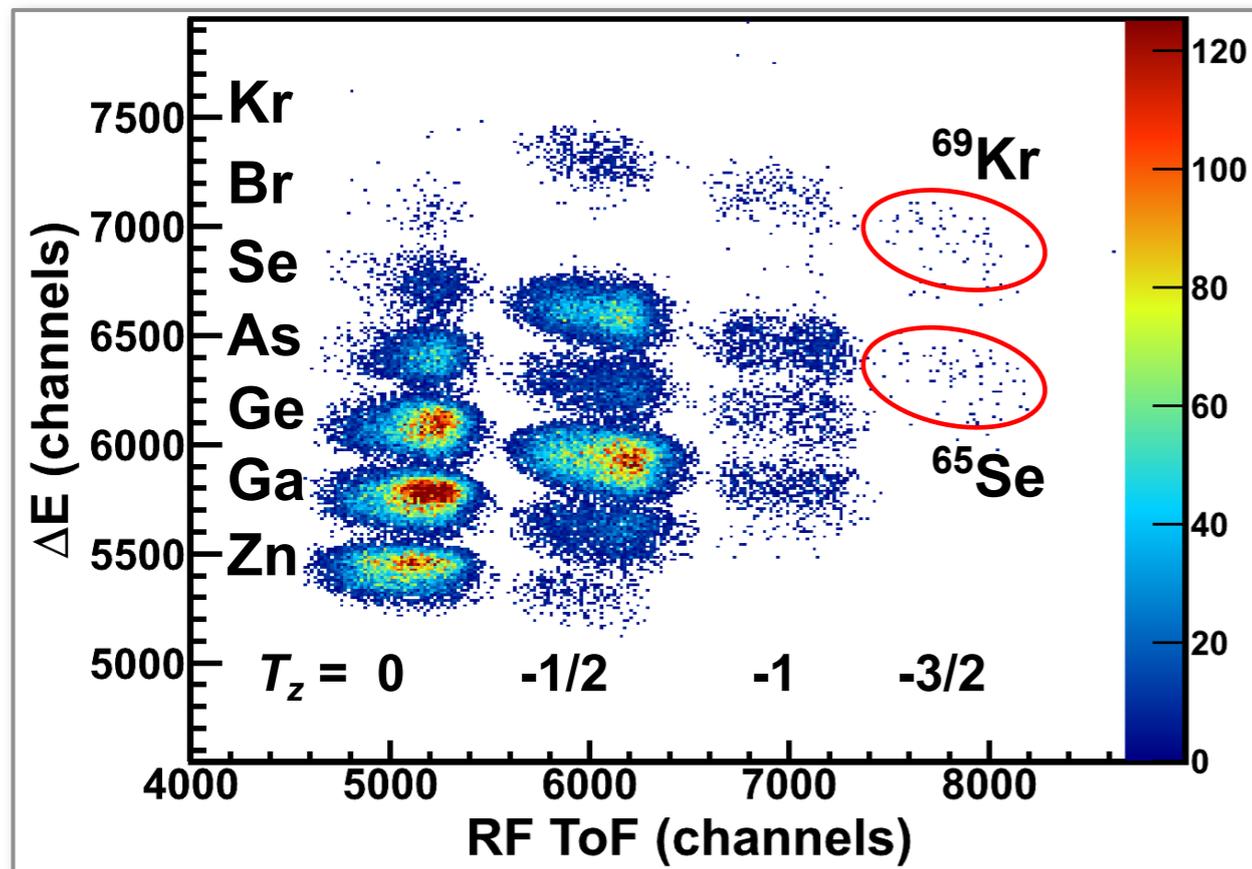
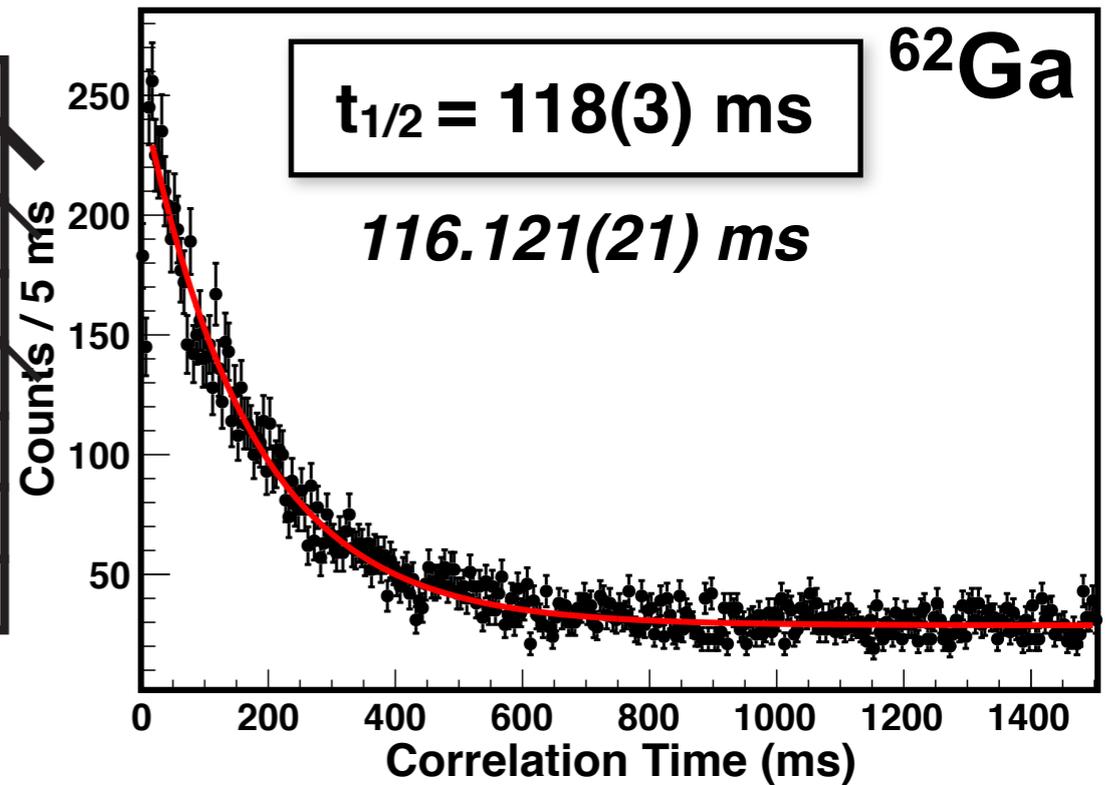
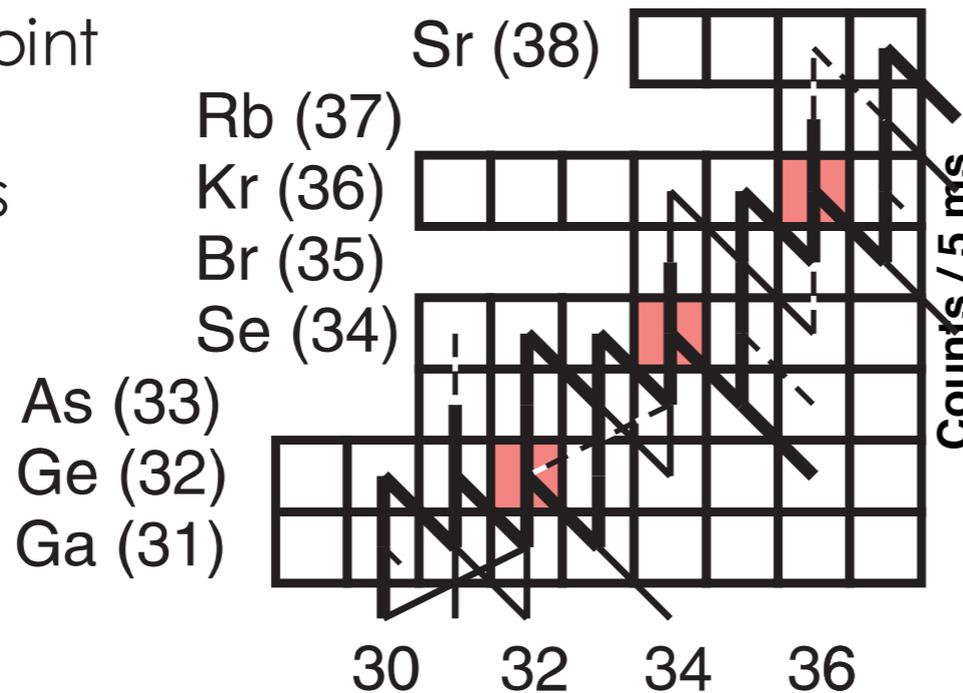
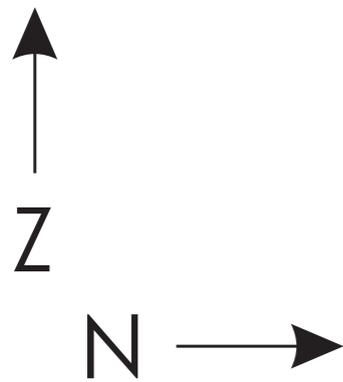


$T_z = 0$: ^{62}Ga , ^{66}As , and ^{70}Br

J. Savory *et al.* PRL **102**, 132501 (2009)

 waiting point

 rp process



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J. Savory *et al.* PRL **102**, 132501 (2009)

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